		METRIC/SI (ENGLISH)
NASA	NASA TECHNICAL STANDARD	NASA-STD-6016B
National Aerona	utics and Space Administration	
		Approved: 2020-05-14 Superseding NASA-STD-6016A
	STANDARD MATERIALS AND REQUIREMENTS FOR SPA	

### **DOCUMENT HISTORY LOG**

Status	Document Revision	Change Number	Approval Date	Description
Interim			2006-09-11	Interim Release
Baseline			2008-07-11	Baseline Release
				Transitioned Interim Standard NASA-STD-(I)-6016 to NASA Technical Standard NASA-STD-6016.
Revision	A		2016-11-30	Significant changes were made to the document. It is recommended that the document be reviewed in its entirety before implementation.  Key changes were:
				<ul> <li>Updated applicable standards to the latest verified acceptable versions.</li> <li>Simplified requirements on M&amp;P control process.</li> <li>Revised requirements on material design</li> </ul>
				<ul> <li>values.</li> <li>Restructured standard to place all heat treatment and weld process requirements in Processes section.</li> <li>Added controls on use of pure tin</li> </ul>
				<ul> <li>(replacing previous prohibition).</li> <li>Added first article and production controls for castings.</li> <li>Imposed AWS and other voluntary</li> </ul>
				consensus standards for welding as alternative to NASA-STD-5006A.  • Added high-level requirement on
				<ul><li>additive manufacturing.</li><li>Added requirements on control of intermetallic compounds.</li></ul>

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

### **DOCUMENT HISTORY LOG (Continued)**

Status	Document Revision	Change Number	Approval Date	Description
Revision	A			<ul> <li>Replaced prohibition on liquid-locking compounds with imposition of (less restrictive) NASA-STD-5020.</li> <li>Retired Category III MUA codes and incorporated rationales into the standard as exceptions to the requirements.</li> <li>Added appendix with rationales for each requirement.</li> </ul>
Revision	В		2020-05-14	Revised to add requirements to address potential ignition of materials in nitrogen tetroxide and other oxidizer systems—4.2.1.3e [MPR 210], 4.2.1.3.e(1) [MPR 211], and 4.2.1.3.f [MPR 212].

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#### **FOREWORD**

This NASA Technical Standard is published by the National Aeronautics and Space Administration (NASA) to provide uniform engineering and technical requirements for processes, procedures, practices, and methods that have been endorsed as standard for NASA programs and projects, including requirements for selection, application, and design criteria of an item.

This NASA Technical Standard is approved for use by NASA Headquarters and NASA Centers and Facilities and may be cited in contract, program, and other Agency documents as a technical requirement. It may also apply to the Jet Propulsion Laboratory and other contractors only to the extent specified or referenced in applicable contracts.

This NASA Technical Standard defines the minimum requirements for Materials and Processes (M&P) and provides a general control specification for incorporation in NASA program/project hardware procurements and technical programs.

Requests for information should be submitted via "Feedback" at <a href="https://standards.nasa.gov">https://standards.nasa.gov</a>. Requests for changes to this NASA Technical Standard should be submitted via MSFC Form 4657, Change Request for a NASA Engineering Standard.

Original Signed By:	
Adam West	5-14-2020
for Ralph R. Roe, Jr. NASA Chief Engineer	Approval Date

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# STANDARD MATERIALS AND PROCESSES REQUIREMENTS FOR SPACECRAFT

### 1. SCOPE

This NASA Technical Standard is directed toward materials and processes (M&P) used in the design, fabrication, and testing of space program flight hardware for NASA, including but not limited to crewed, uncrewed, robotic, launch vehicle, lander, in-space and surface systems, and spacecraft program/project hardware elements. All spaceflight hardware is covered by the M&P requirements of this document, including vendor-designed, off-the-shelf, and vendor-furnished items.

M&P used in interfacing ground support equipment (GSE), test equipment, hardware processing equipment, hardware packaging, and hardware shipment is covered by the M&P requirements of this NASA Technical Standard only to the extent required to prevent damage to or contamination of spaceflight hardware (see Section 4.0). M&P used in NASA aircraft and aircraft operations are not covered by the M&P requirements of this document.

### 1.1 Purpose

The purpose of this NASA Technical Standard is to define the minimum requirements for M&P and to provide a general control specification for incorporation in NASA program/project hardware procurements and technical programs.

### 1.2 Applicability

The controls described here are applicable to all NASA spacecraft programs:

- a. [MPR 1] Programs shall apply these controls to program/project hardware. Programs, projects, and elements are responsible for flowing requirements down to contractors, subcontractors, and the lowest component-level suppliers.
- b. [MPR 2] Programs shall be responsible for demonstrating compliance with these requirements.

This NASA Technical Standard is approved for use by NASA Headquarters and NASA Centers and Facilities and may be cited in contract, program, and other Agency documents as a technical requirement. It may also apply to the Jet Propulsion Laboratory and other contractors only to the extent specified or referenced in applicable contracts.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Verifiable requirement statements are numbered and indicated by the word "shall" beginning in section 4; this NASA Technical Standard contains 212 requirements. Explanatory or guidance text is indicated in italics beginning in section 4. To facilitate requirements selection and verification by NASA programs and projects, a Requirements Compliance Matrix is provided in Appendix A. This appendix also contains justifications for each verifiable requirement statement.

### 1.3 Tailoring

- a. [MPR 3] Tailoring of this NASA Technical Standard's requirements in the Materials and Processes Selection, Control, and Implementation Plan for specific programs/projects shall be formally documented as part of program or project requirements and approved by the responsible program/project NASA M&P organization, the responsible project/program, and the responsible Technical Authority in accordance with NPR 7120.5, NASA Space Flight Program and Project Management Requirements, or NPR 7120.8, NASA Research and Technology Program and Project Management Requirements. These requirements may be tailored simply by constructing a matrix of applicable paragraphs and paragraphs that are not applicable. Tailoring also includes using existing or previously developed contractor processes and standards as a submittal of the various required plans. Otherwise, the tailoring of requirements may be documented in the Materials and Processes Selection, Control, and Implementation Plan by providing the degree of conformance and the method of implementation for each requirement identified here.
- b. When a Materials and Processes Selection, Control, and Implementation Plan has been approved by the responsible program/project as an acceptable means of compliance with the technical requirements of this NASA Technical Standard, the Plan may be used for the implementation and verification of M&P requirements on the applicable program/project.

### 2. APPLICABLE DOCUMENTS

### 2.1 General

The documents listed in this section contain provisions that constitute requirements of this NASA Technical Standard as cited in the text.

- **2.1.1** [MPR 4] The latest issuances of cited documents shall apply unless specific versions are designated.
- **2.1.2** [MPR 5] Non-use of specifically designated versions shall be approved by the responsible Technical Authority.

The applicable documents are accessible at <a href="https://standards.nasa.gov">https://standards.nasa.gov</a>, may be obtained directly from the Standards Developing Body or other document distributors, or information for obtaining the document is provided.

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### 2.2 Government Documents

The documents in these paragraphs are applicable to the extent specified. The citations below refer to the sections in this NASA Technical Standard.

### National Aeronautics and Space Administration (NASA)

NPR 7120.5 (Cited in section 1.3)	NASA Space Flight Program and Project Management Requirements
NPR 7120.8 (Cited in section 1.3)	NASA Research and Technology Program and Project Management Requirements
NASA-STD-5006A with Change 1 (2016) (Cited in section 4.2.4.6)	General Welding Requirements for Aerospace Materials
NASA-STD-5009 (2008) (Cited in section 4.2.5.1)	Nondestructive Evaluation Requirements for Fracture-Critical Metallic Components
NASA-STD-5020 (2012) (Cited in section 4.2.6.6.1)	Requirements for Threaded Fastening Systems in Spaceflight Hardware
NASA-STD-6001B (2011) with Change 2 (2016) (Cited in sections 4.2.1, 4.2.1.1, 4.2.1.2, 4.2.1.4, and 4.2.1.5)	Flammability, Offgassing, and Compatibility Requirements and Test Procedures
NASA-STD-6012 (2012) (Cited in section 4.2.6.3)	Corrosion Protection for Space Flight Hardware
JSC 20584 (2008) (Cited in section 4.2.1.2)	Spacecraft Maximum Allowable Concentrations for Airborne Contaminants
JSC 29353 (Cited in section 4.2.1.1)	Flammability Configuration Analysis for Spacecraft Applications
Materials and Processes Technical Information System (MAPTIS) (Cited in section 4.2.1.2)	Materials Selection List for Space Hardware Systems

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MSFC-SPEC-445A (1990) (Cited in section 4.2.4.5)	Adhesive Bonding, Process and Inspection, Requirements for
MSFC-STD-3029A (2005) (Cited in section 4.2.2)	Guidelines for the Selection of Metallic Materials for Stress Corrosion Cracking Resistance in Sodium Chloride Environments
<b>Department of Defense</b>	
MIL-STD-810G (2008), with Change 1 (2014) (Cited in section 4.2.3.8)	Department of Defense Test Method Standard for Environmental Engineering Considerations and Laboratory Tests
MIL-STD-1252 (1975) (Cited in section 4.2.4.6.4 (Inactive for New Design effective 3/11/1998 but determined by NASA to be the best existing standard for use)	
MIL-HDBK-454B (Cited in section 4.2.3.8)	General Guidelines for Electronic Equipment
MIL-HDBK-6870B (2012	2) Nondestructive Inspection Program Requirements for Aircraft

### 2.3 Non-Government Voluntary Consensus Standards

The citations below refer to the sections in this NASA Technical Standard.

(Cited in section 4.2.5.1) and Missile Materials and Parts

### **ASTM International (ASTM)**

ASTM B689-97 (Reapproved 2013) (Cited in section 4.2.4.10)	Standard Specification for Electroplated Engineering Nicke Coatings
ASTM B733-15 (Cited in sections 4.2.4.10 and 4.2.6.3)	Standard Specification for Autocatalytic (Electroless) Nickel-Phosphorus Coatings on Metal

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ASTM E595-15 (Cited in section 4.2.3.6)	Standard Test Method for Total Mass Loss and Collected Volatile Condensable Materials from Outgassing in a Vacuum Environment
ASTM E1548 (2009) (Cited in section 4.2.6.7)	Standard Practice for Preparation of Aerospace Contamination Control Plans
American Welding Society (AV	WS)
AWS C3.2M/C3.2 (2008) (Cited in section 4.2.4.7)	Standard Method for Evaluating the Strength of Brazed Joints
AWS C3.3 (2008) (Cited in section 4.2.4.7)	Recommended Practices for Design, Manufacture, and Examination of Critical Brazed Components
AWS C3.4M/C3.4 (2016) (Cited in section 4.2.4.7)	Specification for Torch Brazing
AWS C3.5M/C3.5 (2016) (Cited in section 4.2.4.7)	Specification for Induction Brazing
AWS C3.6M/C3.6 (2016) (Cited in section 4.2.4.7)	Specification for Furnace Brazing
AWS C3.7M/C3.7 (2011) (Cited in section 4.2.4.7)	Specification for Aluminum Brazing
AWS C7.4/C7.4M (2008) (Cited in section 4.2.4.6.1)	Process Specification and Operator Qualification for Laser Beam Welding
AWS D17.1/D17.1M (2010)	Specification for Fusion Welding for Aerospace

AWS D17.3/D17.3M (2016) Specification for Friction Stir Welding of Aluminum Alloys (Cited in section 4.2.4.6.3) for Aerospace Applications

Specification for Resistance Welding for Aerospace

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**Applications** 

**Applications** 

AMD1 (2012) (Cited in section

AWS D17.2/D17.2M (2013)

(Cited in section 4.2.4.6.2)

4.2.4.6.1)

### **Battelle Memorial Institute**

MMPDS-10 (2015) (Cited in	Metallic Materials Properties Development and
section 4.1.8.1, 4.1.8.2, and	Standardization (MMPDS)
4.2.4.1)	

## Government Electronics and Information Technology Association (GEIA) (SAE International)

GEIA-STD-0005-1A (2012)	Performance Standard for Aerospace and High Performance
(Cited in section 4.2.2.11)	Electronic Systems Containing Lead-Free Solder
GEIA-STD-0005-2A (2012)	Standard for Mitigating the Effects of Tin Whiskers in
(Cited in section 4.2.2.11)	Aerospace and High Performance Electronic Systems

### **National Aerospace Standards (NAS)**

(Cited in section 4.2.4.10)

NAS 410, Revision 4 (2014)	NAS Certification and Qualification of Nondestructive Test
(Cited in section 4.2.5.1)	Personnel
NAS 412, Revision 1 (2013)	Foreign Object Damage/Foreign Object Debris (FOD)
(Cited in section 4.2.6.7)	Prevention

(Cited in Section 4.2.6.7)	Prevention
SAE International (SAE)	
SAE AMS2175A (2010) (Cited in section 4.2.4.3)	Castings, Classification and Inspection of
SAE AMS2375D (2007, Reaffirmed 2012) (Cited in section 4.2.4.2)	Control of Forgings Requiring First Article Approval
SAE AMS2403N (2015) (Cited in section 4.2.4.10)	Plating, Nickel General Purpose
SAE AMS2404G (2013) (Cited in section 4.2.4.10 and 4.2.6.3)	Plating, Electroless Nickel
SAE AMS2423E (2015)	Plating, Nickel Hard Deposit

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SAE AMS2488D (2000, Reaffirmed 2011) (Cited in section 4.2.2.3.2)	Anodic Treatment - Titanium and Titanium Alloys Solution, pH 13 or Higher
SAE AMS2491F (2015) (Cited in section 4.2.3.10)	Surface Treatment of Polytetrafluoroethylene, Preparation for Bonding
SAE AMS2680C (2001, Reaffirmed 2010) (Cited in section 4.2.4.6.1)	Electron-Beam Welding for Fatigue Critical Applications
SAE AMS2759E (2008, Reaffirmed 2014) (Cited in section 4.2.4.1)	Heat Treatment of Steel Parts, General Requirements
SAE AMS2759/9D (2009) (Cited in sections 4.2.6.4)	Hydrogen Embrittlement Relief (Baking) of Steel Parts
SAE AMS2770N (2015) (Cited in section 4.2.4.1)	Heat Treatment of Wrought Aluminum Alloy Parts
SAE AMS2771E (2013) (Cited in section 4.2.4.1)	Heat Treatment of Aluminum Alloy Castings
SAE AMS2772G (2016) (Cited in section 4.2.4.1)	Heat Treatment of Aluminum Alloy Raw Materials
SAE AMS2773E (2013) (Cited in section 4.2.4.1)	Heat Treatment, Cast Nickel Alloy and Cobalt Alloy Parts
SAE AMS2774E (2016) (Cited in section 4.2.4.1)	Heat Treatment, Wrought Nickel Alloy and Cobalt Alloy Parts
SAE AMS2801B (2003, Reaffirmed 2014) (Cited in section 4.2.4.1 and 4.2.4.6.1)	Heat Treatment of Titanium Alloy Parts
SAE AMS-H-6875B (2010) (Cited in 4.2.4.1)	Heat Treatment of Steel Raw Materials

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SAE AMS-H-81200D (2014) (Cited in sections 4.2.4.1 and 4.2.4.6.1)	Heat Treatment of Titanium and Titanium Alloys
SAE AMS-STD-401 (1999) (Cited in section 4.2.6.2)	Sandwich Constructions and Core Materials: General Test Methods
SAE AS22759C (2014) (Cited in section 4.2.1.5)	Wire, Electrical, Fluoropolymer-Insulated, Copper or Copper Alloy
SAE CMH-17:	
SAE CMH-17-1G (2012) (Cited in section 4.1.8.1)	Composite Materials Handbook Volume 1 - Polymer Matrix Composites Guidelines for Characterization of Structural Materials
SAE CMH-17-2G (2012) (Cited in section 4.1.8.1)	Composite Materials Handbook Volume 2 - Polymer Matrix Composites Materials Properties
SAE CMH-17-3G (2012) (Cited in section 4.1.8.1)	Composite Materials Handbook Volume 3 - Polymer Matrix Composites Materials Usage, Design, and Analysis
SAE CMH-17-4B (2013) (Cited in section 4.1.8.1)	Composite Materials Handbook Volume 4 - Metal Matrix Composites
MIL-HDBK-17-5 (2002) (Reference section 4.1.8.1)— (Use until SAE CMH-17-5 is published, scheduled in 2017)	Composite Materials Handbook Volume 5 - Ceramic Matrix Composites
SAE CMH-17-6 (2013) (Cited in section 4.1.8.1)	Composite Materials Handbook Volume 6 – Structural Sandwich Composites

Refer to Appendix E for References.

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#### 2.4 Order of Precedence

- **2.4.1** The requirements and standard practices established in this NASA Technical Standard do not supersede or waive existing requirements and standard practices found in other Agency documentation.
- **2.4.2** [MPR 6] Conflict between this NASA Technical Standard and other requirements documents shall be resolved by the responsible Technical Authority.

### 3. ACRONYMS AND DEFINITIONS

### 3.1 Acronyms and Abbreviations

/sec Per Second
AIAA American Institute of Aeronautics and Astronautics

AM Additively Manufactured

AMS Aerospace Material Specification
ANSI American National Standards Institute

AS Aerospace Standard

ASTM International (formerly American Society for

Testing and Materials)

AWS American Welding Society

BZT Benzotriazole

CCP Contamination Control Plan CDR Critical Design Review

cm Centimeter

CMH Composite Materials Handbook COTS Commercial Off-The-Shelf

CP Commercially Pure CR Contractor Report

CVCM Collected Volatile Condensable Materials

°C Degrees Celsius °F Degrees Fahrenheit

D Dimensional

DMLS Direct Metal Laser Sintering
DOT Department of Transportation
DRD Data Requirements Description
EDM Electrical Discharge Machining

EEE Electrical, Electronic, and Electromechanical

ELI Extra Low Interstitial
ESD Electrostatic Discharge
ETFE Ethylene Tetrafluoroethylene

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FAA Federal Aviation Administration
FEP Fluorinated Ethylene Propylene
FOD Foreign Object Damage/Debris

FRR Flight Readiness Review

g Gram

GEIA Government Electronics and Information Technology

Association

GOX Gaseous Oxygen

GSE Ground Support Equipment

HDBK Handbook

HEE Hydrogen Environmental Embrittlement
HRE Hydrogen Reaction Embrittlement
IHE Internal Hydrogen Embrittlement

in Inch

JSC Johnson Space Center

kPa Kilopascals

ksi Kilopounds per Square Inch

lb Pound

LOX Laser Machining LOX Liquid Oxygen

M&P Materials and Processes

MAPTIS Materials and Processes Technical Information System

MIL Military

MIUL Materials Identification and Usage List

mm Millimeter

MMPDS Metallic Materials Properties Development and

Standardization

MNL Manual Megapascals

MPR Materials and Processes Requirement

MSFC Marshall Space Flight Center MUA Material(s) Usage Agreement NAS National Aerospace Standard

NASA National Aeronautics and Space Administration

NDENondestructive EvaluationNDINondestructive InspectionNDTNondestructive Testing

NPR NASA Procedural Requirements
PDF Portable Document Format
PDP Part Development Plans
PDR Preliminary Design Review

PFA Perfluoroalkoxy

PH Precipitation Hardened/Hardenable

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PQR Procedure Qualification Record
PSIA Pounds per Square Inch Absolute

PTFE Polytetrafluoroethylene
PVC Polyvinyl Chloride
RH Relative Humidity
RSW Resistance Spot Welding

RTV Room Temperature Vulcanizing (rubber)
SAGBOE Stress Assisted Grain Boundary Oxidation

Embrittlement

SAE International (formerly Society of Automotive

Engineers)

SDR System Definition Review

sec Second

SLM Selective Laser Melting

SMAC Spacecraft Maximum Allowable Concentration

SOW Statement of Work SPEC Specification

SRR System Requirements Review

STD Standard

TM Technical Memorandum

TML Total Mass Loss

UTS Ultimate Tensile Strength

UV Ultraviolet

VCM Volatile Condensable Materials WPS Welding Procedure Specification

Weld Process Specification

WVR Water Vapor Recovery

### 3.2 Definitions

Additive Manufacturing: Any process for making a three-dimensional object from a 3-D model or other electronic data source primarily through processes in which successive layers of material are deposited under computer control.

<u>Catastrophic Hazard</u>: Presence of a risk situation that could directly result in a catastrophic event, which is defined as loss of life, disabling injury, or loss of a major national asset.

<u>Corrosive Environment</u>: Solid, liquid, or gaseous environment that deteriorates the materials by reaction with the environment. Clean rooms and vacuum are normally considered noncorrosive.

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<u>Critical Hazard</u>: Hazard that can result in the potential for severe injury, severe occupational illness, or major property/equipment damage.

Design Value: The design value is a statistically determined minimum value of a property, most commonly strength properties of materials, design features/elements, or components/parts used in the design of a structure. For A-basis strength properties, at least 99% of the population of strength values is expected to equal or exceed this lower bound with 95% confidence. For B-basis, 90% of the population of strength values is expected to equal or exceed this lower bound with 95% confidence. For metallic materials S-basis design values, the statistics defined by MMPDS are the same as for A-basis, but the test requirements are less comprehensive. Numbers of lots and test specimens required to develop design values are defined in applicable standards. The terms "material allowables," "design allowables," and "design values" are commonly used to address the design values used in structural analysis.

<u>Fretting Corrosion</u>: Occurs when two contacting surfaces under mechanical load are subjected to repeated relative surface motion. Mechanical wear and material transfer at the surfaces can lead to corrosion, metallic debris, and increased contact resistance due to the electrical insulating properties of corrosion products that may build up at the contact interfaces.

<u>Mission Critical Hardware</u>: Hardware, the failure of which may result in the inability to retain operational capability for mission continuation if a corrective action is not successfully performed.

<u>Nondestructive Evaluation (NDE)/Nondestructive Testing (NDT)</u>: Inspection techniques which do not cause physical, mechanical, or chemical changes to the part being inspected or otherwise impair its adequacy for operational service. These inspection techniques are applied to materials and structures to verify required integrity and to detect flaws.

Refractory Alloys: Alloys with a melting point above 2000 °C (3632 °F), plus osmium and iridium.

<u>Safety-Critical</u>: Term describing any condition, event, operation, process, equipment, or system that could cause or lead to severe injury, major damage, or mission failure if performed or built improperly, or allowed to remain uncorrected.

Structural: Pertaining to structure.

<u>Structural Adhesive Bond</u>: Structural joint using adhesive bonds for the purpose of transferring structural load between structures.

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<u>Structure</u>: All components and assemblies designed to sustain loads or pressures, provide stiffness and stability, or provide support or containment.

Structure, Primary: That part of a flight vehicle or element that sustains the significant applied loads and provides main load paths for distributing reactions to applied loads. Also, the main structure that is required to sustain the significant applied loads, including pressure and thermal loads, and that, if it fails, creates a catastrophic hazard. If a component is small enough and in an environment where no serious threat is imposed if it breaks, then it is not primary structure.

<u>Subcontractor</u>: A hardware contractor that reports to a higher level contractor.

<u>Technical Authority</u>: Provides technical checks and balances by assuring that safety and mission success, relevant technical standards, engineering work, and safety and reliability analysis products are being conducted properly in accordance with established, high-reliability processes independent of nontechnical program/project constraints.

<u>Tin Pest</u>: The allotropic transformation of tin that may occur at or below 13.2 °C, where tin transforms from β-phase into its α-phase, a grey, brittle semiconductor that occupies about 27 percent greater volume than the β-phase.

<u>Useful Life</u>: Total life span, including storage life, installed life in a nonoperating mode, and operational service life.

<u>Wet Installed</u>: Fasteners covered with primer or sealant during installation to prevent moisture from penetrating the fastener joint and causing corrosion.

<u>Whisker (Metal)</u>: A spontaneous growth that may form on surfaces of metals, primarily tin, zinc, and cadmium. Metal whiskers may also detach from the surfaces on which they form, producing conductive FOD.

### 4. **REQUIREMENTS**

Requirements for materials used in the fabrication and processing of spaceflight hardware are as follows:

a. [MPR 7] Materials shall meet the worst-case useful-life requirements for the particular application.

The useful-life requirements include, but are not limited to, the following:

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- (1) Operational temperature limits.
- (2) *Loads*.
- (3) Contamination.
- (4) Life expectancy.
- (5) Moisture or other fluid media exposure.
- (6) Vehicle-related induced and natural space environments.

Experimental spaceflight hardware and other hardware that do not provide mission-critical functions may have no useful-life requirements, provided that the safety of the crew, the space vehicle, or launch vehicle are not compromised.

Properties to be considered in material selection include, but are not limited to, the following:

- (1) Mechanical properties.
- (2) Fracture toughness.
- (3) Flammability and offgassing characteristics.
- (4) Corrosion.
- (5) Stress corrosion.
- (6) Thermal and mechanical fatigue properties.
- (7) Glass-transition temperature.
- (8) Coefficient of thermal expansion mismatch.
- (9) Vacuum outgassing.
- (10) Fluids compatibility.
- (11) Microbial resistance.
- (12) Moisture resistance.
- (13) Fretting.
- (14) Galling.
- (15) Susceptibility to electrostatic discharge (ESD).
- (16) Susceptibility to contamination.
- b. [MPR 8] M&P used in interfacing GSE, test equipment, hardware processing equipment, hardware packaging, and hardware shipment shall be controlled to prevent damage to or contamination of spaceflight hardware.

The M&P controls in NASA-STD-5005 (Revision D or later), Standard for the Design and Fabrication of Ground Support Equipment, are acceptable for meeting this requirement for interfacing GSE hardware.

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### 4.1 General Requirements

### 4.1.1 Materials and Processes Selection, Control, and Implementation Plan

a. [MPR 9] Each organization that is responsible for the design and fabrication of spaceflight hardware shall provide a Materials and Processes Selection, Control, and Implementation Plan.

The Materials and Processes Selection, Control, and Implementation Plan documents the degree of conformance and method of implementation for each requirement in this NASA Technical Standard and identifies applicable in-house specifications used to comply with the requirement.

Other documents, such as contractor-specific M&P requirements documents and detailed requirements compliance matrices, can be used to form the basis of the Materials and Processes Selection, Control, and Implementation Plan, provided the content addresses the requirements.

b. [MPR 10] The Materials and Processes Selection, Control, and Implementation Plan shall also describe the methods used to control compliance with these requirements by subcontractors and vendors.

Prime contractors may require subcontractors and vendors to develop a tailored plan to comply with NASA-STD-6016 or a tailored plan to comply with the prime contractor's plan.

Alternatively, prime contractors may flow down a limited subset of (or even no) requirements, with the prime making up the difference between the subset and materials control plan.

Whichever approach is selected, prime contractors are responsible for ensuring that hardware designed and fabricated by their subcontractors meet the materials control plan or NASA-STD-6016.

c. [MPR 11] Upon approval by the procuring activity, the Materials and Processes Selection, Control, and Implementation Plan shall become the M&P implementation document used for verification.

The Materials and Processes Selection, Control, and Implementation Plan should be approved by the responsible design authority.

Additional requirements on the Materials and Processes Selection, Control, and Implementation Plan content follow in sections 4.1.1.1 through 4.1.1.3.

### 4.1.1.1 Coordination, Approval, and Tracking

[MPR 12] The Materials and Processes Selection, Control, and Implementation Plan shall identify the method of coordinating, approving, and tracking all engineering drawings,

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engineering orders, and other documents that establish or modify materials and/or processes usage.

### 4.1.1.2 Approval Signature

[MPR 13] The Materials and Processes Selection, Control, and Implementation Plan shall include a requirement that all hardware design drawings and revisions for spaceflight hardware that provides mission-critical functions contain an M&P approval block, or equivalent, to ensure that the design has been reviewed by the responsible M&P authority and complies with that document.

### **4.1.1.3** Manufacturing Planning

[MPR 14] The Materials and Processes Selection, Control, and Implementation Plan shall identify how the responsible M&P organization participates in manufacturing and inspection/verification planning to ensure compliance with M&P requirements.

### 4.1.2 M&P Controls

- a. [MPR 15] All M&P for spaceflight hardware that provides mission-critical functions shall be defined by standards and specifications selected from government, industry, and company specifications and standards.
- b. [MPR 16] All M&P for spaceflight hardware that provides mission-critical functions shall be identified directly on the appropriate engineering drawing.
- c. [MPR 17] Company M&P specifications shall be identified by document number in the Materials and Processes Selection, Control, and Implementation Plan.
- d. [MPR 18] All M&P specifications used to produce spaceflight hardware that provides mission-critical functions shall be made available to the responsible NASA Program or Project Office and M&P organization.
- e. [MPR 19] Process specifications for spaceflight hardware that provides mission-critical functions shall define process steps at a level of detail that ensures a repeatable/controlled process that produces a consistent and reliable product.
- f. [MPR 20] Process qualification shall be conducted to demonstrate the repeatability of all processes for spaceflight hardware that provides mission-critical functions where the quality of the product cannot be directly verified by subsequent monitoring or measurement.

**Note:** The process requirements in section 4.2.4 of this NASA Technical Standard do not always define process steps at a level of detail that ensures a repeatable/controlled process that

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produces a consistent and reliable product, so it should not be assumed that they are suitable to be called out as process specifications on engineering drawings. They are intended as higher level documents that state minimum requirements and provide general directions for the design of hardware.

### 4.1.2.1 Standard and Specification Obsolescence

[MPR 21] A process shall be established for ensuring that updated, alternate, or new material or process standards or specifications from those identified in the Materials and Processes Selection, Control, and Implementation Plan meet or exceed the technical requirements identified in the original material or process standards or specifications.

During a long-term program, M&P standards and specifications identified in this document or in contractor materials control plans could become obsolete. Continued use of obsolete standards and specifications is acceptable for manufacturing series or new-design hardware. Although updated M&P standards or specifications usually meet or exceed earlier standards and specifications, their use can result in requirements creep so that new hardware no longer meets the original design requirements.

### 4.1.3 Commercial Off-The-Shelf (COTS) Hardware

[MPR 22] A procedure shall be established to ensure that all vendor-designed, off-the-shelf, and vendor-furnished items are covered by the M&P requirements of this document, with the exception that M&P requirements for off-the-shelf hardware and other spaceflight hardware that do not provide mission-critical functions may be limited to those required to ensure safety of flight (for example, flammability, toxic offgassing) and vehicle compatibility (for example, vacuum outgassing).

#### 4.1.4 M&P Control Panel

- a. [MPR 23] An M&P control panel shall be established by each contractor hardware provider (excluding subcontractors).
- b. [MPR 24] The M&P control panel's scope and membership shall be described in the Materials and Processes Selection, Control, and Implementation Plan.

The M&P control panel plans, manages, and coordinates the selection, application, procurement, control, and standardization of M&P for the contract.

The panel also resolves and dispositions M&P problems.

The responsible NASA M&P organization is an active member of the panel and has the right of disapproval of panel decisions.

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### 4.1.5 M&P Usage Documentation

- a. [MPR 25] M&P usage shall be documented in an electronic, searchable parts list or separate electronic searchable Materials Identification and Usage List (MIUL) with the following exceptions:
  - (1) Electrical, electronic, and electromechanical (EEE) parts other than wire, cable, and exposed surfaces of connectors.
  - (2) Materials used in hermetically sealed electronic containers (maximum leak rate less than  $1 \times 10^{-4} \text{ cm}^3/\text{sec}$ ).
  - b. [MPR 26] The documentation of M&P usage shall cover the final design as delivered.
- c. [MPR 27] The documentation approach shall be defined in the Materials and Processes Selection, Control, and Implementation Plan.

Recommended MIUL content is described in Appendix D, Recommended Data Requirements Documents. Material codes and ratings for materials, standard and commercial parts, and components are available in the Materials and Processes Technical Information System (MAPTIS). When required, new material codes will be assigned by NASA's Marshall Space Flight Center (MSFC). In some cases, MAPTIS contains averages for ratings or test results for generic materials controlled by military or industry specifications; the material codes for the generic materials are used.

MAPTIS is accessible via the Internet at <a href="http://maptis.nasa.gov">http://maptis.nasa.gov</a>.

*Note:* Accessibility to MAPTIS is by registration only.

### **4.1.6** Material Usage Agreements (MUAs)

a. [MPR 28] MUAs containing sufficient information to demonstrate that the application is acceptable shall be submitted by the responsible M&P organization for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

The use of M&P that do not comply with the requirements of this NASA Technical Standard may still be acceptable in the actual hardware applications.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

The MUA generation and approval system should be defined in the Materials and Processes Selection, Control, and Implementation Plan. A recommended MUA approach is described in Appendix D.

b. [MPR 29] MUAs shall not be used to change the M&P requirements for a nonconforming product.

When the nonconformance is a deviation from M&P requirements that is acceptable for future series hardware, an MUA may be generated to provide technical support for a change to the product baseline.

A typical MUA form is shown in Appendix B, Typical MUA Form.

### **4.1.6.1** Human-Rated Spacecraft

For human-rated spaceflight hardware, a tiered MUA system with three categories is recommended.

### **4.1.6.1.1** Category I MUAs

Category I MUAs are those that involve M&P usage that could affect the safety of the mission, crew, or vehicle or affect the mission success but have to be used for functional reasons.

Category I MUAs are delivered by the hardware developer and approved by the responsible NASA M&P organization and the NASA Program/Project Office.

#### 4.1.6.1.2 Category II MUAs

Category II MUAs are those that involve M&P usage that fails a screening of M&P requirements and is not considered a hazard in its use application but for which no Category III rationale code exists. Category II MUAs are delivered by the hardware developer and approved by the responsible NASA M&P organization.

### 4.1.6.1.3 Category III MUAs

Contractors who want to use Category III rationale codes relevant to their hardware may do so through their Materials and Processes Selection, Control, and Implementation Plan. Category III MUAs are those that involve M&P that have not been shown to meet these requirements but have an appropriate rationale code listed in the Materials and Processes Selection, Control, and Implementation Plan. The rationale codes are approved as part of the overall Materials and Processes Selection, Control, and Implementation Plan approval. Category III rationale codes are evaluated and determined to be acceptable at the configuration/part level.

Approved Category III MUAs are reported in the MIUL system or electronic data system.

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Category III MUAs are approved by the hardware developer and responsible M&P organization through acceptance of the MIUL. No MUA form is submitted.

Note: The Category III MUA rationale codes in the previous release of this NASA Technical Standard have been retired, either because the acceptance rationale was deemed inadequate or because the application was made an exception to the requirement. Retired codes are listed in Appendix C, Retired Category III MUA Rationale Codes, for continuity purposes but should not be used for hardware designed to this NASA-STD-6016 release unless they are listed as approved rationale codes in the Materials and Processes Selection, Control, and Implementation Plan.

### 4.1.7 Materials Certification and Traceability

- a. [MPR 30] All parts or materials for spaceflight hardware that provides mission-critical functions shall be certified as to composition, properties, and requirements as identified by the procuring document.
- b. [MPR 31] With the exception of off-the-shelf parts, parts and materials used in critical applications, such as life-limited materials and/or safety- and fracture-critical parts, shall be traceable through all processing steps defined in the engineering drawing to the end-item application.
- c. [MPR 32] Distributors or other processors shall not heat treat, hot work, or cold work metal stock unless they take the responsibilities as the producer of the metal and produce a new certification.

Processing records should be retained for the life of the program. Processing records for program residual hardware should be delivered to the procuring authority as part of contract termination.

### 4.1.8 Material Design Values

In the design and analysis of aerospace hardware, the terms "material allowables," "design allowables," and "design values" are commonly used to address the design values used in structural analysis. The term "design values" is used throughout this document which encompasses both the material and design feature performance, whichever is used to support the structural certification.

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### **4.1.8.1** Requirements for Design Values

a. [MPR 33] A, B, or S-basis statistical values for mechanical properties of materials shall be utilized for the design and analysis of hardware for all applications where structural analysis is required.

Statistical design values are needed for any hardware where structural analysis is required in order to demonstrate positive margins of safety for the design loads and environments in combination with the factor of safety requirements.

Each distinct form of a material should be assumed to have unique design values unless testing and statistical analysis shows that design values are combinable. For example, rolled bar may have different design values than the same alloy in plate, forging, spin forming, extrusion, or casting. Different layups affect the properties of composite structures. Manufacturing methods, like welding, brazing, swaging, forming, diffusion bonding, adhesive bonding, and co-curing of sandwich alter the properties of the original materials. Design features, such as joints, ply-drops, and tapered ramps affect the design values of composites.

Design values are also required for other mechanical properties, such as dynamic properties like fatigue and fracture. The basis for these properties is not necessarily statistical, but the sampling is expected to be representative of the material, product form, and state used in the design. Some applications require lower bound, and others require typical properties. The specific requirement can be found in the governing specifications for the design, such as NASA-STD-5019, Fracture Control Requirements for Spaceflight Hardware, or NASA-STD-5012, Strength and Life Assessment Requirements for Liquid-Fueled Space Propulsion System Engines.

b. [MPR 34] The sampling for other mechanical properties, such as dynamic properties like fatigue and fracture, and verification of design values shall be representative of the material, product form, and state used in the design.

The statistical basis for fatigue and fracture properties should be consistent with the governing specification. For example, NASA-STD-5019 allows for the use of typical fracture toughness and crack growth rate properties in the assessment of assumed defects; NASA-STD-5012 requires the use of bounding fatigue design curves for critical hardware in the primary load path. Fatigue data provided in MMPDS requires further analysis to derive a bounded design curve.

c. [MPR 35] A, B, or S-basis statistical methods shall be defined by, and values for mechanical properties in their design environment taken from MMPDS, Metallic Materials Properties Development and Standardization, or SAE CMH-17, Composite Materials Handbook.

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S-basis statistical values apply to metallic structures only. Although SAE CMH-17 does use the term "S-basis," it is used only for screening composite materials and such values may not be used in design.

Design values in CMH-17 Volume 2 may be used only if each production facility substantiates that its material and process controls produce repeatable and reliable results that support the published design value. "Equivalency" test methods such as those outlined in DOT/FAA/AR-03/19, Material Qualification and Equivalency for Polymer Matrix Composite Material Systems: Updated Procedure, are acceptable.

d. [MPR 36] For metallic materials, the alloy, heat treatment, product specification, product form, and thickness shall match the alloy, heat treatment, product specification, product form, and thickness in MMPDS.

Since the testing to develop design values is specific to alloy, heat treatment, specification and form, the statistical relationship is relevant only to that same combination. Thickness affects strength of metal because of metallurgical factors that influence strength, like heat transfer during heat treatment and variability of reduction during metal working.

SAE CMH-17 is composed of six volumes: SAE CMH-17-1G, Volume 1 – Polymer Matrix Composites Guidelines for Characterization of Structural Materials; SAE CMH-17-2G, Volume 2 – Polymer Matrix Composites Materials Properties; SAE CMH-17-3G, Volume 3 – Polymer Matrix Composites Materials Usage, Design, and Analysis; SAE CMH-17-4B, Volume 4 – Metal Matrix Composites; MIL-HDBK-17-5, Volume 5 – Ceramic Matrix Composites; and SAE CMH-17-6, Volume 6 – Structural Sandwich Composites.

#### Notes:

- (1) Design values of structural materials listed in later versions of MMPDS or SAE CMH-17 than those specified in section 2 may be used provided the methodology used to develop the allowable mechanical properties is at least as conservative.
- (2) When released, SAE CMH-17-5 may be used in place of MIL-HDBK-17-5. SAE CMH-17-5 is scheduled for publication in 2017.
- (3) Published properties need to be appropriate for the design environment. For example, published properties at ambient temperature are not typically appropriate for applications in high-temperature environments.
- (4) Design Values calculated based on regression analysis according to SAE CMH-17 (Volume 1, section 8.3.7) are acceptable.
- (5) Caution is warranted for material properties that significantly exceed minimum specification values. Sensitivity to stress corrosion cracking, loss of ductility and

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fracture toughness, and degraded mechanical properties at cryogenic temperatures, may result in some alloys that are over-strengthened. For example, for quenched and tempered alloy steels, precipitation hardened steels, heat treatable aluminums etc., the durability and behavior in service environments may be adversely affected when they are strengthened significantly beyond their minimum strength requirements.

- (6) Section 4.2.2 of this NASA Technical Standard contains requirements for test verification of the adequacy of the heat treatment process when metallic materials are user heat treated.
- (7) For composite structures, "pristine" A and B-basis design values may not be appropriate as they can be compromised by manufacturing defects, mishandling, impacts, etc. Such damage is commonly in the form of subsurface delaminations that cannot be seen by visual inspection or detected by a practical NDE program. Degraded design values that take into account damage tolerance may be substantially lower than pristine design values, and may be required in accordance with NASA-STD-5019, Fracture Control Requirements for Spaceflight Hardware.
- e. [MPR 37] When statistical design values for new or existing structural materials are not available, they shall be determined by methods described in MMPDS or SAE CMH-17 and a report documenting the derivation of the new design values be made available to NASA for review.

Design values for polymeric materials other than composites are covered by this requirement but are not addressed by MMPDS or SAE CMH-17. The methods described in SAE CMH-17 are appropriate for such materials.

It is recognized that the development of statistical design values may, at times, be impractical for materials in extreme environments given project resource limitations. In such cases, the contractor should develop a tailored approach to adequately substantiate the design values for the environment and submit the approach and design values for approval via an MUA.

f. [MPR 38] The implementation of an approach for generating statistical design values that deviates from the sampling methodology and statistical methods in MMPDS or SAE CMH-17 and the use of design values that deviate from those published in MMPDS or SAE CMH-17 shall be approved with an MUA.

At a minimum, the following should be should be addressed in the MUA documenting the rationale for use of the alternative approach for generating statistical design values that deviate from the guidance in MMPDS or SAE CMH-17.

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- (1) Description of the statistical approach.
- (2) Description of the number of test specimens, number of lots, heats, and/or production units, e.g., weld panels, castings, parts.
- (3) Description of the range of relevant process parameters.
- (4) Verification that the test specimens are representative of the product specification and product form used in the design (for metallic materials, the heat treatment and thickness also need to be verified as representative).

The following should be addressed in the MUA documenting the rationale for use of the alternative design values:

- (1) How the design values have been derived.
- (2) How future material lots will be verified for performance.
- (3) Justification for use of the alternate statistical methods or the use of engineering reduction factors.

For new or modified production methods, consistency with the original qualification testing and the associated design values should be demonstrated at an appropriate structural scale.

g. [MPR 39] All contractor-developed mechanical and physical property data shall be made available to the responsible NASA M&P organization.

### 4.1.8.2 Design Value Implementation in Design

a. [MPR 40] Material "B" design values shall not be used except in redundant structure in which the failure of a component would result in a safe redistribution of applied loads to other load-carrying members.

Material "B" or "B-basis" design values are specified to assure reliability for redundant structures, which are typically components or structural elements with a redundant load path. Material "A" or "A-basis" design values may be used in lieu of Material "B" or "B-basis" because they are derived using a more conservative statistical method.

Note: For nonmetallic structures, this requirement applies only to pristine material "B" design values. For fracture-critical nonmetallic structures, B-basis design values should be used in accordance with the methods outlined in NASA-STD-5019. B-basis design values developed for intentionally damaged structure as part of damage tolerance assessment may be acceptable for non-redundant structure. As strength and life verification of composites requires empirical

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testing, it may become necessary to first develop design values representing the intrinsic material constitutive properties, and then separately establish design values for discrete design features which cannot be adequately correlated via traditional stress analysis. Examples may include complex ply-drop scenarios, discontinuities, composite/metallic interfaces, sandwich ramps, or unique bonded/bolted joints. In such cases, strictly using "material" design values rather than establishing design values specific to the design feature may result in an inadequately designed structure.

[Composite damage tolerance is outside the scope of this NASA Technical Standard; NASA-STD-5019, Fracture Control Requirements for Spaceflight Hardware, contains requirements on this subject.]

b. [MPR 41] Minimum property acceptance values in material specifications (specification minimums) not explicitly published as "S" design values in MMPDS shall require an approved MUA for use as design values.

MMPDS requires three distinct lots of metal be tested and the data statistically analyzed and tested before the "S" design values are published in the handbook.

To minimize MUA activity, a process or set of standardized criteria can be defined in the Materials and Process Control Plan to allow the use of specification minimums for design without MUAs. Approaches could include extra lot testing, proof testing, substantiating the "S" basis over time, high margin applications, or the use of substantiated engineering reduction factors.

### 4.1.8.3 Structural Fastener Design Values

[MPR 42] Structural fastener design values shall be defined by minimum load test requirements in the applicable part and/or procurement specification (government, aerospace industry consensus, company-specific, or custom specification).

MMPDS design values are not transferrable to fasteners, because raw material used to make fasteners is reprocessed using various metallurgical practices such as hot heading, thread rolling, and heat treating. These processes change the strength of the metal from the original bar stock. NASA has chosen to adopt lot tested design strength defined in the specific fastener part and procurement specifications as the design value instead of the certifications of the original bar stock.

Other structural fastener requirements are identified in section 4.2.6.6.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

### **4.2** Detailed Requirements

### 4.2.1 Flammability, Offgassing, and Compatibility Requirements

[MPR 43] Materials shall meet the requirements of NASA-STD-6001B, Flammability, Offgassing, and Compatibility Requirements and Test Procedures, as described below.

### **4.2.1.1** Flammability Control

[MPR 44] Materials that are nonflammable or self-extinguishing in their use configuration as defined by NASA-STD-6001B, Test 1 or an appropriate configurational flammability test per NASA-STD-6001B, shall be used for flammability control with the following exceptions:

- a. Ceramics, metal oxides, and inorganic glasses are exempt.
- b. Materials that are designed to ignite and burn in their use application (for example, pyrotechnic materials) are exempted from flammability requirements, provided that systems/experiments using such materials are designed so that the burning materials cannot act as an ignition source for other hardware.
- c. Materials used in minor quantities (dimensions controlled so the potential fire propagation path is less than 15 linear cm (6 linear in) and the surface area is no more than 80 cm² (12 square in)) in crew environments and 30 linear cm (12 linear in) for external materials) with no propagation path or ignition source.
- d. Materials used in sealed containers are exempt because insufficient oxygen is available to maintain combustion.
- e. Materials within vented electronics packages with metallic cases and no forced air convection are exempt because of the self-extinguishing effect of expanding combustion gases in a constrained volume.
- f. Materials that have been shown by test to meet the requirements of NASA-STD-6001B may be used in an environment with an oxygen concentration lower than the test level without further testing (provided that the oxygen partial pressure is no greater than the partial pressure at the test level or general test data exist to demonstrate that the higher oxygen partial pressure is outweighed by the lower percentage concentration for the environments in question).
- g. Materials are acceptable when used on a metal substrate that provides an adequate heat sink. A heat sink is considered adequate in the use configuration by test or analysis. When testing is conducted, materials passing the flammability test on a metal substrate are acceptable on metal substrates of the same thickness or greater. Materials that are flammable but have a

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thickness less than 0.25 mm (0.010 in) and are attached to a metallic surface greater than 1.6 mm (0.062 in) thick are acceptable by analysis.

h. Materials are unexposed, overcoated with a verified fire-blocking material, or no more than 1/4 inch thick and sandwiched between nonflammable materials with only the edges exposed.

Many situations arise where flammable materials are used in an acceptable manner without test, using mitigation practices and the MUA approval system. Guidelines for hardware flammability assessment and mitigation can be found in JSC 29353, Flammability Configuration Analysis for Spacecraft Applications.

i. Flammability configuration analysis in accordance with JSC 29353 shows hardware configuration to be self-extinguishing.

Material flammability ratings and tests based on NASA-STD-6001B for many materials are found in the MAPTIS database.

### 4.2.1.2 Toxic Offgassing

- a. [MPR 45] All nonmetallic materials used in habitable flight compartments, with the exception of ceramics, metal oxides, inorganic glasses, and materials used in sealed container (maximum leak rate less than  $1 \times 10^{-4} \text{ cm}^3/\text{sec}$ ), shall meet the offgassing requirements of Test 7 of NASA-STD-6001B.
- b. [MPR 46] Spacecraft maximum allowable concentration (SMAC) values shall be obtained from JSC 20584 (2008), Spacecraft Maximum Allowable Concentrations for Airborne Contaminants, or from MAPTIS for compounds for which no SMAC values are found in JSC 20584.

### **4.2.1.3** Fluid Compatibility (Fluids Other Than Oxygen)

a. [MPR 47] Materials exposed to hazardous fluids<sup>1</sup> shall be evaluated or tested for compatibility.

NASA-STD-6001B, Test 15, is a 48-hour screening test for short-term exposure to fuels and oxidizers.

<sup>&</sup>lt;sup>1</sup> For the purpose of this standard, the definition of hazardous fluids includes gaseous oxygen (GOX), liquid oxygen (LOX), fuels, oxidizers, and other fluids that could cause corrosion, chemically or physically degrade materials in the system, or cause an exothermic reaction.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

b. [MPR 48] Appropriate long-term tests to simulate the worst-case use environment that would enhance reactions or degradation shall be conducted for materials with long-term exposure to liquid fuels, oxidizers, and other hazardous liquids.

The test program needs to demonstrate that materials will not degrade unacceptably during the actual time of hazardous fluid exposure, including ground processing prior to flight, flight exposure, and post-flight processing prior to decontamination. Use of elevated temperatures to accelerate the test and/or extrapolation of minor degradation from the test duration to the actual time of hazardous fluid exposure are acceptable approaches.

NASA-STD-6001B, Supplemental Test A.7, identifies changes resulting from incidental exposure (minor amounts, such as a splash) to fuels or oxidizers.

- c. [MPR 49] Materials degradation in long-term tests shall be characterized by post-test analyses of the material and fluid to determine the extent of changes in chemical and physical characteristics, including mechanical properties.
- d. [MPR 50] The effect of material condition (for example, parent versus weld metal or heat-affected zone) shall be addressed in the compatibility determination.
- e. [MPR 210] Materials used in nitrogen tetroxide systems shall be evaluated for flammability in nitrogen tetroxide using promoted combustion tests similar to NASA-STD-6001B, Test 17, for metallic materials used in oxygen systems and Test 1 for polymeric materials.
- (1) [MPR 211] When materials are determined to be flammable, a nitrogen tetroxide compatibility assessment shall be conducted using the methodology described for oxygen systems in NASA-STD-6001B and the system safety rationale of this assessment documented in an MUA.
- f. [MPR 212] Materials used in other oxidizer systems shall be evaluated for potential ignition.

### 4.2.1.4 Oxygen Compatibility

a. [MPR 51] Materials and components, and systems used in liquid oxygen (LOX) and gaseous oxygen (GOX) environments, compressed air systems, and pressurized systems containing enriched oxygen shall be evaluated for oxygen compatibility in accordance with NASA-STD-6001B.

Material flammability ratings and tests based on NASA-STD-6001B for many materials are found in the MAPTIS database.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

b. [MPR 52] When materials in such systems are determined to be flammable, an oxygen compatibility assessment shall be conducted as described in NASA-STD-6001B and the system safety rationale of this assessment documented in an MUA.

As described in NASA-STD-6001B, material/component configurational testing may be required to support the compatibility assessment.

Compressed air systems and pressurized systems containing enriched oxygen are inherently less hazardous than systems containing pure oxygen; the hazard increases with oxygen concentration and pressure.

Guidelines on the design of safe oxygen systems are contained in ASTM MNL 36, Safe Use of Oxygen and Oxygen Systems: Handbook for Design, Operation, and Maintenance; ASTM G88, Standard Guide for Designing Systems for Oxygen Service; ASTM G63, Standard Guide for Evaluating Nonmetallic Materials for Oxygen Service; ASTM G94, Standard Guide for Evaluating Metals for Oxygen Service; and NASA/TM-2007-213740, Guide for Oxygen Compatibility Assessments on Oxygen Components and Systems.

## **4.2.1.4.1** Oxygen Component Acceptance Test

[MPR 53] GOX and enriched air system components that operate at pressures above 1.83 MPa (265 psia), with the exception of metallic components, such as hard lines (rigid metallic tubing), metallic flex hoses, metallic fluid fitting with all metal seals, and metallic pressure vessels (including composite overwrapped pressure vessels with metallic liners), shall undergo oxygen component acceptance testing for a minimum of ten cycles from ambient pressure to maximum design pressure within 100 milliseconds to ensure that all oxygen system spaceflight hardware is exposed to oxygen prior to launch.

This test is an acceptance test, not a qualification test, and is required for all sets of spaceflight hardware. Retesting is required if post-test actions (such as rework, repair, or interfacing with hardware having uncontrolled cleanliness) invalidate the acceptance test.

LOX system components should also be acceptance tested, but the system hardware acceptance test is normally adequate for this purpose. The number of test cycles should be as defined in the system hardware acceptance test (typically well below the ten cycles required for gaseous systems).

#### **4.2.1.5** Electrical Wire Insulation Materials

a. [MPR 54] Electrical wire insulation materials shall be evaluated for flammability in accordance with NASA-STD-6001B, Test 4 or Test 1.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Test 4 should be used for insulation on electrical power wiring where the maximum current passing through the wiring can raise the temperature above 49 °C (120 °F). Either test can be used for signal/data wiring and other wiring where the current is too small to raise the temperature above this value.

b. [MPR 55] Arc tracking shall be evaluated in accordance with NASA-STD-6001B, Test 18, for all wire insulation constructions except polytetrafluoroethylene (PTFE), PTFE/polyimide insulation conforming to SAE AS22759C, Wire, Electrical, Fluoropolymer-Insulated, Copper or Copper Alloy, and used in conditions bounded by the dry arc-tracking test specified by SAE AS22759C, ethylene tetrafluoroethylene (ETFE), and silicone-insulated wires (the resistance of these materials to arc tracking has already been established).

#### **4.2.2** Metals

[MPR 56] MSFC-STD-3029A, Guidelines for the Selection of Metallic Materials for Stress Corrosion Cracking Resistance in Sodium Chloride Environments, shall be used to select metallic materials to control stress corrosion cracking of metallic materials in sea and air environments, with the exception that an MUA is not required for the following conditions:

- a. Parts in electrical/electronic assemblies with maximum tensile stress less than 50 percent of the yield strength.
- b. Martensitic or precipitation-hardening (PH) stainless steels used in ball bearing or similar applications where the loading is compressive.

This exception cannot be used for ball-bearing races for which the primary loading is tensile.

- c. Carbon and low alloy high-strength steels with strength greater than 1240 MPa (180 ksi) used in ball bearings, springs, or similar applications where the loading is compressive and there is a history of satisfactory performance.
  - d. Hardware provides no mission-critical functions.

Additional information regarding metallic materials can be found in MAPTIS.

#### **4.2.2.1 Aluminum**

Aluminum alloys used in structural applications should be resistant to general corrosion, pitting, intergranular corrosion, and stress corrosion cracking.

[MPR 57] The 5000-series alloys containing more than 3 percent magnesium shall not be used in spaceflight hardware that provides mission-critical functions where the temperature exceeds  $66 \,^{\circ}\text{C} \, (150 \,^{\circ}\text{F})$ .

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Grain boundary precipitation above 66 °C (150 °F) can create stress-corrosion sensitivity.

#### 4.2.2.2 Steel

## 4.2.2.2.1 Drilling and Grinding of High-Strength Steel

When performing drilling, grinding, reaming, or machining of steels, low-stress machining techniques with coolant should be used. Uncontrolled high-stress machining used without coolant is detrimental to the steel microstructure. Untempered martensite is formed that leads to cracking. Overheating can soften the steel due to overtempering or decarburization. Low-stress machining practices, such as those in SAE AMS2453, Low Stress Grinding of Steel Parts Heat Treated to 180 ksi or Over, and Low Stress Grinding of Chrome Plating Applied to Steel Parts Heat Treated to 180 ksi or Over, should be used to prevent damage to the microstructure.

- a. [MPR 58] When drilling, grinding, reaming, or machining is performed on high-strength steels that can form martensite and are used in spaceflight hardware that provides mission-critical functions, a validated process for machining shall be used.
- b. [MPR 59] The absence of machining damage for high-strength steels used in spaceflight hardware that provides mission-critical functions shall be verified by microexamination of production parts (such as Nital etch inspection) or by a microhardness and metallurgical examination of sample parts for either of the following situations:
  - (1) When the material has very low toughness (such as martensitic steel above 200 ksi) and the part has low stress margins or is fatigue driven.
  - (2) When the surface condition of the part is critical to the design (such as its ability to withstand hertzian stresses or remain perfectly flat).

#### 4.2.2.2.2 Corrosion-Resistant Steel

- a. [MPR 60] Unstabilized, austenitic steels shall not be processed or used above 371 °C (700 °F) in spaceflight hardware that provides mission-critical functions.
- b. [MPR 61] Welded assemblies used in spaceflight hardware that provides mission-critical functions shall be solution heat-treated and quenched after welding except for the stabilized or low carbon grades, such as 321, 347, 316L, and 304L.
- c. [MPR 62] Service-related corrosion issues are common for free-machining alloys, such as 303, and these alloys shall not be used in spaceflight hardware that provides mission-critical functions when they can be exposed to moisture other than transient condensation, or to nitrogen tetroxide.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

# **4.2.2.2.3 Ductile-Brittle Transition Temperature**

[MPR 63] Steels shall not be used in tension below their ductile-brittle transition temperature.

Alloy and carbon steels, as well as ferritic, martensitic, and duplex steels tend to become brittle as the temperature is reduced. Balls in ball bearings are generally acceptable because they are in compression.

#### **4.2.2.3** Titanium

#### 4.2.2.3.1 Titanium Contamination

a. [MPR 64] All cleaning fluids and other chemicals used during manufacturing and processing of titanium hardware for spaceflight hardware that provides mission-critical functions shall be verified to be compatible and not detrimental to performance before use.

Hydrochloric acid, chlorinated solvents, chlorinated cutting fluids, fluorinated hydrocarbons, and anhydrous methyl alcohol can all produce stress corrosion cracking. Mercury, cadmium, silver, and gold have been shown to cause liquid-metal-induced embrittlement and/or solid-metal-induced embrittlement in titanium and its alloys. Liquid-metal-induced embrittlement of titanium alloys by cadmium can occur as low as 149 °C (300 °F), and solid-metal-induced embrittlement of titanium alloys by cadmium can occur as low as room temperature.

b. [MPR 65] The surfaces of titanium and titanium alloy mill products used for spaceflight hardware that provides mission-critical functions shall be 100 percent machined, chemically milled, or pickled to a sufficient depth to remove all contaminated zones and layers formed while the material was at elevated temperature.

Contaminated zones and layers may be formed as a result of mill processing, heat treating, and elevated temperature-forming operations.

#### 4.2.2.3.2 Titanium Wear

Titanium and its alloys exhibit very poor resistance to wear. Fretting that occurs at interfaces with titanium and its alloys has often contributed to crack initiation, especially fatigue initiation. The preferred policy is a design that avoids fretting and/or wear with titanium and its alloys. Bolted joints are not considered to fret.

[MPR 66] All regions of titanium alloys for spaceflight hardware that provides mission-critical functions that are subject to fretting or wear shall be anodized per SAE AMS2488D, Anodic Treatment – Titanium and Titanium Alloys Solution, pH 13 or Higher, or hard-coated utilizing a wear-resistance material, such as tungsten carbide/cobalt thermal spray.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

## 4.2.2.3.3 Titanium Flammability

- a. [MPR 67] Titanium alloys shall not be used with LOX or GOX at any pressure or with air at oxygen partial pressures above 35 kPa (5 psia).
- b. [MPR 68] Titanium alloys shall not be machined inside spacecraft modules during ground processing or in flight, because machining operations can ignite titanium turnings and cause fire.

#### 4.2.2.4 Magnesium

- a. [MPR 69] Magnesium alloys shall not be used in primary structure or in other areas of spaceflight hardware that provides mission-critical functions that are subject to wear, abuse, foreign object damage, abrasion, erosion, or where fluid or moisture entrapment is possible.
- b. [MPR 70] Magnesium alloys shall not be machined inside spacecraft modules during ground processing or in flight, because machining operations can ignite magnesium turnings and cause fire.

## 4.2.2.5 Beryllium

Beryllium alloys are exceptionally lightweight but are not often used because of the extreme toxicity of beryllium salts and oxides, and because it is unusually susceptible to damage. Alloys containing up to 4 percent beryllium by weight are not an issue, provided they are not machined inside spacecraft crew compartments.

- a. [MPR 71] Alloys containing more than 4 percent beryllium by weight shall not be used for primary structural applications.
- b. [MPR 72] Alloys containing more than 4 percent beryllium by weight shall not be used for any application within spacecraft crew compartments unless suitably protected to prevent erosion or formation of salts or oxides.
- c. [MPR 73] Design of beryllium parts for spaceflight hardware that provides mission-critical functions shall address its low-impact resistance and notch sensitivity, particularly at low temperatures, and its directional material properties (anisotropy) and sensitivity to surface finish requirements.
- d. [MPR 74] All beryllium parts used in spaceflight hardware that provides mission-critical functions shall be processed to ensure complete removal of the damaged layer (twins and microcracks) produced by surface-metal-working operations, such as machining and grinding.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Chemical/milling and etching are recognized successful processes for removal of the damaged layer.

e. [MPR 75] Beryllium-containing alloys (including alloys containing less than 4 percent beryllium by weight) and oxides of beryllium shall not be machined inside spacecraft crew compartments at any stage of manufacturing, assembly, testing, modification, or operation.

Stripping, crimping, and cutting electrical wire are not considered to be machining operations.

f. [MPR 76] All beryllium parts used in spaceflight hardware that provides mission-critical functions shall be penetrant-inspected for crack-like flaws with a high-sensitivity fluorescent dye penetrant in accordance with section 4.2.5.

#### **4.2.2.6** Cadmium

Cadmium is highly toxic, can sublime and cause outgassing contamination at elevated temperatures in vacuum, and can cause liquid metal embrittlement of titanium and some steel alloys. Cadmium plating can spontaneously form cadmium whiskers.

- a. [MPR 77] Cadmium shall not be used in crew or vacuum environments.
- b. [MPR 78] Cadmium-plated tools and other hardware shall not be used in the manufacture or testing of spaceflight hardware that provides mission-critical functions.

#### 4.2.2.7 Zinc

[MPR 79] Owing to zinc's ability to grow whiskers, zinc plating other than black zinc-nickel plating shall not be used in spaceflight hardware that provides mission-critical functions.

Metallic zinc is less volatile than cadmium but should not be used in vacuum environments where the temperature/pressure environment could cause contamination of optical surfaces or electrical devices.

## **4.2.2.8** Mercury

a. [MPR 80] Equipment containing mercury shall not be used where the mercury could come in contact with spaceflight equipment during manufacturing, assembly, test, checkout, and flight.

*Mercury has the potential for causing liquid-metal embrittlement.* 

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b. [MPR 81] Spaceflight hardware (including fluorescent lamps) containing mercury shall have three levels of containment to prevent mercury leakage.

Nonflight lamps containing mercury, such as those used in hardware ground processing and fluorescent dye penetrant inspection of flight parts, are acceptable, provided that the bulbs are protected by a nonshatterable, leak-proof outer container.

## 4.2.2.9 Refractory Metals

[MPR 82] For refractory alloys (alloys with a melting point above 2000 °C (3600 °F), plus osmium and iridium) used in mission-critical applications, tests shall be performed to characterize critical design properties for the intended application and the data documented in an MUA.

Engineering data on refractory alloys are limited, especially under extreme environmental conditions of spacecraft.

## **4.2.2.10** Superalloys (Nickel-Based and Cobalt-Based)

In these requirements, a superalloy refers to a nickel- or cobalt- based alloy that retains all or most of its strength at usage temperatures approaching 538 °C (1000 °F) and higher. Examples include both wrought products such as Inconel 718 and castings such as Mar-M-247 and Inconel 625.

a. [MPR 83] High-nickel content alloys are susceptible to sulfur embrittlement; therefore, for spaceflight hardware that provides mission-critical functions, any foreign material which could contain sulfur, such as oils, grease, and cutting lubricants, shall be removed by suitable means prior to heat treatment, welding, or high temperature service.

Some of the precipitation-hardening superalloys are susceptible to alloying element depletion at the surface in a high temperature, oxidizing environment. Nickel-based superalloys are susceptible to grain boundary cracking phenomena at elevated temperatures, such as Stress Assisted Grain Boundary Oxidation Embrittlement (SAGBOE), and to stress rupture during heat treatment.

b. [MPR 84] The reduction to design properties of alloying element depletion at the surface in a high temperature, oxidizing environment shall be evaluated when a thin sheet of one of these alloys is used for spaceflight hardware that provides mission-critical functions, since a slight amount of depletion could involve a considerable proportion of the effective cross section of the material.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

#### 4.2.2.11 Tin

High-purity tin and tin plating are susceptible to two degradation phenomena: tin whisker growth and tin pest (sometimes known as tin plague). The following requirements for tin whisker mitigation may not be adequate to prevent tin pest from occurring:

- a. [MPR 85] For spaceflight hardware that provides mission-critical functions, tin and tin plating shall be alloyed with at least 3 percent lead by weight or other proven alloying element(s) to prevent tin whisker growth.
- b. [MPR 86] Tin and tin plating alloyed with less than 3 percent lead by weight and used in electrical/electronic applications shall comply with GEIA-STD-0005-1A, Performance Standard for Aerospace and High Performance Electronic Systems Containing Lead-Free Solder, and Control Level 2C requirements of GEIA-STD-0005-2A, Standard for Mitigating the Effects of Tin Whiskers in Aerospace and High Performance Electronic Systems, with the following exceptions:
  - (1) Solder alloy Sn96.3Ag3.7 (Sn96) used for high-temperature applications.
  - (2) Solder alloy Au80Sn20 used as a die attach material or as a package sealing material.
  - (3) Tin alloys containing less than 20 percent tin by weight.
- c. [MPR 87] When high-purity tin and tin plating are used for spaceflight hardware that provides mission-critical functions and will also be exposed to temperatures below 13 °C for periods longer than 6 months, the method for preventing tin pest formation shall be documented in the materials control plan.

At this time, insufficient data exist to define hard requirements for controlling tin pest. Alloying with more than 5 percent lead or smaller quantities of antimony or bismuth significantly slows tin pest formation but may not eliminate it completely. Alloying recommendations based on weight percentage are:

- (1) Not less than 5 percent lead.
- (2) Not less than 0.3 percent bismuth.
- (3) Not less than 0.5 percent antimony.
- (4) Not less than 3.5 percent silver.
- d. [MPR 88] Tin plating shall not be used for contacts in electrical interconnects (connectors, sockets, switches, etc.) for spaceflight hardware that provides mission-critical functions.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Tin plating has been demonstrated to have oxidation, wear, cold-weld, fretting, and tin whisker issues that reduce performance and reliability. Tin plating may be accepted through the MUA process, provided appropriate controls (contact lubricant, stabilant, etc.) are used to mitigate the performance and/or reliability risk.

#### 4.2.3 Nonmetallic Materials

#### **4.2.3.1** Elastomeric Materials

- a. [MPR 89] Elastomeric materials used in spaceflight hardware that provides mission-critical functions shall be selected to operate within design parameters for the useful life of the hardware.
- b. [MPR 90] Elastomeric materials used in spaceflight hardware that provides mission-critical functions, other than those used in off-the-shelf parts, such as cable clamps, shall be curedated for tracking purposes.
- c. [MPR 91] Room temperature vulcanizing (RTV) silicones that liberate acetic acid during cure shall not be used because they can cause corrosion.
- d. [MPR 92] When rubbers or elastomers are used at low temperatures in spaceflight hardware that provides mission-critical functions, the ability of these materials to maintain and provide required elastomeric properties shall be verified.

Elastomers do not seal effectively below their glass-transition temperature, and the ability of elastomers to seal decreases significantly as the glass-transition temperature is approached. The high glass-transition temperature of Viton® rubbers was a major contributor to the loss of the Space Shuttle Challenger, and other elastomers may struggle to retain sealing performance at spacecraft temperatures.

#### 4.2.3.2 Polyvinyl Chloride

[MPR 93] Use of polyvinyl chloride on spaceflight hardware shall be limited to applications in pressurized areas where temperatures do not exceed 49 °C (120 °F).

Polyvinyl chloride offgasses unacceptably at temperatures above 49 °C (120 °F). It is also normally flammable in pressurized areas of spacecraft; so, when it is used, its flammability has to be controlled in accordance with section 4.2.1.1.

Polyvinyl chloride is not vacuum-compatible.

Rigid polyvinyl chloride tubing is not acceptable for pressurized gas applications, because it can have a brittle failure when used for pressurized gas transport.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

## **4.2.3.3** Composite Materials

Requirements and guidance on materials design values for polymer matrix, ceramic matrix, and metal matrix composites are in section 4.1.8. Requirements on sandwich assemblies are in section 4.2.6.2.

#### 4.2.3.4 Lubricants

NASA-TM-86556, Lubrication Handbook for the Space Industry, Part A: Solid Lubricants, Part B: Liquid Lubricants, provides guidance on the evaluation and selection of lubricants for spaceflight systems and components. Guidelines on additional lubricants not listed in NASA-TM-86556 are contained in NASA/CR-2005-213424, Lubrication for Space Applications. Lubricants containing chloro-fluoro components may react with newly exposed rubbing surfaces of aluminum, magnesium or titanium alloys, especially at elevated temperatures.

#### 4.2.3.5 Limited-Life Items

[MPR 94] All materials shall be selected to meet the useful life of the hardware with no maintenance or be identified as limited-life items requiring maintainability.

## 4.2.3.6 Thermal Vacuum Stability

- a. [MPR 95] Nonmetallic materials that are exposed to space vacuum, with the exception of ceramics, metal oxides, inorganic glasses, and cetyl alcohol lubricants used on fasteners outside closed compartments, shall be tested using the technique of ASTM E595-15, Standard Test Method for Total Mass Loss and Collected Volatile Condensable Materials from Outgassing in a Vacuum Environment, with acceptance criteria as follows:
  - (1)  $\leq 0.1$  percent collected volatile condensable materials (CVCM).
  - (2) ≤1.0 percent total mass loss (TML) less water vapor recovery (WVR), except that a higher mass loss is permitted if this mass loss has no effect on the functionality of the material itself and no effect on the functionality of any materials, components, or systems that could be adversely affected by the subject mass loss.

Many materials contain absorbed water, but the loss of absorbed water does not normally affect functionality; so the WVR (a measure of the total water vapor lost in the ASTM E595-15 test) is subtracted from the TML.

More stringent requirements may be needed for materials that are line of sight to contamination-sensitive surfaces on spacecraft or attached vehicles. Contamination-sensitive surfaces include windows, lenses, star trackers, solar arrays, radiators, and other surfaces with highly controlled

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optical properties. The approach taken depends on the specific program needs but may include lowering the CVCM requirement to  $\leq 0.01$  percent CVCM, use of optical surfaces in testing to characterize the effects of deposition, or measurement of outgassing deposition rates as functions of source and target temperature (the standard test method is ASTM E1559, Standard Test Method for Contamination Outgassing Characteristics of Spacecraft Materials) and calculating deposition on critical surfaces using an integrated vehicle model. Spacecraft with cryogenic optics may be sensitive to water vapor deposition; in such cases, the WVR would not be subtracted from the TML.

- b. [MPR 96] With the following exceptions, hardware items (components, assemblies, etc.) containing materials that fail the CVCM requirement and/or having unidentified materials shall be vacuum baked at the maximum tolerable temperature of the component, 10 °C above the maximum predicted operating temperature, or an alternate temperature selected by the program/project, to meet the program/project acceptance outgassing criteria:
  - (1) Materials that are not near a critical surface and have a CVCM between 0.1 and 1.0 percent and an exposed surface area less than 13 cm<sup>2</sup> (2 in<sup>2</sup>) are exempt.
  - (2) Materials with an exposed surface area less than  $1.6 \text{ cm}^2 (0.25 \text{ in}^2)$  are exempt.
  - (3) Materials that are unexposed, overcoated, or encapsulated with approved materials are exempt.
  - (4) Materials enclosed in a sealed container (maximum leak rate less than 1 x 10<sup>-4</sup> cm<sup>3</sup>/sec) are exempt.

Determination of acceptable molecular outgassing limits, selection of the bakeout method and temperature, and determination of the specific bakeout completion criteria are the responsibility of the program/project. ASTM E2900, Standard Practice for Spacecraft Hardware Thermal Vacuum Bakeout, is recommended as a guide for performing thermal vacuum bakeout.

A vacuum-bake temperature of 125 °C (257 °F) (the ASTM E595-15 screening temperature) may damage some spaceflight hardware. Temperature requirements for hardware thermal vacuum bakeout should be adjusted to prevent damage to components. Because bakeout time and efficiency are dependent on temperature, the chosen temperature should be the highest possible without damage to hardware.

A hardware functionality bench test should be performed to re-verify performance after baking.

## 4.2.3.7 External Environment Survivability

[MPR 97] The critical properties of materials exposed in the spacecraft external environment shall meet operational requirements for their intended life-cycle exposure.

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Applicable space environments include atomic oxygen, solar ultraviolet (UV) radiation, ionizing radiation, plasma, vacuum, thermal cycling, and contamination. Applicable planetary environments, such as dust and planetary atmospheres, may also apply. Meteoroids and orbital debris should also be considered in the analysis of long-term degradation.

## 4.2.3.8 Fungus Resistance

[MPR 98] Materials that are non-nutrient to fungi, as identified in MIL-HDBK-454B, General Guidelines for Electronic Equipment, Requirement 4, Fungus-Inert Materials, Table 4-I, Group I, shall be used in launch vehicles and pressurized flight compartments, except when one of the following criteria is met:

- a. Materials have been tested to demonstrate acceptability per MIL-STD-810G, Department of Defense Test Method Standard for Environmental Engineering Considerations and Laboratory Tests, Method 508.
  - b. Materials are used in crew areas where fungus would be visible and easily removed.
- c. Materials are used inside sealed containers (maximum leak rate less than  $1 \times 10^{-4}$  cm<sup>3</sup>/sec) with internal container humidity less than 60 percent relative humidity (RH) at ambient conditions.
- d. Materials are used inside electrical boxes where the temperature is always greater than or equal to the ambient cabin temperature.
  - e. Materials have edge exposure only.
  - f. Materials are normally stowed with no risk of condensation in stowage locations.
- g. Materials are used on noncritical, off-the-shelf electrical/electronic hardware that is stowed and/or used in crew areas.
  - h. Materials are fluorocarbon polymers (including ETFE) or silicones.
  - i. Materials are used in crew clothing items.

When fungus-nutrient materials have to be used (and none of the above exception criteria are met) and an MUA is submitted for approval, supporting rationale should include how materials are treated to prevent fungus growth, using a fungus treatment that does not adversely affect unit performance or service life, does not constitute a health hazard to higher order life, and is not leached out by the use environment.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

#### **4.2.3.9** Glycols

[MPR 99] When solutions containing glycols (aliphatic dihydric alcohols) are used aboard spacecraft that have electrical or electronic circuits containing silver or silver-coated copper, a silver chelating agent, such as benzotriazole (BZT), shall be added to the solution to prevent spontaneous ignition from the reaction of silver with the glycol.

This reaction is known to occur for ethylene and propylene glycol. Solutions containing other glycols may be exempted if testing is conducted to demonstrate that the spontaneous ignition reaction does not occur.

## **4.2.3.10** Etching Fluorocarbons

a. [MPR 100] The etching of PTFE, perfluoroalkoxy (PFA), and fluorinated ethylene propylene (FEP) shall meet the requirements of SAE AMS2491F, Surface Treatment of Polytetrafluoroethylene, Preparation for Bonding, when adhesion to the fluorocarbon surface is required, except that for insulated wire or cable a pull test on co-produced specimens may be performed in lieu of the tensile and shear strength tests in AMS2491, section 3.5.2.

Adhesion to the fluorocarbon surface is required for electrical wire or cable insulated or coated with fluorocarbons intended for potting if mechanical bond strength and environmental sealing are a design requirement.

b. [MPR 101] Etched surfaces shall be processed within 24 hours or within 1 year if packaged per SAE AMS2491F.

*The open end of the wire should not be exposed to the etchant.* 

#### 4.2.4 Processes

#### **4.2.4.1** Heat Treatment

- a. [MPR 102] Heat treatment of aluminum alloys used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS2772G, Heat Treatment of Aluminum Alloy Raw Materials; SAE AMS2770N, Heat Treatment of Wrought Aluminum Alloy Parts; or SAE AMS2771E, Heat Treatment of Aluminum Alloy Castings.
- b. [MPR 103] Heat treatment of steel alloys used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS-H-6875B, Heat Treatment of Steel Raw Materials, or SAE AMS2759E, Heat Treatment of Steel Parts, General Requirements.
- c. [MPR 104] Heat treatment of titanium alloys used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS-H-81200D, Heat

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Treatment of Titanium and Titanium Alloys, for raw stock and SAE AMS2801B, Heat Treatment of Titanium Alloy Parts, for parts requiring heat treatment during fabrication.

d. [MPR 105] Heat treatment of nickel- and cobalt-based alloy parts used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS2774E, Heat Treatment, Wrought Nickel Alloy and Cobalt Alloy Parts, or SAE AMS2773E, Heat Treatment, Cast Nickel Alloy and Cobalt Alloy Parts.

Care should be taken in design of heat treatment fixturing and in heat treatment procedures for nickel- and cobalt-based alloy parts to avoid the introduction of excessive tensile stress. Inconel 718 parts have failed through SAGBOE and stress rupture from stresses induced by as little as an abrupt change in part thickness combined with introduction of a "cold" part into a hot furnace.

These AMS heat treatment specifications require hardness and/or conductivity measurements to verify the adequacy of the heat treatment process. In many cases, hardness tests are inadequate for spacecraft hardware; and testing of process-control tensile-test coupons is required.

- e. [MPR 106] For spaceflight hardware that provides mission-critical functions, process-control tensile-test coupons shall be taken from the production part (or from the same material lot, having the same thickness as and processed identically to the production part) to verify the adequacy of the heat treatment process for the following conditions:
  - (1) Aluminum alloys are solution heat-treated.
  - (2) High-strength steels (>200 ksi (1380 MPa) UTS), tool steels, and maraging steel alloys are heat-treated to high strength levels.
  - (3) A286 or MP35N alloys (which have poor correlation between hardness and tensile strength) are heat treated.
  - (4) Titanium alloys are annealed or solution heat treated and aged.
  - (5) Nickel- and cobalt-based alloys are work strengthened before age hardening, resulting in age-hardened tensile strengths greater than 1030 MPa (150 ksi) UTS.
  - (6) Precipitation hardenable nickel- and cobalt-based alloys are solution heat treated.

Note: Representative tensile test coupons are preferred over hardness and conductivity measurements for aging of aluminum alloys.

f. [MPR 107] When process-control tensile-test coupons are required, the requirement for the coupons shall be specified on the engineering drawing for the part.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- g. [MPR 108] If no tensile values are available in MMPDS for a specific alloy, tensiletest acceptance values shall be specified on the engineering drawing for the part.
- h. [MPR 109] Materials shall not be used in spaceflight hardware that provides mission-critical functions outside the limits of their procurement specification, heat treat specification, or MMPDS specification.

Procurement specifications, heat treat specifications, and MMPDS all limit product size of metal stock to ensure full consolidation of cast structure, product uniformity, and consistent mechanical properties.

## **4.2.4.2** Forging

Because mechanical properties are optimum in the direction of material flow during forging, forging techniques should be used that, whenever possible, produce an internal grain-flow pattern such that the direction of flow is essentially parallel to the principal stresses. If forging techniques do not allow for an internal grain-flow pattern such that the direction of the flow is parallel to the principal stresses, parts should be designed such that the weakest grain flow direction is not in line with the principal stresses. The forging pattern should be essentially free from re-entrant and sharply folded flow lines.

a. [MPR 110] Where forgings are used in mission-critical applications, first-article (preproduction) approval shall be obtained from the procuring authority.

First article requirements apply to all forgings, including hand forging and spin forming. The first article requirements may be waived for hand forging by review of the forging plan through the MUA process.

b. [MPR 111] First-article approval and the controls to be exercised in producing subsequent production forgings shall be in accordance with SAE AMS2375D, Control of Forgings Requiring First Article Approval.

Mechanical properties testing requirements may include fracture, durability, or damage tolerance testing.

- c. [MPR 112] After the forging technique, including degree of working, is established, the first production forging shall be sectioned to show the grain-flow patterns and to determine mechanical properties at control areas and the trim ring/protrusion specimens (prolongations).
- d. [MPR 113] The mechanical properties of the trim ring/protrusion specimens (prolongations) for the first article shall be compared to the control coupons to show they are predictive of the properties in the body of the first article.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

e. [MPR 114] Sectioning to show the grain-flow patterns and to determine mechanical properties at control areas shall be repeated after any substantive change in the forging technique, as determined by M&P analysis.

The information gained from this effort is utilized to redesign the forging as necessary.

- f. [MPR 115] These data and results of tests on the redesign shall be retained and made available for review by the procuring activity.
- g. [MPR 116] Trim ring or protrusion specimens (prolongations) shall be obtained for each production forging used in safety-critical applications and tested for required minimum mechanical properties.
- h. [MPR 117] Surface and volumetric nondestructive inspection (NDI) shall be performed on all safety-critical forgings.

# **4.2.4.3** Castings

- a. [MPR 118] Castings used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS2175A (2010), Castings, Classification and Inspection of.
- b. [MPR 119] Where castings are used in mission-critical applications, pre-production castings shall be subjected to first-article inspection to verify proper material flow, proper material integrity, minimum required mechanical properties, proper grain size, and macro/microstructure.
- c. [MPR 120] The mechanical properties in trim ring/protrusion of the first article shall be compared to the control coupons to show they are predictive of the properties in the body of the first article.

Mechanical properties testing requirements may include fracture, durability, or damage tolerance testing.

d. [MPR 121] The same casting practice and heat-treating procedure shall be used for the production castings as for the approved first-article castings.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- e. [MPR 122] For Class 1 and Class 2 castings (classes as defined by SAE AMS2175A (2010)), mechanical property testing of integrally cast or excised tensile bars at critical locations shall be conducted to ensure foundry control of cast lots.
- f. [MPR 123] Periodic cut-ups or functional testing shall be conducted for Class 1 and Class 2 castings (classes as defined by SAE AMS2175A (2010)).
- g. [MPR 124] Surface and volumetric nondestructive inspection shall be performed on all safety-critical castings.

#### 4.2.4.4 Formed Panels

Barrel and gore panels with complex geometries and integral stiffeners are often formed by processes such as roll forming, brake forming, peen forming, stretch forming, and explosive forming and then heat treated. The mechanical and thermal forming processes can result in strength and toughness variations across the panel.

- a. [MPR 125] Where formed panels are used in mission-critical applications, preproduction panels shall be subjected to first-article inspection to verify proper material integrity, minimum required mechanical properties, proper grain size, and macro/microstructure.
- b. [MPR 126] The mechanical properties of the first production article shall be compared to control coupons to show they are predictive of the properties in the body of the first article.

Mechanical properties testing requirements may include fracture, durability, or damage tolerance testing.

- c. [MPR 127] The same forming practice and heat-treating procedure shall be used for the production formed panels as for the approved first-article panels.
- d. [MPR 128] Sectioning to determine mechanical properties at control areas shall be repeated after any substantive change in the forming technique, as determined by M&P analysis.
- e. [MPR 129] Surface and volumetric NDI shall be performed on all safety-critical formed panels.

Given the complexities of some formed panels, volumetric NDI may be performed as a raw stock inspection.

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## 4.2.4.5 Adhesive Bonding

a. [MPR 130] Structural adhesive bonding shall meet MSFC-SPEC-445A, Adhesive Bonding, Process and Inspection, Requirements for.

The Operator Certification Plan and the Adhesive Control Plan may be described in the implementing process specification in place of submittal to NASA for approval.

Retesting of adhesives used for production parts is not required if they are within shelf life.

b. [MPR 131] Structural adhesive bonding processes shall be controlled to prevent contamination that would cause structural failure that could affect the safety of the mission, crew, or vehicle or affect mission success.

The sensitivity of structural adhesive bonds to contamination is of particular concern. Bond sensitivity studies should be conducted to verify that the required adhesive properties are maintained after exposure to potential contaminant species and concentrations, and in-process cleanliness inspections should be conducted as part of the bonding process. Silicone contamination is a particular concern because it severely degrades adhesive performance.

c. [MPR 132] Bonded primary structural joints shall demonstrate cohesive failure modes in shear.

# **4.2.4.6** Welding

The design selection of parent materials and weld methods should be based on consideration of the weldments, including adjacent heat-affected zones, as they affect operational capability of the parts concerned. Peaking and mismatch limits should be considered in the mechanical properties.

Welding procedures should be selected to provide the required weld quality, minimum weld energy input, and protection of the heated metal from contamination.

The suitability of the equipment, processes, welding supplies, and supplementary treatments selected should be demonstrated through qualification testing of welded specimens representing the materials and joint configuration of production parts.

Working with the responsible Technical Authority and NASA M&P organization, Programs/Projects will assess if it is more beneficial to directly use welding specifications cited in this section or develop alternatives. The requirements in this section provide compliance with NASA-STD-5006A, General Welding Requirements for Aerospace Materials. If the requirements in this section are met, no further application of NASA-STD-5006A is needed.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

a. [MPR 133] If alternative specifications to those cited in this section are utilized or developed, those specifications shall meet the requirements of NASA-STD-5006A, General Welding Requirements for Aerospace Materials.

Note: NASA-STD-5006A defines weld classes in terms of weld criticality (with Class A representing safety-critical structural welds) and AWS D17.1/D17.1M AMD 1 defines weld classes in terms of inspection requirements (with Class A representing the most stringent nondestructive inspection requirements).

b. [MPR 134] Material Review Board disposition shall be required for weld repair/rework/processing activities that are not in accordance with the approved weld process specification (WPS).

## Examples include:

- Wrong filler metal used.
- More than two attempts performed at the same location on heat-sensitive materials.
- More than five attempts performed at the same location on materials that are not heat sensitive.
- Repair weld required after the weldment has been post-weld heat treated.
- Repair weld required after final machining has been completed.
- Repair extends outside the original weld zone.
- Weldment has been direct aged.
- Repairs following proof or leak test.
- c. [MPR 135] A weld development and certification plan shall be developed for large structural welded components such as crew modules and welded cryogenic tanks.

This plan should include full scale pathfinder weldments, tooling development, and a design values program including sensitivity testing.

## 4.2.4.6.1 Fusion Welding

[MPR 136] The processing and quality assurance requirements for manual, automatic, and semiautomatic welding for spaceflight applications that provide mission-critical functions shall meet the requirements of AWS D17.1/D17.1M (2010) AMD 1 (2012), Specification for Fusion Welding for Aerospace Applications, with the following modifications/additions:

Note: AWS D17.1/D17.1M (2010) AMD 1 (2012) defines weld classes in terms of inspection requirements (with Class A representing the most stringent nondestructive inspection requirements).

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- a. [MPR 137] Mission-critical structural welds shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012), Class A requirements.
- b. [MPR 138] Other structural welds shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012), Class A or Class B requirements.
- c. [MPR 139] Non-critical welds (including seal welds) shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012), Class C requirements.
- d. [MPR 140] All Class A and Class B welds (including manual welds), as defined by AWS D17.1/D17.1M (2010) AMD 1 (2012), shall be qualified in accordance with AWS D17.1/D17.1M (2010) AMD 1 (2012).
- AWS G2.4/G2.4M, Guide for the Fusion Welding of Titanium and Titanium Alloys, should be used for guidance on titanium welding.
- e. [MPR 141] Titanium welds shall be light/dark straw or better (Ref. AWS D17.1/D17.1M (2010) AMD 1 (2012), Table 7.1).
- f. [MPR 142] Titanium and its alloys shall be welded with alloy-matching or metallurgically compatible fillers or autogenously.
- *Ti-6Al-4V filler metal is considered to be metallurgically compatible with Ti-3Al-2.5V.*
- g. [MPR 143] Extra low interstitial (ELI) filler wires shall be used for titanium cryogenic applications and are preferred for general applications.
- h. [MPR 144] Commercially pure (CP) titanium filler shall not be used on Ti-6Al-4V or other alloyed base material.

Hydride formation can occur in the weld, which can produce a brittle, catastrophic failure.

i. [MPR 145] Nitrogen, hydrogen, carbon dioxide, and mixtures containing these gases shall not be used in welding titanium and its alloys.

Care needs to be exercised to ensure complete inert gas (argon or helium) coverage during welding.

- (1) [MPR 146] The inert gas shall have a dew point of -60° C (-76° F) or lower.
- j. [MPR 147] Welded alpha and alpha plus beta titanium alloys shall be stress relieved in a vacuum or inert gas environment (Ar or He), or stress relieved in air with verification of

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oxide removal per SAE AMS-H-81200D or SAE AMS2801B, or certified in the as-welded condition.

k. [MPR 148] Titanium beta alloys that are welded shall be evaluated on a case-by-case basis with respect to stress relief.

*Note: Stress relief of weldments does not require tensile test coupons.* 

- l. [MPR 149] Laser welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or AWS C7.4/C7.4M (2008), Process Specification and Operator Qualification for Laser Beam Welding.
- m. [MPR 150] Electron beam welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or SAE AMS2680C, Electron-Beam Welding for Fatigue Critical Applications.

Compliance with SAE AMS2680C is preferred but compliance with AWS D17.1/D17.1M (2010) AMD 1 (2012) is acceptable.

- n. [MPR 151] The following welding practices permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012) shall not be used without an approved MUA to document the acceptance rationale:
  - (1) Welding from both sides if full penetration of the first pass is not verified (either by inspection of the back side or by grinding prior to welding on the opposite side).
  - (2) Partial weld penetration in structural welds.
  - (3) Straightening operation after welding.
  - (4) Lap welds in structural applications.
- o. [MPR 152] The Welding Procedure Specification (WPS) shall include the following content in addition to that required by AWS D17.1/D17.1M (2010) AMD 1 (2012):
  - (1) Prequalified rework welds in accordance with AWS D17.1/D17.1M (2010) AMD 1 (2012).
  - (2) Testing and documentation of allowable parameter variations for automatic and semi-automatic welds.
  - (3) Manual welding parameters.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

(4) An associated Procedure Qualification Record (PQR) with tension testing and macro-examination results as part of weld qualification requirements.

Qualification strength requirements should be included in weld qualification test acceptance. Qualification strength values are not the same as materials design values.

## 4.2.4.6.2 Resistance Welding

[MPR 153] Resistance welding for spaceflight hardware that provides mission-critical functions, including resistance spot welding (RSW), shall meet the requirements of AWS D17.2/D17.2M (2013), Specification for Resistance Welding for Aerospace Applications.

## 4.2.4.6.3 Friction-Stir Welding of Aluminum Alloys

[MPR 154] Friction-stir welding of aluminum alloys for spaceflight hardware that provides mission-critical functions shall meet the requirements of AWS D17.3/D17.3M (2016), Specification for Friction Stir Welding of Aluminum Alloys for Aerospace Applications.

## 4.2.4.6.4 Inertia Welding

[MPR 155] Inertia welding for spaceflight hardware that provides mission-critical functions shall meet the requirements of MIL-STD-1252 (1975), Inertia Friction Welding Process, Procedure and Performance Qualification.

- a. [MPR 156] Surface inspection (penetrant) and volumetric inspection (radiography) shall be performed.
  - b. [MPR 157] All welds shall be proof tested.
  - c. [MPR 158] Inertia welds used in fluid systems shall be helium leak tested.

Acceptable helium leak rates should be defined by the system.

## **4.2.4.7 Brazing**

a. [MPR 159] Brazing for spaceflight hardware that provides mission-critical functions shall be conducted in accordance with AWS C3.3 (2008), Recommended Practices for Design, Manufacture, and Examination of Critical Brazed Components.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- b. [MPR 160] Brazing of aluminum alloys for spaceflight hardware that provides mission-critical functions shall meet the requirements of AWS C3.7M/C3.7 (2011), Specification for Aluminum Brazing.
- c. [MPR 161] Torch, induction, and furnace brazing for spaceflight hardware that provides mission-critical functions shall meet the requirements of AWS C3.4M/C3.4 (2016), Specification for Torch Brazing; AWS C3.5M/C3.5 (2016), Specification for Induction Brazing; and AWS C3.6M/C3.6 (2016), Specification for Furnace Brazing, respectively.
- d. [MPR 162] Subsequent fusion-welding operations in the vicinity of brazed joints or other operations involving high temperatures that might affect the brazed joint shall be prohibited for spaceflight hardware that provides mission-critical functions unless it can be demonstrated that the fixturing, processes, methods, and/or procedures employed will preclude degradation of the brazed joint.
- e. [MPR 163] Brazed joints used in spaceflight hardware that provides mission-critical functions shall be designed for shear loading and not be relied upon for strength in axial loading for structural parts.
- f. [MPR 164] The shear strength of brazed joints used in spaceflight hardware that provides mission-critical functions shall be evaluated in accordance with AWS C3.2M/C3.2 (2008), Standard Method for Evaluating the Strength of Brazed Joints.
- g. [MPR 165] For furnace brazing of complex configurations of spaceflight hardware that provides mission-critical functions, such as heat exchangers and cold plates, destructive testing shall be conducted on pre-production brazed joints to verify that the braze layer that extends beyond the fillet area is continuous and forms a uniform phase.

## 4.2.4.8 Structural Soldering

[MPR 166] Soldering shall not be used for structural applications.

## 4.2.4.9 Electrical Discharge Machining and Laser Machining

- a. [MPR 167] Electrical-discharge machining (EDM) and laser machining (LM) processes for spaceflight hardware that provides mission-critical functions shall be controlled to limit the depth of the oxide layer, the recast layer, and the heat-affected zone.
  - (1) [MPR 168] The oxide layer shall be removed from the surface.
  - (2) [MPR 169] In addition, the recast layer and the heat-affected zone shall be removed from bearing, wear, fatigue or fracture-critical surfaces, and from crack-or notch-sensitive materials.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

The recast layer and heat-affected zone may be left on a part if an engineering evaluation shows that they are not of consequence to the required performance of the part.

b. [MPR 170] EDM/LM schedules for spaceflight hardware that provides mission-critical functions shall be qualified to determine the maximum thickness of the affected layers when the depth of the affected material must be known for removal or analysis.

# 4.2.4.10 Nickel Plating

- a. [MPR 171] Electrodeposited nickel plating for spaceflight hardware that provides mission-critical functions shall be applied according to the requirements of SAE AMS2403N, Plating, Nickel General Purpose; SAE AMS2423E, Plating, Nickel Hard Deposit; or ASTM B689-97, Standard Specification for Electroplated Engineering Nickel Coatings.
- b. [MPR 172] Electroless nickel plate for spaceflight hardware that provides mission-critical functions shall be applied per SAE AMS2404G, Plating, Electroless Nickel, or ASTM B733-15, Standard Specification for Autocatalytic (Electroless) Nickel-Phosphorus Coatings on Metal.
- c. [MPR 173] The nickel-aluminum interface in nickel-plated aluminum used in spaceflight hardware that provides mission-critical functions shall be protected from exposure to corrosive environments.

Nickel and aluminum form a strong galvanic cell at the nickel-aluminum interface, and exposure of the aluminum alloy to a corrosive environment can produce rapid disbonding of the nickel plate.

## 4.2.4.11 Additive Manufacturing

Guidelines documents and standards for additive manufacturing are in development at this time. The requirements of this NASA Technical Standard on M&P controls, materials design values, metallic and nonmetallic materials, and nondestructive inspection apply to hardware manufactured by additive techniques, just as they do for traditional manufacturing techniques. For nonstructural, nonmetallic 3-D printed hardware, controlled and verified processes are essential; but other M&P aspects like flammability, toxic offgassing, and vacuum outgassing also apply, just as for any other nonmetallic material.

[MPR 174] When structural hardware is manufactured by additive manufacturing techniques, a manufacturing and qualification plan shall be submitted to NASA and approved by the responsible NASA M&P and design organizations.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Key aspects of producing structural metallic hardware by additive manufacturing techniques, such as direct metal laser sintering (DMLS) and selective laser melting (SLM), include proper development of structural design values and controlled processes, although other requirements, such as stress-corrosion resistance and corrosion control, also apply. Verification of appropriate process control should include first article inspection to verify proper material properties and macro/microstructure and mechanical property testing of integrally manufactured specimens from each hardware unit.

#### **4.2.5** Material Nondestructive Evaluation (NDE)

#### **4.2.5.1** Nondestructive Evaluation (NDE) Plan

- a. [MPR 175] The NDE Plan shall address the process for establishment, implementation, execution, and control of NDE through design, manufacturing, operations, and maintenance of spaceflight hardware.
- b. [MPR 176] The Plan shall meet the intent of MIL-HDBK-6870B, Nondestructive Inspection Program Requirements for Aircraft and Missile Materials and Parts, and, when fracture control is applicable, the requirements of NASA-STD-5009, Nondestructive Evaluation Requirements for Fracture-Critical Metallic Components.

In case of conflict between the requirements of the two standards, the requirements of NASA-STD-5009 are applicable. It is expected that fracture-critical and safety-critical parts have surface and volumetric inspections unless there is rationale that it is not necessary. The need for internal (volumetric) inspection depends on the application and on materials characteristics such as thickness, product form, and other factors. Internal inspection requirements and methods should be determined early in the design process so that proper flaw screening is accomplished.

c. [MPR 177] Qualification and certification of personnel involved in nondestructive testing shall comply with NAS 410 (Revision 4), NAS Certification and Qualification of Nondestructive Test Personnel.

#### **4.2.5.2 NDE** Etching

- a. [MPR 178] All machined or otherwise mechanically disturbed surfaces on metallic parts that are to be fluorescent dye-penetrant inspected shall be adequately etched to assure removal of smeared, masking material prior to penetrant application, with the following exceptions:
  - (1) Previously etched parts do not need etching if the surface has not been smeared since the last etching.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- (2) When supporting rationale is provided, close tolerance parts may be machined near-final and etched and penetrant inspected before final machining in lieu of etching and penetrant inspecting after final machining.
- b. [MPR 179] The etching procedure shall specify the minimum amount of material to be removed to ensure that smeared metal does not mask cracks.

Minimum material removal requirements for fracture-critical hardware are identified in NASA-STD-5009.

c. [MPR 180] If etching is not feasible, it shall be demonstrated that the required flaw size can be reliably detected.

#### **4.2.6** Special Materials Requirements

#### 4.2.6.1 Residual Stresses

Residual tensile stresses are induced into manufactured parts as a result of forming, machining, heat treating, welding, special metal-removal processes, or the straightening of warped parts. Residual stresses may be harmful in structural applications when the part is subjected to fatigue loading, operation stresses, or corrosive environments. Special consideration should be given to the possibility of high residual stresses that might develop during off-nominal processing, such as repeated weld repairs in the same location. Residual stresses should be controlled or minimized during the fabrication sequence by special treatments, such as annealing and stress relieving. Bending and forming of tubing (for example, stainless steel and titanium tubing) is typically not stress relieved.

a. [MPR 181] Estimates of residual stresses in structural or stress-corrosion-sensitive hardware shall be considered in structural analyses and corrosion/stress-corrosion assessments.

Residual stresses should be quantified by an appropriate technique (such as x-ray diffraction).

b. [MPR 182] The straightening of warped parts in structural hardware shall require an approved MUA.

#### 4.2.6.2 Sandwich Assemblies

Structural sandwich assemblies using honeycomb or open-cell core constructions which are exposed to ascent-aerodynamic heating and/or vacuum exposure may be either vented to relieve internal pressure, or non-vented.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

a. [MPR 183] For vented sandwich architectures, the differential pressure on ascent shall be adequately relieved to preclude core-to-face sheet bond line "peel" failure modes that could result in face-sheet separation.

Associated material and process controls should demonstrate that production of full-scale flight articles produces venting performance that is both repeatable and reliable.

- b. [MPR 184] Sandwich architectures that are not vented shall be capable of withstanding pressure buildup without violating strength and stability requirements.
- c. [MPR 185] Structural sandwich assemblies shall be designed to prevent the entrance and entrapment of water vapor or other contaminants into the core structure.
- d. [MPR 186] Structural honeycomb sandwich assemblies that will be subjected to heating shall be tested for the expected environments to show that the construction can withstand them.
- e. [MPR 187] Sandwich assemblies using perforated and moisture-absorbing cores shall be protected from water intrusion during assembly and prelaunch activities.
- f. [MPR 188] Test methods for structural sandwich constructions and core materials shall meet the requirements of SAE AMS-STD-401 (1999), Sandwich Constructions and Core Materials: General Test Methods.

Because the ability of NDE to detect core-to-face sheet bond line defects is limited, the potential presence of defects makes it necessary to address both the static strength and cyclic loading capability under combined loading environments. Such environments can include pressure, temperature, and externally applied loads. Elevated temperatures from panel heating can soften adhesives and cause failure.

Acceptance / proof testing of each flight article should address the critical combined loading environment, including rapid decompression.

#### 4.2.6.3 Corrosion Prevention and Control

[MPR 189] All parts, assemblies, and equipment used in spaceflight hardware that provides mission-critical functions, including spares, shall be finished to provide protection from corrosion in accordance with the requirements of NASA-STD-6012, Corrosion Protection for Space Flight Hardware, with the following exceptions:

a. SAE AMS2404G is permitted for electroless nickel plating as an alternative to ASTM B733-15.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

b. Titanium fasteners may be used in contact with graphite composites, provided that they are wet installed with sealant or primer materials.

#### **4.2.6.3.1** Passivation

[MPR 190] Corrosion-resistant steels used in spaceflight hardware that provides mission-critical functions shall be passivated after machining.

## **4.2.6.3.2** Sealing

[MPR 191] Removable panels and access doors in exterior or interior corrosive environments shall be sealed either by mechanical seals or by separable, faying-surface sealing.

## 4.2.6.4 Hydrogen Embrittlement

Hydrogen embrittlement through hydrogen-metals interactions can be classified into three broad categories: hydrogen environmental embrittlement (HEE), internal hydrogen embrittlement (IHE), and hydrogen reaction embrittlement (HRE). In general, hydrogen environmental embrittlement represents the condition where the materials are exposed to a high-pressure gaseous hydrogen environment. The hydrogen for internal hydrogen embrittlement is usually not from a high-pressure gaseous system, but from an electrochemical process such as electroplating, corrosion, cathodic charging, and even from thermal charging. The hydrogen for internal hydrogen embrittlement can also come from moisture and enter the metals during welding, casting, and solidification processes from the foundry.

The hydrogen environmental embrittlement and internal hydrogen embrittlement effects are similar in many instances and they both require an external applied stress in order for the hydrogen embrittlement effects to occur. In contrast, hydrogen reaction embrittlement is usually irreversible hydrogen damage caused by a chemical reaction with hydrogen and such damage can occur without an external applied stress. This form of hydrogen damage can occur in materials such as titanium, zirconium, and some types of iron or steel-based alloys.

Overall, hydrogen embrittlement of materials is not very well understood and only limited materials property data have been generated. NASA/TM-2016-218602, Hydrogen Embrittlement, provides a detailed description of hydrogen embrittlement mechanisms, a comprehensive summary of existing hydrogen embrittlement data, and guidance on selection of materials and control of processes to prevent hydrogen embrittlement. It is a companion document to ANSI/AIAA G-095, Guide to Safety of Hydrogen and Hydrogen Systems.

a. [MPR 192] When designing liquid or gaseous hydrogen systems, the degradation of metallic materials properties by hydrogen embrittlement shall be addressed in the Materials and Processes Selection, Control, and Implementation Plan.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

b. [MPR 193] An MUA shall be written rationalizing the selection of metallic materials for liquid or gaseous hydrogen systems to preclude cracking and to ensure system reliability and safety.

*Test data may have to be generated in a simulated environment to support the rationale.* 

- c. [MPR 194] Electrochemical processes or exposure to acids or bases during manufacturing or processing of spaceflight hardware that provides mission-critical functions shall be controlled to prevent hydrogen embrittlement, or embrittlement relief treatment shall be performed promptly after processing.
  - (1) [MPR 195] When acid cleaning baths or plating processes are used on steel parts for spaceflight hardware that provides mission-critical functions, the part shall be baked in accordance with SAE AMS2759/9D, Hydrogen Embrittlement Relief (Baking) of Steel Parts, to alleviate potential hydrogen embrittlement problems.

## 4.2.6.5 Intermetallic Compounds

When joining two or more metals together (soldering, wire bonding, etc.), intermetallic compounds can form that are problematic to the metal joint, leading to a weakened mechanical or electrical connection. Problems can arise from embrittlement, changes in density, or conductivity of the intermetallic compound. Gold-indium and gold-tin are two of the more common systems that form intermetallic compounds that will degrade a metal joint.

#### 4.2.6.5.1 Gold-Indium Intermetallic Formation

Indium reacts with gold to form a succession of gold-indium intermetallic compounds. The gold-indium intermetallic compounds occupy a volume approximately four times the original volume of the consumed gold and are brittle. The original mechanical and thermal properties of gold are degraded by this intermetallic reaction possibly resulting in unreliable electrical interconnections. The gold-indium intermetallic formation progresses significantly even at room temperature and accelerates at elevated temperatures.

[MPR 196] Gold shall not be used in contact with indium or an indium alloy (such as indium solder) for spaceflight hardware that provides mission-critical functions.

#### **4.2.6.5.2** Gold-Tin Intermetallic Formation

The combination of gold and tin is subject to two distinct degradation mechanisms: gold embrittlement of tin-based solder joints and fretting corrosion of gold-coated contacts when mated with tin or tin alloy-coated contacts.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

When tin-based solder is used to join gold-plated surfaces, the gold coatings will dissolve into the final solder joint. If the concentration of gold in the tin-based solder joint exceeds approximately 3 percent by weight, then a brittle gold-tin intermetallic compound may form within the joint that can impact the long-term reliability of the solder joint.

a. [MPR 197] When used with tin-based solder joints in mission-critical hardware, gold shall be removed from at least 95 percent of the surface to be soldered of all component leads, component terminations, and solder terminals.

A double tinning process or dynamic solder wave may be used for gold removal prior to mounting the component on the assembly.

The combination of one gold-coated surface and one tin-coated or tin-alloy-coated surface for separable contact interfaces (e.g., electrical connector contact pairs) is highly prone to fretting corrosion, which can build up an electrically insulating tin-oxide film at the contact interface, resulting in increased contact resistance.

b. [MPR 198] Gold-coated contacts shall not be mated with tin or tin alloy-coated contacts for separable contact interfaces in mission-critical hardware.

#### 4.2.6.5.3 Gold-Aluminum Intermetallic Formation

An aluminum-rich intermetallic phase, the  $AuAl_2$  intermetallic known as "Purple Plague," is inherent (and not necessarily harmful) to gold-aluminum brazing; however, if excessive heat is applied too much of the intermetallic can form at the braze/part interface, causing joint failure. A gold-rich phase, the  $Au_5Al_2$  intermetallic known as "White Plague," is always detrimental. Its formation is catalyzed by silicon, so care should be taken to keep the braze joint zone free of contamination.

a. [MPR 199] Gold-aluminum brazing processes shall be controlled to minimize formation of the  $AuAl_2$  intermetallic known as "Purple Plague" and prevent formation of the  $Au_5Al_2$  intermetallic known as "White Plague."

Purple Plague is a significant problem in microelectronic applications, because as purple plague forms, it reduces in volume. This creates cavities in the metal surrounding the purple plague, which increases electrical resistance and structurally weakens the wire bonding. White plague is worse, because it has low electrical conductivity and, if enough of it forms, the resulting electrical resistance can cause a total failure of the component.

b. [MPR 200] Gold-aluminum bonding processes shall be controlled to prevent the formation of the AuAl<sub>2</sub> intermetallic known as "Purple Plague" and the Au<sub>5</sub>Al<sub>2</sub> intermetallic known as "White Plague."

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

#### **4.2.6.6** Fastener Installation

## 4.2.6.6.1 Liquid Locking Compounds

[MPR 201] If a liquid-locking compound is used as a locking feature where rotational loosening or disengagement would result in a critical or catastrophic hazard, its use shall comply with the design and quality requirements and best practices in NASA-STD-5020, Requirements for Threaded Fastening Systems in Spaceflight Hardware, sections 5.5 and 7.6 and Appendix C.

#### 4.2.6.6.2 Silver-Plated Fasteners

Silver reacts rapidly with atomic oxygen to generate a loose, friable, black oxide that can cause contamination and affect the operation of mechanisms.

[MPR 202] Silver-plated fasteners shall not be used in external applications where the silver plating is directly exposed to atomic oxygen for a period longer than 2 weeks.

#### **4.2.6.7** Contamination Control

Contamination, if not adequately anticipated and controlled, can result in loss of spacecraft, performance degradation, mission degradation, and/or loss or injury of flight crew. Examples of contamination sources and mechanisms include:

- Particulate and molecular contamination from both ground processing and on-orbit migration may degrade the performance of optical devices, thermal control surfaces, and solar arrays.
- Particulate contamination accumulated during ground processing or generated during operations may interfere with mechanisms, bearings, and seals; may plug or restrict fluid orifices or filters; and may pose a hazard to the crew.
- Particulate and nonvolatile residues pose an ignition hazard within systems containing oxidizers, such as oxygen or nitrogen tetroxide. Cleaning agents intended to remove contaminants from these systems may leave reactive residues if not adequately controlled and removed.
- Microbial contamination within life support systems and ultrapure water systems may degrade these systems.
- Control of terrestrial microbial contamination and extraterrestrial material may be required in accordance with NASA Procedural Requirements (NPR) 8020.12 on Planetary Protection Provisions for Robotic Extraterrestrial Missions.
- a. [MPR 203] A Contamination Control Plan shall be generated in accordance with the guidelines of ASTM E1548 (2009), Standard Practice for Preparation of Aerospace Contamination Control Plans.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

- b. [MPR 204] The Contamination Control Plan shall include controls on contamination-sensitive manufacturing processes, such as adhesive bonding, controls on packaging for shipment and storage, and a foreign object damage/debris (FOD) prevention program.
- c. [MPR 205] The FOD prevention program shall be established for all ground operations of mechanical and electrical systems of spaceflight hardware, including the design, development, manufacturing, assembly, repair, processing, testing, maintenance, operation, and checkout of the equipment to ensure the highest practical level of cleanliness.
- d. [MPR 206] The FOD prevention program shall conform to NAS 412 (Revision 1), Foreign Object Damage/Foreign Object Debris (FOD) Prevention.
- e. [MPR 207] Cleanliness levels for assembly- and subassembly-level hardware shall be identified on the engineering drawings.

## 4.2.6.8 Packaging

[MPR 208] Packaging shall protect spaceflight hardware from corrosion and contamination during shipping and storage.

#### 4.3 Verification

[MPR 209] Verification of compliance with the requirements of this NASA Technical Standard shall consist of the following steps, as a minimum:

- a. NASA approval of the contractor Materials and Processes Selection, Control, and Implementation Plan and other applicable materials data requirements documents, such as the Contamination Control Plan and NDE Plan.
- b. Contractor M&P signature on engineering drawings to verify compliance with the requirements of this NASA Technical Standard or the Materials and Processes Selection, Control, and Implementation Plan.
- c. NASA audits of contractor M&P activities relating to hardware design and manufacturing.
- d. Establishment and operation of the M&P control panel in accordance with section 4.1.4 of this NASA Technical Standard.
  - e. NASA approval of MUAs.
  - f. NASA approval of MIULs.

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Additional aspects of the verification process should be documented in the Materials and Processes Selection, Control, and Implementation Plan.							
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NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.							

## **APPENDIX A**

# STANDARD MATERIALS AND PROCESSES REQUIREMENTS FOR SPACECRAFT

# REQUIREMENTS COMPLIANCE MATRIX WITH REQUIREMENTS JUSTIFICATIONS

#### A.1 PURPOSE

NASA-STD-6016A defines the minimum requirements for Materials and Processes (M&P) and provides a general control specification for incorporation in NASA program/project hardware procurements and technical programs. Incorporating a general control specification provides procedural requirements for programmatic and M&P oversight to ensure that the M&P minimum requirements are implemented, controlled, and verified. These M&P minimum requirements are derived mostly from a history of successful use by NASA and the aerospace industry of best practices and lessons learned; their imposition better ensures uniformity, interoperability, a high likelihood of reliable hardware, and ultimately, mission success.

The purpose of this appendix is to provide the justification for each of the mandatory minimum requirements that are imposed by NASA-STD-6016A. Requirement ("shall") statements indicate contractually binding requirements that have to be implemented and their implementation verified. In some cases, the justification is obvious in the requirement statement itself. In many others, the justification results from prior failures or successes with a material or a material process, i.e., lessons learned, or based on a best practice. The section/paragraph numbers and titles are also presented for easy reference. NASA-STD-6016A has a significant amount of italicized text that provides additional requirements-related guidance and information in many of the sections.

(Note: Enter "Yes" to describe the requirement's applicability to the program or project; or enter "No" if the intent is to tailor, and enter how tailoring is to be applied in the "Rationale" column.)

NOTE: Per section 4.1.6: The use of M&P that do not comply with the requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
1.2a	Scope, Applicability	[MPR 1] Programs shall apply these controls to program/project hardware.	It is NASA policy to provide clear, concise, verifiable requirements for processes, products, and components; and it is NASA policy to track and implement requirements using requirements management and configuration management control processes.		
1.2b	Scope, Applicability	[MPR 2] Programs shall be responsible for demonstrating compliance with these requirements.	It is NASA policy to implement and track requirements.		
1.3a	Scope, Tailoring	[MPR 3] Tailoring of this NASA Technical Standard's requirements in the Materials and Processes Selection, Control, and Implementation Plan for specific programs/projects shall be formally documented as part of program or project requirements and approved by the responsible program/project NASA M&P organization, the responsible project/program, and the responsible Technical Authority in accordance with NPR 7120.5, NASA Space Flight Program and Project Management Requirements, or NPR 7120.8, NASA Research and Technology Program and Project Management Requirements.	Requirements management processes require that M&P requirement modifications be tracked and approved by responsible and knowledgeable M&P personnel and program organizations.		
2.1.1	Applicable Documents, General	[MPR 4] The latest issuances of cited documents shall apply unless specific versions are designated.	Current NASA Office of the Chief Engineer policy is to include this statement in all NASA standards.		
2.1.2	Applicable Documents, General	[MPR 5] Non-use of specifically designated versions shall be approved by	Current NASA Office of the Chief Engineer policy is to include this		

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		the responsible Technical Authority.	statement in all NASA standards.		
2.4.2	Applicable Documents,	[MPR 6] Conflict between this NASA	Current NASA Office of the Chief		
	Order of Precedence	Technical Standard and other	Engineer policy is to include this		
		requirements documents shall be resolved	statement in all NASA standards.		
		by the responsible Technical Authority.			
4a	Requirements	[MPR 7] Materials shall meet the worst-	Common sense requirement that		
		case useful-life requirements for the	materials used in an application be		
		particular application.	assessed for all of the		
			environmental extremes that the		
			materials will encounter during the		
			life cycle.		
4b	Requirements	[MPR 8] M&P used in interfacing GSE,	Ensures spaceflight hardware will		
		test equipment, hardware processing	not be damaged or contaminated by		
		equipment, hardware packaging, and	GSE, test equipment, or other M&P		
		hardware shipment shall be controlled to	that comes in contact with the		
		prevent damage to or contamination of	spaceflight hardware.		
		spaceflight hardware.			
4.1.1a	Materials and Processes	[MPR 9] Each organization that is	The Materials and Processes		
	Selection, Control, and	responsible for the design and fabrication	Selection, Control, and		
	Implementation Plan	of spaceflight hardware shall provide a	Implementation Plan represents a		
		Materials and Processes Selection,	best practice for implementing,		
		Control, and Implementation Plan.	controlling, and verifying that the		
			M&P requirements of this NASA		
			Technical Standard are imposed		
			and tracked through the		
			program/project/element life cycle.		
4.1.1b	Materials and Processes	[MPR 10] The Materials and Processes	The Materials and Processes		
	Selection, Control, and	Selection, Control, and Implementation	Selection, Control, and		
	Implementation Plan	Plan shall also describe the methods used	Implementation Plan needs to		
		to control compliance with these	provide to NASA insight into how		
		requirements by subcontractors and	the M&P requirements are imposed		
		vendors.	and controlled at the subcontractor		
			and vendor level.		

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
4.1.1c	Materials and Processes	[MPR 11] Upon approval by the	Since the Materials and Processes		
	Selection, Control, and	procuring activity, the Materials and	Selection, Control, and		
	Implementation Plan	Processes Selection, Control, and	Implementation Plan contains the		
		Implementation Plan shall become the	details of how a company		
		M&P implementation document used for	implements and controls the		
		verification.	requirements imposed by this		
			NASA Technical Standard, it		
			follows that the Plan is the		
			document to be used to verify that		
			the requirements have been met.		
4.1.1.1	Coordination, Approval,	[MPR 12] The Materials and Processes	A process needs to be in place for		
	and Tracking	Selection, Control, and Implementation	coordinating, approving, and		
		Plan shall identify the method of	tracking all M&P usage and M&P		
		coordinating, approving, and tracking all	changes. The Materials and		
		engineering drawings, engineering orders,	Processes Selection, Control, and		
		and other documents that establish or	Implementation Plan is the logical		
		modify materials and/or processes usage.	place for such a process to be		
			identified.		
4.1.1.2	Approval Signature	[MPR 13] The Materials and Processes	The M&P signature block on		
		Selection, Control, and Implementation	spaceflight hardware drawings		
		Plan shall include a requirement that all	ensures that M&P called out on		
		hardware design drawings and revisions	drawings, and changes thereto,		
		for spaceflight hardware that provides	have been approved by M&P		
		mission-critical functions contain an	knowledgeable personnel.		
		M&P approval block, or equivalent, to			
		ensure that the design has been reviewed			
		by the responsible M&P authority and			
		complies with that document.			
4.1.1.3	Manufacturing Planning	[MPR 14] The Materials and Processes	M&P expertise is required in the		
		Selection, Control, and Implementation	selection and processing of		
		Plan shall identify how the responsible	materials during manufacturing.		
		M&P organization participates in	How that expertise is applied and		
		manufacturing and inspection/verification	utilized needs to be described in the		

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		planning to ensure compliance with M&P	Materials and Processes Selection,		
		requirements.	Control, and Implementation Plan.		
4.1.2a	M&P Controls	[MPR 15] All M&P for spaceflight	Manufacturing spaceflight		
		hardware that provides mission-critical	hardware to consensus,		
		functions shall be defined by standards	Government, or company M&P		
		and specifications selected from	standards and specifications ensures		
		government, industry, and company	reliable, repeatable, and trackable		
		specifications and standards.	processes and spaceflight hardware.		
			Manufacturing spaceflight		
			hardware to standards and		
			specifications has been a mandatory		
			practice for a long time.		
4.1.2b	M&P Controls	[MPR 16] All M&P for spaceflight	Identifying all M&P directly on the		
		hardware that provides mission-critical	drawing ensures that the M&P		
		functions shall be identified directly on	usage has been reviewed and		
		the appropriate engineering drawing.	approved. It also ensures that		
			manufacturing follows the correct		
			M&P processes, and that hardware		
			built to print is repeatable.		
4.1.2c	M&P Controls	[MPR 17] Company M&P specifications	Ensures that NASA's oversight		
		shall be identified by document number	responsibility has complete insight		
		in the Materials and Processes Selection,	into all of the M&P that will be		
		Control, and Implementation Plan.	used to manufacture the spaceflight		
			hardware.		
4.1.2d	M&P Controls	[MPR 18] All M&P specifications used to	NASA's oversight role of		
		produce spaceflight hardware that	approving and verifying M&P		
		provides mission-critical functions shall	usage on mission-critical		
		be made available to the responsible	spaceflight hardware requires that		
		NASA Program or Project Office and	all standards and specifications be		
		M&P organization.	available for review.		
4.1.2e	M&P Controls	[MPR 19] Process specifications for	Necessary to ensure a consistent		
		spaceflight hardware that provides	and reliable product.		
		mission-critical functions shall define			

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		process steps at a level of detail that ensures a repeatable/controlled process that produces a consistent and reliable product.			
4.1.2f	M&P Controls	[MPR 20] Process qualification shall be conducted to demonstrate the repeatability of all processes for spaceflight hardware that provides mission-critical functions where the quality of the product cannot be directly verified by subsequent monitoring or measurement.	Necessary to ensure a consistent and reliable product.		
4.1.2.1	Standard and Specification Obsolescence	[MPR 21] A process shall be established for ensuring that updated, alternate, or new material or process standards or specifications from those identified in the Materials and Processes Selection, Control, and Implementation Plan meet or exceed the technical requirements identified in the original material or process standards or specifications.	The use of new material or material process standards or specifications in ongoing programs requires that the changes be reviewed and approved by the M&P and program authorities. A process for ensuring such a review and approval occurs needs to be identified in the Materials and Processes Selection, Control, and Implementation Plan. Also, engineering drawings do not call out company specifications by revision; so changes to such specifications can affect the repeatability of hardware built to print.		
4.1.3	Commercial Off-The- Shelf (COTS) Hardware	[MPR 22] A procedure shall be established to ensure that all vendor-designed, off-the-shelf, and vendor-furnished items are covered by the M&P	COTS hardware can present or contain unknown hazards unless the M&P used to manufacture such hardware meets the requirements of		
		requirements of this document, with the	this NASA Technical Standard, or		

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		exception that M&P requirements for off- the-shelf hardware and other spaceflight hardware that do not provide mission- critical functions may be limited to those required to ensure safety of flight (for example, flammability, toxic offgassing) and vehicle compatibility (for example, vacuum outgassing).	the COTS M&P usage is reviewed and approved by the responsible NASA M&P and program authorities. A process needs to be established to ensure that COTS hardware is properly reviewed.		
4.1.4a	M&P Control Panel	[MPR 23] An M&P control panel shall be established by each contractor hardware provider (excluding subcontractors).	Each hardware provider needs to establish a material control panel to provide quick M&P expertise, review, and approval for hardware manufacturing problems and M&P changes. In addition, the panel provides the NASA M&P oversight responsibility with insight into company M&P implementation and control issues.		
4.1.4b	M&P Control Panel	[MPR 24] The M&P control panel's scope and membership shall be described in the Materials and Processes Selection, Control, and Implementation Plan.	The NASA M&P oversight responsibility requires understanding of who and how the contractor implements and controls requirements.		
4.1.5a	M&P Usage Documentation	[MPR 25] M&P usage shall be documented in an electronic, searchable parts list or separate electronic searchable Materials Identification and Usage List (MIUL) with the following exceptions:  (1) Electrical, electronic, and electromechanical (EEE) parts other than wire, cable, and exposed surfaces of connectors.	The MIUL is a best practice that has a long history of use in NASA that provides a quick, reliable, and easy review process for tracking and verifying M&P usage for both NASA and the contractors.		

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		(2) Materials used in hermetically sealed electronic containers (maximum leak rate less than 1 x $10^{-4}$ cm <sup>3</sup> /sec).			
4.1.5b	M&P Usage Documentation	[MPR 26] The documentation of M&P usage shall cover the final design as delivered.	Common sense requirement that the end product reflects the actual M&P utilized in the as-built hardware  (including M&P changes resulting from repairs to nonconforming hardware).		
4.1.5c	M&P Usage Documentation	[MPR 27] The documentation approach shall be defined in the Materials and Processes Selection, Control, and Implementation Plan.	Ensures documentation of M&P usage and allows organizations to use their own documentation system.		
4.1.6a	Material Usage Agreements (MUAs)	[MPR 28] MUAs containing sufficient information to demonstrate that the application is acceptable shall be submitted by the responsible M&P organization for all M&P that are technically acceptable but do not meet the requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.	The MUA process is a long used NASA M&P best practice that enables acceptance of materials and material processes that do not meet the requirements of this NASA Technical Standard but, through the MUA review process, are determined to be acceptable. The MUA process also provides the benefit of satisfactorily resolving design non-conformances at the engineering level as opposed to the program level.		
4.1.6b	Material Usage Agreements (MUAs)	[MPR 29] MUAs shall not be used to change the M&P requirements for a nonconforming product.	The purpose of the MUA process is to justify the acceptance of specific material or material process design		

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			non-conformances, not the		
			acceptance of a nonconforming		
			product.		
4.1.7a	Materials Certification	[MPR 30] All parts or materials for	Ensures that consistent and reliable		
	and Traceability	spaceflight hardware that provides	materials are used in spaceflight		
		mission-critical functions shall be	hardware and further ensures that		
		certified as to composition, properties,	materials and their properties can		
		and requirements as identified by the	be repeated from program to		
		procuring document.	program and from company to		
			company.		
4.1.7b	Materials Certification	[MPR 31] With the exception of off-the-	M&P traceability to the end item of		
	and Traceability	shelf parts, parts and materials used in	critical parts ensures that each		
		critical applications, such as life-limited	processing step was accomplished		
		materials and/or safety- and fracture-	and that a processing record exists		
		critical parts, shall be traceable through	which often aids in understanding a		
		all processing steps defined in the	problem or failure.		
		engineering drawing to the end-item			
		application.			
4.1.7c	Materials Certification	[MPR 32] Distributors or other processors	Required to control procurement of		
	and Traceability	shall not heat treat, hot work, or cold	raw metallic materials. The		
		work metal stock unless they take the	processing changes the material		
		responsibilities as the producer of the	properties and invalidates the		
		metal and produce a new certification.	original vendor's certification.		
4.1.8.1a	Requirements for	[MPR 33] A, B, or S-basis statistical	To ensure structural integrity of		
	Design Values	values for mechanical properties of	spacecraft parts and structures,		
		materials shall be utilized for the design	materials with statistically based		
		and analysis of hardware for all	minimum mechanical properties are		
		applications where structural analysis is required.	required.		
4.1.8.1b	Requirements for	[MPR 34] The sampling for other	Needed to ensure design values for		
	Design Values	mechanical properties, such as dynamic	other required mechanical		
		properties like fatigue and fracture, and	properties are representative of the		
		verification of design values shall be	material, product form, and state		

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		representative of the material, product	used in the design.		
		form, and state used in the design.	_		
4.1.8.1c	Requirements for	[MPR 35] A, B, or S-basis statistical	The handbooks imposed here have		
	Design Values	methods shall be defined by, and values	long been NASA's and the		
		for mechanical properties in their design	aerospace industries' most trusted		
		environment taken from MMPDS,	and reliable sources of statistically		
		Metallic Materials Properties	derived mechanical design		
		Development and Standardization, or	properties. MMPDS is the		
		SAE CMH-17, Composite Materials	replacement for the old MIL-		
		Handbook.	HDBK-5 and SAE CMH-17 is the		
			replacement for the old MIL-		
			HDBK-17. SAE CMH-17-5 is		
			scheduled for publication in 2017		
			and MIL-HDBK-17-5 remains		
			active until it is released.		
4.1.8.1d	Requirements for	[MPR 36] For metallic materials, the	Since the testing to develop design		
	Design Values	alloy, heat treatment, product	values is specific to alloy, heat		
		specification, product form, and thickness	treatment, specification and form,		
		shall match the alloy, heat treatment,	the statistical relationship is		
		product specification, product form, and	relevant only to that same		
		thickness in MMPDS.	combination. Thickness affects		
			strength of metal because of		
			metallurgical factors that influence		
			strength, like heat transfer during		
			heat treatment and variability of		
			reduction during metal working.		
			This requirement is stated in		
			MMPDS but frequently ignored.		
4.1.8.1e	Requirements for	[MPR 37] When statistical design values	The statistical methods used in		
	Design Values	for new or existing structural materials	these handbooks are the NASA-		
		are not available, they shall be determined	and aerospace industry-accepted		
		by methods described in MMPDS or SAE	standard for determining		

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		CMH-17 and a report documenting the derivation of the new design values be made available to NASA for review.	mechanical design properties.		
4.1.8.1f	Requirements for Design Values	[MPR 38] The implementation of an approach for generating statistical design values that deviates from the sampling methodology and statistical methods in MMPDS or SAE CMH-17 and the use of design values that deviate from those published in MMPDS or SAE CMH-17 shall be approved with an MUA.	Not all materials, product forms, and sizes are available in the cited handbooks. Development of design values by the analytical methods described in MMPDS or SAE CMH-17 is sometimes prohibitively expensive for the application. When the test approach deviates from the published values in MMPDS or the guidance in SAE CMH-17, the MUA review process by responsible and competent M&P engineering personnel assures that acceptable minimum design properties will be derived and verified.		
4.1.8.1g	Requirements for Design Values	[MPR 39] All contractor-developed mechanical and physical property data shall be made available to the responsible NASA M&P organization.	NASA needs to have the capability to verify that contractor-developed mechanical and physical property data have been developed adequately and determine when an MUA is required per 4.1.8.1 g. NASA recognizes that such data may be proprietary and that the contractor can place limitations on how the data are made available.		
4.1.8.2a	Design Value Implementation in Design	[MPR 40] Material "B" design values shall not be used except in redundant structure in which the failure of a component would result in a safe	"B" design values are designed for use in redundant structure. They have a less statistically significant minimum design value than "A"		

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		redistribution of applied loads to other	design values and are, therefore,		
		load-carrying members.	less reliable and not to be used in		
			single load path critical structure.		
4.1.8.2b	Design Value Implementation in Design	[MPR 41] Minimum property acceptance values in material specifications (specification minimums) not explicitly	Not all materials, product forms, and sizes are available in the cited handbooks. In some cases,		
	Design	published as "S" design values in	specification minimums or "S"		
		MMPDS shall require an approved MUA	design values published in other		
		for use as design values.	sources are not properly derived in accordance with MMPDS.		
			Therefore, the MUA review process		
			by responsible and competent M&P		
			engineering personnel assures that		
			acceptable minimum design		
			properties will be derived and		
			verified.		
4.1.8.3	Structural Fastener	[MPR 42] Structural fastener design	MMPDS design values are not		
	Design Values	values shall be defined by minimum load	transferrable to fasteners, because		
		test requirements in the applicable part	raw material used to make fasteners		
		and/or procurement specification	is reprocessed using various		
		(government, aerospace industry	metallurgical practices, such as hot		
		consensus, company-specific, or custom	heading, thread rolling, and heat		
		specification).	treating. These processes change		
			the strength of the metal from the		
			original bar stock. NASA has		
			chosen to adopt lot tested design		
			strength defined in the specific		
			fastener part and procurement		
			specifications as the design value		
			instead of the certifications of the		
4.0.1	T1 1 111	D. (D) (2) 1 ( 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	original bar stock.		
4.2.1	Flammability,	[MPR 43] Materials shall meet the	Ensures that the NASA-required		
	Offgassing, and	requirements of NASA-STD-6001B,	tests and evaluations of materials		

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		NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
	Compatibility	Flammability, Offgassing, and	for flammability, offgassing, and		
	Requirements	Compatibility Requirements and Test	compatibility are imposed.		
		Procedures, as described below.			
4.2.1.1	Flammability Control	[MPR 44] Materials that are	The lessons learned from the		
		nonflammable or self-extinguishing in	Apollo 1 fire regarding the use of		
		their use configuration as defined by	flammable materials in an oxygen-		
		NASA-STD-6001B, Test 1 or an	rich environment makes it		
		appropriate configurational flammability	mandatory that special control and		
		test per NASA-STD-6001B, shall be used for flammability control with the	testing be exercised by M&P engineering to ensure that		
		following exceptions:	engineering to ensure that		
		Tollowing exceptions.	flammable materials are minimized		
		a. Ceramics, metal oxides, and	and controlled in spacecraft		
		inorganic glasses are exempt.	environments.		
		morganic glasses are exempt.	chynomichts.		
		b. Materials that are designed to			
		ignite and burn in their use application			
		(for example, pyrotechnic materials) are			
		exempted from flammability			
		requirements, provided that			
		systems/experiments using such materials			
		are designed so that the burning materials			
		cannot act as an ignition source for other			
		hardware.			
		c. Materials used in minor quantities			
		(dimensions controlled so the potential			
		fire propagation path is less than 15 linear			
		cm (6 linear in) and the surface area is no more than 80 cm <sup>2</sup> (12 square in)) in crew			
		environments and 30 linear cm (12 linear			
		in) for external materials) with no			
		propagation path or ignition source.			
		propugation pain or ignition source.			

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		d. Materials used in sealed containers are exempt because insufficient oxygen is available to maintain combustion.			
		e. Materials within vented electronics packages with metallic cases and no forced air convection are exempt because of the self-extinguishing effect of expanding combustion gases in a constrained volume.			
		f. Materials that have been shown by test to meet the requirements of NASA-STD-6001B may be used in an environment with an oxygen concentration lower than the test level without further testing (provided that the oxygen partial pressure is no greater than the partial pressure at the test level or general test data exist to demonstrate that the higher oxygen partial pressure is outweighed by the lower percentage concentration for the environments in question).			
		g. Materials are acceptable when used on a metal substrate that provides an adequate heat sink. A heat sink is considered adequate in the use configuration by test or analysis. When testing is conducted, materials passing the flammability test on a metal substrate are acceptable on metal substrates of the same thickness or greater. Materials that			

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		are flammable but have a thickness less than 0.25 mm (0.010 in) and are attached to a metallic surface greater than 1.6 mm (0.062 in) thick are acceptable by analysis.			
		h. Materials are unexposed, overcoated with a verified fire-blocking material, or no more than 1/4 inch thick and sandwiched between nonflammable materials with only the edges exposed.			
		i. Flammability configuration analysis in accordance with JSC 29353 shows hardware configuration to be self-extinguishing.			
4.2.1.2a	Toxic Offgassing	[MPR 45] All nonmetallic materials used in habitable flight compartments, with the exception of ceramics, metal oxides, inorganic glasses, and materials used in sealed container (maximum leak rate less than 1 x 10 <sup>-4</sup> cm <sup>3</sup> /sec), shall meet the offgassing requirements of Test 7 of NASA-STD-6001B.	All materials offgas small quantities of trace gas contaminants. Materials that release toxic gases must be controlled in closed spacecraft-habitable compartments. The required testing ensures that the materials used are safe from a toxicity standpoint.		
4.2.1.2b	Toxic Offgassing	[MPR 46] Spacecraft maximum allowable concentration (SMAC) values shall be obtained from JSC 20584, Spacecraft Maximum Allowable Concentrations for Airborne Contaminants, or from MAPTIS for compounds for which no SMAC values are found in JSC 20584.	Industrial maximum concentrations of airborne contaminants are based on an 8-hour workday exposure and are not appropriate for the continuous exposure that applies in spacecraft environments. The SMAC values in JSC 20584 are set by the NASA/JSC Toxicology		

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			Group in cooperation with the National Research Council Committee on Toxicology. Supplementary values in MAPTIS are set by the NASA/JSC Toxicology Group only for		
4.2.1.3a	Fluid Compatibility (Fluids Other Than Oxygen)	[MPR 47] Materials exposed to hazardous fluids shall be evaluated or tested for compatibility.	evaluation of offgassing test data.  Obviously, it is necessary to ensure that materials are compatible with the hazardous fluids with which they are in contact or will come in contact.		
4.2.1.3b	Fluid Compatibility (Fluids Other Than Oxygen)	[MPR 48] Appropriate long-term tests to simulate the worst-case use environment that would enhance reactions or degradation shall be conducted for materials with long-term exposure to liquid fuels, oxidizers, and other hazardous liquids.	Since some incompatible material/fluid combinations only manifest themselves after long-term exposure, it is necessary to conduct long-term exposure testing.		
4.2.1.3c	Fluid Compatibility (Fluids Other Than Oxygen)	[MPR 49] Materials degradation in long- term tests shall be characterized by post- test analyses of the material and fluid to determine the extent of changes in chemical and physical characteristics, including mechanical properties.	To determine in long- or short-term tests if material degradation has occurred, post-test analyses must be performed to determine, e.g., if mechanical properties have changed or if unacceptable levels of the test material have been dissolved into the test fluid.		
4.2.1.3d	Fluid Compatibility (Fluids Other Than Oxygen)	[MPR 50] The effect of material condition (for example, parent versus weld metal or heat-affected zone) shall be addressed in the compatibility determination.	It has long been known that a material's condition, such as a weld, its heat-affected zone, and the parent metal, can have significantly different outcomes in corrosion/compatibility testing		

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			which needs to be addressed when		
			determining compatibility and any		
			necessary testing.		
4.2.1.3e	Fluid Compatibility	[MPR 210] Materials used in nitrogen	Nitrogen tetroxide is a powerful		
	(Fluids Other Than	tetroxide systems shall be evaluated for	oxidizer, and flight hardware		
	Oxygen)	flammability in nitrogen tetroxide using	failures have been caused by		
		promoted combustion tests similar to	ignition of metallic materials		
		NASA-STD-6001B, Test 17, for metallic	(notably titanium).		
		materials used in oxygen systems and			
		Test 1 for polymeric materials.			
4.2.1.3(1)	Fluid Compatibility	[MPR 211] When materials are	The rigorous Oxygen Compatibility		
	(Fluids Other Than	determined to be flammable, a nitrogen	Assessment (OCA) methodology		
	Oxygen)	tetroxide compatibility assessment shall	described in NASA-STD-6001 for		
		be conducted using the methodology	evaluating potential materials		
		described for oxygen systems in NASA-	ignition in oxygen systems is also		
		STD-6001B and the system safety	the most effective methodology for		
		rationale of this assessment documented	evaluating ignition in nitrogen		
		in an MUA.	tetroxide systems.		
4.2.1.3f	Fluid Compatibility	[MPR 212] Materials used in other	The possibility of similar ignition		
	(Fluids Other Than	oxidizer systems shall be evaluated for	issues occurring in systems		
	Oxygen)	potential ignition.	containing oxidizers other than		
			oxygen and nitrogen tetroxide		
			needs to be addressed.		
4.2.1.4a	Oxygen Compatibility	[MPR 51] Materials and components, and	Because of the highly reactive		
		systems used in liquid oxygen (LOX) and	nature of oxygen with metals and		
		gaseous oxygen (GOX) environments,	nonmetals, it is necessary that all		
		compressed air systems, and pressurized	materials that are in contact with or		
		systems containing enriched oxygen shall	will come in contact with oxygen		
		be evaluated for oxygen compatibility in	must be evaluated for compatibility		
		accordance with NASA-STD-6001B.	with oxygen. NASA-STD-6001B		
			governs how such evaluation is to		
			be accomplished.		
4.2.1.4b	Oxygen Compatibility	[MPR 52] When materials in such	Materials are commonly found to		

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		systems are determined to be flammable, an oxygen compatibility assessment shall	be flammable in standard flammability tests but can often be		
		be conducted as described in NASA-	found not to be a flammability		
		STD-6001B and the system safety	hazard in their use configuration.		
		rationale of this assessment documented	Such a determination is made by		
		in an MUA.	conducting an oxygen compatibility		
			assessment and documenting the		
			acceptance rationale in an MUA.		
4.2.1.4.1	Oxygen Component	[MPR 53] GOX and enriched air system	Ensures that material surfaces that		
	Acceptance Test	components that operate at pressures	can react with oxygen at relatively		
		above 1.83 MPa (265 psia), with the	high pressures have been		
		exception of metallic components, such as	thoroughly exposed and		
		hard lines (rigid metallic tubing), metallic	conditioned to the system oxygen		
		flex hoses, metallic fluid fitting with all	pressure and will be nonreactive to		
		metal seals, and metallic pressure vessels	oxygen during use.		
		(including composite overwrapped			
		pressure vessels with metallic liners),			
		shall undergo oxygen component			
		acceptance testing at maximum design			
		pressure for a minimum of ten cycles			
		from ambient pressure to maximum			
		design pressure within 100 milliseconds			
		to ensure that all oxygen system			
		spaceflight hardware is exposed to oxygen prior to launch.			
4.2.1.5a	Electrical Wire	[MPR 54] Electrical wire insulation	The lessons learned from the		
1.2.1.54	Insulation Materials	materials shall be evaluated for	Apollo 1 fire and the Apollo 13		
	The diamon in incoming	flammability in accordance with NASA-	oxygen tank explosion make it		
		STD-6001B, Test 4 or Test 1.	imperative that the flammability of		
			wire insulation be evaluated.		
			NASA-STD-6001 specifies how to		
			conduct such tests.		

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4.2.1.5b	Electrical Wire	[MPR 55] Arc tracking shall be evaluated	Since arc tracking is a problem that	, ,	
	Insulation Materials	in accordance with NASA-STD-6001B,	is due to a breakdown of a wire's		
		Test 18, for all wire insulation	insulating material that results in		
		constructions except	uncontrolled arcing to other wires		
		polytetrafluoroethylene (PTFE),	and components, it is necessary to		
		PTFE/polyimide insulation conforming to	test wire insulating materials for		
		SAE AS22759C, Wire, Electrical,	their susceptibility to arc tracking.		
		Fluoropolymer-Insulated, Copper or			
		Copper Alloy, and used in conditions			
		bounded by the dry arc-tracking test			
		specified by SAE AS22759C, ethylene			
		tetrafluoroethylene (ETFE), and silicone-			
		insulated wires (the resistance of these			
		materials to arc tracking has already been			
		established).			
4.2.2	Metals	[MPR 56] MSFC-STD-3029A,	Stress corrosion cracking in		
		Guidelines for the Selection of Metallic	seacoast and air environments is a		
		Materials for Stress Corrosion Cracking	potential problem for the high-		
		Resistance in Sodium Chloride	strength alloys typically used in		
		Environments, shall be used to select	spacecraft structures. MSFC-STD-		
		metallic materials to control stress	3029 provides data on the stress-		
		corrosion cracking of metallic materials	corrosion sensitivity of most		
		in sea and air environments, with the	structural alloys and contains		
		exception that an MUA is not required for	requirements to eliminate the		
		the following conditions:	potential for stress-corrosion		
			cracking when stress-corrosion-		
		a. Parts in electrical/electronic	sensitive materials are used. The		
		assemblies with maximum tensile stress	standard also contains test methods		
		less than 50 percent of the yield strength.	for evaluating stress-corrosion		
			sensitivity of alloys without		
		b. Martensitic or precipitation-	existing data and defines stress		
		hardening (PH) stainless steels used in	corrosion cracking threshold values		
		ball bearing or similar applications where	for many of the alloys used in		
		the loading is compressive.	spacecraft structures.		

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		c. Carbon and low alloy high- strength steels with strength greater than 1240 MPa (180 ksi) used in ball bearings, springs, or similar applications where the loading is compressive and there is a history of satisfactory performance.			
		d. Hardware provides no mission- critical functions			
4.2.2.1	Aluminum	[MPR 57] The 5000-series alloys containing more than 3 percent magnesium shall not be used in spaceflight hardware that provides mission-critical functions where the temperature exceeds 66 °C (150 °F).	Under certain conditions, an intergranular aluminum-magnesium grain boundary precipitate can occur rendering such alloys susceptible to exfoliation corrosion or stress corrosion.		
4.2.2.2.1a	Drilling and Grinding of High-Strength Steel	[MPR 58] When drilling, grinding, reaming, or machining is performed on high-strength steels that can form martensite and are used in spaceflight hardware that provides mission-critical functions, a validated process for machining shall be used.	A well-known lesson learned is that some metal removal processes, particularly aggressive ones, cause surface overheating in high-strength steels that produces the undesirable crack-prone condition of untempered martensite.		
4.2.2.2.1b	Drilling and Grinding of High Strength Steel	[MPR 59] The absence of machining damage for high-strength steels used in spaceflight hardware that provides mission-critical functions shall be verified by microexamination of production parts (such as Nital etch inspection) or by a microhardness and metallurgical examination of sample parts for either of the following situations:	Tests and examinations cited are best practices for identifying the presence of untempered martensite.		

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		(1) When the material has very low toughness (such as martensitic steel above 200 ksi) and the part has low stress margins or is fatigue driven.			
		(2) When the surface condition of the part is critical to the design (such as its ability to withstand hertzian stresses or remain perfectly flat).			
4.2.2.2.2a	Corrosion-Resistant Steel	[MPR 60] Unstabilized, austenitic steels shall not be processed or used above 371 °C (700 °F) in spaceflight hardware that provides mission-critical functions.	Eliminates the potential of a corrosion-susceptible condition due to grain boundary precipitation of chromium carbide.		
4.2.2.2.2b	Corrosion-Resistant Steel	[MPR 61] Welded assemblies used in spaceflight hardware that provides mission-critical functions shall be solution heat-treated and quenched after welding except for the stabilized or low carbon grades, such as 321, 347, 316L, and 304L.	Eliminates the potential of a corrosion-susceptible condition of weld heat-affected zone grain boundary precipitation of chromium carbide.		
4.2.2.2.2c	Corrosion-Resistant Steel	[MPR 62] Service-related corrosion issues are common for free-machining alloys, such as 303, and these alloys shall not be used in spaceflight hardware that provides mission-critical functions when they can be exposed to moisture other than transient condensation, or to nitrogen tetroxide	Eliminates the exposure of the more corrosion-susceptible stainless steel alloys to moisture or to nitrogen tetroxide, for which corrosion of these alloys has also been observed.		
4.2.2.2.3	Ductile-Brittle Transition Temperature	[MPR 63] Steels shall not be used in tension below their ductile-brittle transition temperature.	Prevents the use of alloys that are too impact- and crack-sensitive and prone to unexpected failure at low		

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			temperature.		
4.2.2.3.1a	Titanium Contamination	[MPR 64] All cleaning fluids and other chemicals used during manufacturing and processing of titanium hardware for spaceflight hardware that provides mission-critical functions shall be verified to be compatible and not detrimental to performance before use.	An Apollo Program lesson learned occurred when a titanium pressure vessel failed due to stress corrosion in anhydrous methanol that was used as a substitute pressurant for Aerozine-50 in a ground test. Methanol, a commonly used solvent for cleaning metals, was considered benign to titanium.		
4.2.2.3.1b	Titanium Contamination	[MPR 65] The surfaces of titanium and titanium alloy mill products used for spaceflight hardware that provides mission-critical functions shall be 100 percent machined, chemically milled, or pickled to a sufficient depth to remove all contaminated zones and layers formed while the material was at elevated temperature.	A lesson learned from a titanium pressure vessel that was severely cracked from an alpha case that formed during heat treatment.		
4.2.2.3.2	Titanium Wear	[MPR 66] All regions of titanium alloys for spaceflight hardware that provides mission-critical functions that are subject to fretting or wear shall be anodized per SAE AMS2488D, Anodic Treatment – Titanium and Titanium Alloys Solution, pH 13 or Higher, or hard-coated utilizing a wear-resistance material, such as tungsten carbide/cobalt thermal spray.	Since titanium is subject to wear and fretting which can lead to crack initiation, it is necessary to harden the titanium surfaces by anodizing per the cited specification or per a hard-coating process.		
4.2.2.3.3a	Titanium Flammability	[MPR 67] Titanium alloys shall not be used with LOX or GOX at any pressure or with air at oxygen partial pressures above 35 kPa (5 psia).	Titanium is highly flammable in oxygen-rich environments, and its use in such environments must be avoided.		
4.2.2.3.3b	Titanium Flammability	[MPR 68] Titanium alloys shall not be	Because of titanium's sensitivity to		

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		machined inside spacecraft modules during ground processing or in flight, because machining operations can ignite titanium turnings and cause fire.	ignition in oxygen-containing environments, fine turnings and particles with large surface areas from machining and grinding processes can even ignite in air.		
			Obviously, such fires in a spacecraft must be prevented.		
4.2.2.4a	Magnesium	[MPR 69] Magnesium alloys shall not be used in primary structure or in other areas of spaceflight hardware that provides mission-critical functions that are subject to wear, abuse, foreign object damage, abrasion, erosion, or where fluid or moisture entrapment is possible.	Magnesium's low strength and hardness renders it relatively sensitive to mechanical damage and abuse and is relatively corrosion sensitive. Therefore, its use in primary structure needs to be avoided.		
4.2.2.4b	Magnesium	[MPR 70] Magnesium alloys shall not be machined inside spacecraft modules during ground processing or in flight, because machining operations can ignite magnesium turnings and cause fire.	Magnesium can be ignited in air at room temperature from machining operations. Obviously, such fires in a spacecraft must be prevented.		
4.2.2.5a	Beryllium	[MPR 71] Alloys containing more than 4 percent beryllium by weight shall not be used for primary structural applications.	Beryllium alloys have an inherent low ductility and brittle nature, and their use in primary structure needs to be avoided.		
4.2.2.5b	Beryllium	[MPR 72] Alloys containing more than 4 percent beryllium by weight shall not be used for any application within spacecraft crew compartments unless suitably protected to prevent erosion or formation of salts or oxides.	Beryllium containing alloys, even those containing as little as 4 percent beryllium, present a problem in that oxides and salts of beryllium are highly toxic and the use thereof requires that the metal be protected from abrasion or conditions that could form		

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			beryllium particles, beryllium		
			oxides, or salts.		
4.2.2.5c	Beryllium	[MPR 73] Design of beryllium parts for	When beryllium is required to be		
		spaceflight hardware that provides	used in mission-critical spaceflight		
		mission-critical functions shall address its	hardware, it is important that the		
		low-impact resistance and notch	low ductility and brittle nature of		
		sensitivity, particularly at low	beryllium be critically reviewed.		
		temperatures, and its directional material	When analyzing the stress state in		
		properties (anisotropy) and sensitivity to	beryllium, it is important to		
		surface finish requirements.	recognize the low Poisson's Ratio		
			of beryllium. This low Poisson's		
			Ratio can lead to very high stresses.		
4.2.2.5d	Beryllium	[MPR 74] All beryllium parts used in	When beryllium is required to be		
		spaceflight hardware that provides	used in mission-critical hardware,		
		mission-critical functions shall be	the detrimental surface damage that		
		processed to ensure complete removal of	occurs in beryllium from		
		the damaged layer (twins and	mechanical metal removal methods,		
		microcracks) produced by surface-metal-	such as machining and grinding,		
		working operations, such as machining	must be removed. The damage		
		and grinding.	removal must be by chemical etch		
			to remove the surface damage. The		
			technique of removing successively		
			shallower cuts will reduce the depth		
			of the damage but will never		
			completely eliminate the damage.		
			The nature of the damage is a		
			crystal twinning in the grains which		
			pins		
			dislocations and subsequently		
			reduces material ductility.		
4.2.2.5e	Beryllium	[MPR 75] Beryllium-containing alloys	Due to the highly toxic nature of		
		(including alloys containing less than 4	beryllium dust and oxides formed		

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		percent beryllium by weight) and oxides of beryllium shall not be machined inside spacecraft crew compartments at any stage of manufacturing, assembly, testing,	during machining or grinding, such operations must be highly controlled and never allowed to occur in spacecraft crew		
		modification, or operation.	compartments.		
4.2.2.5f	Beryllium	[MPR 76] All beryllium parts used in spaceflight hardware that provides mission-critical functions shall be penetrant-inspected for crack-like flaws with a high-sensitivity fluorescent dye penetrant in accordance with section 4.2.5.	Ensures that the crack-sensitive beryllium parts are crack free.		
4.2.2.6a	Cadmium	[MPR 77] Cadmium shall not be used in crew or vacuum environments.	Because of its toxic nature and relatively high vapor pressure, the use of cadmium in spacecraft crew compartments and in the space vacuum environment needs to be prevented.		
4.2.2.6b	Cadmium	[MPR 78] Cadmium-plated tools and other hardware shall not be used in the manufacture or testing of spaceflight hardware that provides mission-critical functions.	Cadmium is relatively soft and could be readily transferred to spacecraft parts through contact between the parts and cadmiumplated tools. Therefore, the use of such tools must be prevented.		
4.2.2.7	Zinc	[MPR 79] Owing to zinc's ability to grow whiskers, zinc plating other than black zinc-nickel plating shall not be used in spaceflight hardware that provides mission-critical functions.	The use of zinc-plated parts in spaceflight hardware needs to be prevented because zinc has a tendency to grow whiskers that cause electrical shorts and are also a source of contamination. Zinc also has a relatively high vapor pressure and, in the vacuum of space, it presents the risk of		

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			volatilizing and redepositing on		
			critical surfaces.		
4.2.2.8a	Mercury	[MPR 80] Equipment containing mercury	Mercury in contact with some		
		shall not be used where the mercury could	metals can result in severe		
		come in contact with spaceflight	embrittlement; therefore, such		
		equipment during manufacturing,	contact must be prevented.		
		assembly, test, checkout, and flight.			
4.2.2.8b	Mercury	[MPR 81] Spaceflight hardware	Because of the high toxicity of		
		(including fluorescent lamps) containing	mercury vapor and liquid mercury's		
		mercury shall have three levels of	potential for causing embrittlement		
		containment to prevent mercury leakage.	of other metals, its safe		
			containment in a spacecraft		
			environment must be		
			extraordinarily redundant.		
4.2.2.9	Refractory Metals	[MPR 82] For refractory alloys (alloys	Refractory metals are used in high-		
		with a melting point above 2000 °C (3600	temperature applications where the		
		°F), plus osmium and iridium) used in	material properties at the intended		
		mission-critical applications, tests shall be	use-temperature are lacking or		
		performed to characterize critical design	limited. Testing must be performed		
		properties for the intended application	to obtain the necessary design		
		and the data documented in an MUA.	properties for the application.		
			Documentation of the design		
			properties is also required.		
4.2.2.10a	Superalloys (Nickel-	[MPR 83] High-nickel content alloys are	Since superalloys are susceptible to		
	Based and Cobalt-	susceptible to sulfur embrittlement;	sulfur embrittlement from contact		
	Based)	therefore, for spaceflight hardware that	with sulfur containing materials at		
		provides mission-critical functions, any	elevated temperatures, it is		
		foreign material which could contain	mandatory that such materials be		
		sulfur, such as oils, grease, and cutting	removed from the surface of the		
		lubricants, shall be removed by suitable	superalloys before they are exposed		
		means prior to heat treatment, welding, or	to high temperatures.		
4.0.0.10:	0 11 0711	high temperature service.			
4.2.2.10b	Superalloys (Nickel-	[MPR 84] The reduction to design	Since superalloys experience alloy		

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	Based and Cobalt- Based)	properties of alloying element depletion at the surface in a high temperature, oxidizing environment shall be evaluated when a thin sheet of one of these alloys is used for spaceflight hardware that provides mission-critical functions, since a slight amount of depletion could involve a considerable proportion of the effective cross section of the material.	depletion at elevated temperatures, it is mandatory that the depth of such depletion on a superalloy's design properties be assessed, particularly in the case of thin sheets.		
4.2.2.11a	Tin	[MPR 85] For spaceflight hardware that provides mission-critical functions, tin and tin plating shall be alloyed with at least 3 percent lead by weight or other proven alloying element(s) to prevent tin whisker growth.	Self-explanatory, in that 3 percent lead in tin and tin plating is necessary to prevent tin-whisker growth. Several other alloying elements in tin and tin plating have also been shown to prevent tin whiskers.		
4.2.2.11b	Tin	[MPR 86] Tin and tin plating alloyed with less than 3 percent lead by weight and used in electrical/electronic applications shall comply with GEIA-STD-0005-1A, Performance Standard for Aerospace and High Performance Electronic Systems Containing Lead-Free Solder, and Control Level 2C requirements of GEIA-STD-0005-2A, Standard for Mitigating the Effects of Tin Whiskers in Aerospace and High Performance Electronic Systems, with the following exceptions:  (1) Solder alloy Sn96.3Ag3.7 (Sn96) used for high-temperature applications.	Since the cited standards specifically address how to mitigate the tin whisker problems for tin and tin-plating containing less than 3 percent lead, it is necessary that they be used for applications that use tin and tin-plating with less than 3 percent lead.		

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		a die attach material or as a			
		package sealing material.			
		(3) Tin alloys containing less than			
		20 percent tin by weight.			
4.2.2.11c	Tin	[MPR 87] When high-purity tin and tin	Since tin pest is a problem that		
4.2.2.110		plating are used for spaceflight hardware	results from tin and tin plating		
		that provides mission-critical functions	being exposed to a low temperature		
		and will also be exposed to temperatures	for a long period of time (as can		
		below 13 °C for periods longer than 6	occur for spacecraft external		
		months, the method for preventing tin	materials), it is necessary to address		
		pest formation shall be documented in the	how the tin pest problem will be		
		materials control plan.	controlled. Tin pest has been		
		materials control plan.	observed on ISS external hardware.		
4.2.2.11d	Tin	[MPR 88] Tin plating shall not be used	Because of the many problems that		
4.2.2.11d	1111	for contacts in electrical interconnects	have been encountered with tin		
		(connectors, sockets, switches, etc.) for	plating, such as oxidation, wear,		
		spaceflight hardware that provides	fretting, and whiskers, it is		
		mission-critical functions.	necessary to limit the use of tin		
		mission-critical functions.	plating in spaceflight hardware		
			unless the potential problems are		
			suitably mitigated and its use		
			approved through an MUA review		
			process.		
4.2.3.1a	Elastomeric Materials	[MPR 89] Elastomeric materials used in	Since elastomers have age-life		
		spaceflight hardware that provides	limitations, it is necessary to select		
		mission-critical functions shall be	elastomeric materials that can		
		selected to operate within design	function and endure the space		
		parameters for the useful life of the	environment for the expected life of		
		hardware.	the hardware.		
4.2.3.1b	Elastomeric Materials	[MPR 90] Elastomeric materials used in	The age-life of elastomers begin		
2.3.10	Ziastomere materials	spaceflight hardware that provides	when they are cured; therefore,		
		mission-critical functions, other than	because of age-life limitations, their		

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		those used in off-the-shelf parts, such as	cure dates need to be recorded so		
		cable clamps, shall be cure-dated for	the ages of the elastomers can be		
		tracking purposes.	tracked.		
4.2.3.1c	Elastomeric Materials	[MPR 91] Room temperature vulcanizing	Requirement justifies itself, in that		
		(RTV) silicones that liberate acetic acid	the release of a corrosive acid is		
		during cure shall not be used because they	unacceptable.		
		can cause corrosion.			
4.2.3.1d	Elastomeric Materials	[MPR 92] When rubbers or elastomers	The lesson learned from the		
		are used at low temperatures in	Challenger O-ring failure due to its		
		spaceflight hardware that provides	inelastic behavior at a moderately		
		mission-critical functions, the ability of	cold temperature strongly		
		these materials to maintain and provide	emphasizes the need to verify the		
		required elastomeric properties shall be	low temperature elastic properties		
		verified.	of rubbers and elastomers.		
			Fluorocarbon elastomers are		
			particularly susceptible to		
			embrittlement.		
4.2.3.2	Polyvinyl Chloride	[MPR 93] Use of polyvinyl chloride on	Polyvinyl chloride (PVC) cannot be		
		spaceflight hardware shall be limited to	used in space vacuum because it		
		applications in pressurized areas where	contains large quantities of		
		temperatures do not exceed 49 °C (120	plasticizers that outgas in space		
		°F).	vacuum, making the PVC brittle		
			and acting as a source of		
			contamination. PVC also offgasses		
			excessively above 120 °F, so its use		
			in hardware that experiences such		
			temperatures must be restricted.		
			PVC is flammable in spacecraft		
			cabin environments, and its use is		
			subject to the same controls as		
			other flammable materials.		
4.2.3.5	Limited-Life Items	[MPR 94] All materials shall be selected	If a material cannot meet the useful		
		to meet the useful life of the hardware	life requirements of the hardware of		

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		with no maintenance or be identified as	which it is a part, then it must be		
		limited-life items requiring	identified as having limited-life and		
		maintainability.	a maintenance plan identified to		
			address its limited-life.		
4.2.3.6a	Thermal Vacuum	[MPR 95] Nonmetallic materials that are	Since nonmetallic materials outgas		
	Stability	exposed to space vacuum, with the	in the vacuum of space, it is		
		exception of ceramics, metal oxides,	necessary to quantify the nature and		
		inorganic glasses, and cetyl alcohol	amount of outgassing that can		
		lubricants used on fasteners outside	occur. ASTM E595 is the		
		closed compartments, shall be tested	consensus standard for conducting		
		using the technique of ASTM E595-15,	such tests and quantifying mass		
		Standard Test Method for Total Mass	loss and CVCM.		
		Loss and Collected Volatile Condensable			
		Materials from Outgassing in a Vacuum	The traditional $\leq 1.0$ percent total		
		Environment, with acceptance criteria as	mass loss (TML) spacecraft		
		follows:	requirement is relaxed in this		
			standard. Vacuum outgassing		
		(1) $\leq 0.1$ percent collected volatile	causes contamination only from		
		condensable materials (CVCM).	condensable materials and the TML		
			is unimportant except in special		
		(2) $\leq 1.0$ percent total mass loss	cases where cryogenic surfaces are		
		(TML) less water vapor	present and in cases where the mass		
		recovery (WVR), except that a	loss causes unacceptable		
		higher mass loss is permitted if	degradation of the material. The		
		this mass loss has no effect on	vast majority of materials with a		
		the functionality of the material	TML ≤5 percent are acceptable for		
		itself and no effect on the	normal spacecraft applications,		
		functionality of any materials,	provided the ≤0.1 percent CVCM		
		components, or systems that	requirement is met.		
		could be adversely affected by	_		
		the subject mass loss.			
4.2.3.6b	Thermal Vacuum	[MPR 96] With the following exceptions,	Since vacuum baking can		
	Stability	hardware items (components, assemblies,	sufficiently outgas materials that		
		etc.) containing materials that fail the	fail the CVCM requirements		

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		CVCM requirement and/or having unidentified materials shall be vacuum baked at the maximum tolerable temperature of the component, 10 °C above the maximum predicted operating temperature, or an alternate temperature selected by the program/project, to meet the program/project acceptance outgassing criteria:	established by this NASA Technical Standard, it is necessary to vacuum bake hardware items that contain materials that do not meet the CVCM requirements.		
		(1) Materials that are not near a critical surface and have a CVCM between 0.1 and 1.0 percent and an exposed  surface area less than 13 cm <sup>2</sup> (2 in <sup>2</sup> ) are exempt.			
		(2) Materials with an exposed surface area less than 1.6 cm <sup>2</sup> (0.25 in <sup>2</sup> ) are exempt.			
		(3) Materials that are unexposed, overcoated, or encapsulated with approved materials are exempt.			
		(4) Materials enclosed in a sealed container (maximum leak rate less than 1 x 10 <sup>-4</sup> cm <sup>3</sup> /sec) are exempt.			
4.2.3.7	External Environment Survivability	[MPR 97] The critical properties of materials exposed in the spacecraft external environment shall meet	The spacecraft external environment includes ultraviolet radiation, atomic oxygen in low-		

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		operational requirements for their intended life-cycle exposure.	Earth orbit, plasma, and high- energy radiation, all of which can cause materials degradation. For example, ultraviolet radiation causes darkening of many materials, leading to loss of thermal control, and atomic oxygen erodes most polymeric materials, causing physical degradation. Since repair capabilities are very limited or nonexistent, it is imperative that materials so exposed meet their		
4.2.3.8	Fungus Resistance	[MPR 98] Materials that are non-nutrient to fungi, as identified in MIL-HDBK-454B, General Guidelines for Electronic Equipment, Requirement 4, Fungus-Inert Materials, Table 4-I, Group I, shall be used in launch vehicles and pressurized flight compartments, except when one of the following criteria is met:  a. Materials have been tested to demonstrate acceptability per MIL-STD-810G, Department of Defense Test Method Standard for Environmental Engineering Considerations and Laboratory Tests, Method 508.  b. Materials are used in crew areas where fungus would be visible and easily removed.	operational life cycle.  Materials that resist the growth of fungus are required in launch vehicles that are exposed to weather environments and in pressurized habitable compartments. The requirement statement identifies many exceptions where such controls are unnecessary.		

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		c. Materials are used inside sealed		)	
		containers (maximum leak rate less than 1			
		x 10 <sup>-4</sup> cm <sup>3</sup> /sec) with internal container			
		humidity less than 60 percent relative			
		humidity (RH) at ambient conditions.			
		d. Materials are used inside			
		electrical boxes where the temperature is			
		always greater than or equal to the			
		ambient cabin temperature.			
		e. Materials have edge exposure			
		only.			
		f. Materials are normally stowed			
		with no risk of condensation in stowage			
		locations.			
		g. Materials are used on noncritical,			
		off-the-shelf electrical/electronic			
		hardware that is stowed and/or used in			
		crew areas.			
		h. Materials are fluorocarbon			
		polymers (including ETFE) or silicones.			
		i. Materials are used in crew			
		clothing items.			
4.2.3.9	Glycols	[MPR 99] When solutions containing	Required to prevent this unusual		
		glycols (aliphatic dihydric alcohols) are	spontaneous ignition reaction.		
		used aboard spacecraft that have electrical			
		or electronic circuits containing silver or			
		silver-coated copper, a silver chelating			
		agent, such as benzotriazole (BZT), shall			

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		be added to the solution to prevent			
		spontaneous ignition from the reaction of			
		silver with the glycol.			
4.2.3.10a	Etching Fluorocarbons	[MPR 100] The etching of PTFE,	It is NASA policy to use voluntary		
		perfluoroalkoxy (PFA), and fluorinated	consensus standards where		
		ethylene propylene (FEP) shall meet the	possible. The cited specification is		
		requirements of SAE AMS2491F,	the industry standard for preparing		
		Surface Treatment of	polytetrafluoroethylene for bonding		
		Polytetrafluoroethylene, Preparation for	and has been reviewed and		
		Bonding, when adhesion to the	approved for use by NASA.		
		fluorocarbon surface is required, except			
		that for insulated wire or cable a pull test			
		on co-produced specimens may be			
		performed in lieu of the tensile and shear			
		strength tests in AMS2491 section 3.5.2.			
4.2.3.10b	Etching Fluorocarbons	[MPR 101] Etched surfaces shall be	Ensures that the etched surface		
		processed within 24 hours or within 1	remains active and ready for		
		year if packaged per SAE AMS2491F.	bonding.		
4.2.4.1a	Heat Treatment	[MPR 102] Heat treatment of aluminum	It is NASA policy to use voluntary		
		alloys used in spaceflight hardware that	consensus standards where		
		provides mission-critical functions shall	possible. The cited standards are		
		meet the requirements of SAE	the widely accepted consensus		
		AMS2772G, Heat Treatment of	standards for heat treating		
		Aluminum Alloy Raw Materials; SAE	aluminum alloys, and they have		
		AMS2770N, Heat Treatment of Wrought			
		Aluminum Alloy Parts; or SAE	been reviewed and approved for use		
		AMS2771E, Heat Treatment of	by NASA.		
		Aluminum Alloy Castings.			
4.2.4.1b	Heat Treatment	[MPR 103] Heat treatment of steel alloys	It is NASA policy to use voluntary		
		used in spaceflight hardware that provides	consensus standards where		
		mission-critical functions shall meet the	possible. The cited standards are		
		requirements of SAE AMS-H-6875B,	the widely accepted consensus		
		Heat Treatment of Steel Raw Materials,	standards for heat treating steel		

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		or SAE AMS2759E, Heat Treatment of Steel Parts, General Requirements.	alloys, and they have been reviewed and approved for use by NASA.		
4.2.4.1c	Heat Treatment	[MPR 104] Heat treatment of titanium alloys used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS-H-81200D, Heat Treatment of Titanium and Titanium Alloys, for raw stock and SAE AMS2801B, Heat Treatment of Titanium Alloy Parts, for parts requiring heat treatment during fabrication.	It is NASA policy to use voluntary consensus standards where possible. The cited standards are the widely accepted consensus standards for heat treating titanium alloys, and they have been reviewed and approved for use by NASA.		
4.2.4.1d	Heat Treatment	[MPR 105] Heat treatment of nickel- and cobalt-based alloy parts used in spaceflight hardware that provides mission-critical functions shall meet the requirements of SAE AMS2774E, Heat Treatment, Wrought Nickel Alloy and Cobalt Alloy Parts, or SAE AMS2773E, Heat Treatment, Cast Nickel Alloy and Cobalt Alloy Parts.	It is NASA policy to use voluntary consensus standards where possible. The cited standards are the widely accepted consensus standards for heat treating nickel-and cobalt-based alloys and have been reviewed and approved for use by NASA.		
4.2.4.1e	Heat Treatment	[MPR 106] For spaceflight hardware that provides mission-critical functions, process-control tensile-test coupons shall be taken from the production part (or from the same material lot, having the same thickness as and processed identically to the production part) to verify the adequacy of the heat treatment process for the following conditions:  (1) Aluminum alloys are solution	Heat treat variations can compromise the strength and ductility of the alloys for the heat-treat conditions cited. In addition, the commonly used hardness test to verify the adequacy of the heat treat process is not a good predictor of strength and ductility.		

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		heat-treated.			
		(2) High-strength steels (>200 ksi (1380 MPa) UTS), tool steels, and maraging steel alloys are heat-treated to high strength levels.			
		(3) A286 or MP35N alloys (which have poor correlation between hardness and tensile strength) are heat treated.			
		(4) Titanium alloys are annealed or solution heat treated and aged.			
		(5) Nickel- and cobalt-based alloys are work strengthened before age hardening resulting in agehardened tensile strengths greater than 1030 MPa (150 ksi) UTS.			
		(6) Precipitation hardenable nickel- and cobalt-based alloys are solution heat treated.			
4.2.4.1f	Heat Treatment	[MPR 107] When process-control tensile- test coupons are required, the requirement for the coupons shall be specified on the engineering drawing for the part.	Ensures compliance.		
4.2.4.1g	Heat Treatment	[MPR 108] If no tensile values are available in MMPDS for a specific alloy, tensile-test acceptance values shall be specified on the engineering drawing for	Ensures that accept/reject criteria are established.		

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		the part.			
4.2.4.1h	Heat Treatment	[MPR 109] Materials shall not be used in spaceflight hardware that provides mission-critical functions outside the limits of their procurement specification, heat treat specification, or MMPDS specification.	Ensures that the materials that are used have defined and dependable design properties.		
4.2.4.2a	Forging	[MPR 110] Where forgings are used in mission-critical applications, first-article (preproduction) approval shall be obtained from the procuring authority.	Ensures that a NASA M&P technical expert(s) has reviewed and approved the first-article cut-up process.		
4.2.4.2b	Forging	[MPR 111] First-article approval and the controls to be exercised in producing subsequent production forgings shall be in accordance with SAE AMS2375D, Control of Forgings Requiring First Article Approval.	It is NASA policy to use voluntary consensus standards where possible. The cited standard is the widely accepted consensus standard for control of the first-article forging cut-up and has been reviewed and approved for use by NASA.		
4.2.4.2c	Forging	[MPR 112] After the forging technique, including degree of working, is established, the first production forging shall be sectioned to show the grain-flow patterns and to determine mechanical properties at control areas and the trim ring/protrusion specimens (prolongations).	Ensures that the forging process has broken up the cast structure and that expected microstructure and mechanical properties are produced by the forging process.		
4.2.4.2d	Forging	[MPR 113] The mechanical properties of the trim ring/protrusion specimens (prolongations) for the first article shall be compared to the control coupons to show they are predictive of the properties	The mechanical properties of the trim ring/protrusion specimens (prolongations) for subsequent articles will be used to verify that the mechanical properties of		

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		in the body of the first article.	subsequent articles are		
			acceptable. As such, they have to		
			be representative of the properties		
			in the body of each subsequent		
			article. For the first article, they are		
			compared with the mechanical		
			properties of the control coupons		
			from the body of the article to		
			verify that they are truly		
			representative.		
4.2.4.2e	Forging	[MPR 114] Sectioning to show the grain-	Since any changes in the forging		
		flow patterns and to determine	process can significantly alter the		
		mechanical properties at control areas	grain flow, microstructure, and		
		shall be repeated after any substantive	mechanical properties, it is		
		change in the forging technique, as	necessary to conduct a first-article-		
		determined by M&P analysis.	like cut-up to ensure the resulting		
			properties are acceptable.		
4.2.4.2f	Forging	[MPR 115] These data and results of tests	Since forging process changes can		
		on the redesign shall be retained and	significantly alter the mechanical		
		made available for review by the	and metallurgical properties of the		
		procuring activity.	forging, it is necessary to conduct a		
			first-article-like cut-up and have the		
			results reviewed and approved by		
			NASA M&P engineering.		
4.2.4.2g	Forging	[MPR 116] Trim ring or protrusion	It is standard practice in the forging		_
		specimens (prolongations) shall be	industry to obtain and test trim ring		
		obtained for each production forging used	or protrusion specimens to ensure		
		in safety-critical applications and tested	that the mechanical properties of		
		for required minimum mechanical	each forging are achieved.		
		properties.			
4.2.4.2h	Forging	[MPR 117] Surface and volumetric	Obviously, the severe plastic		
		nondestructive inspection (NDI) shall be	deformation involved in a forging		
		performed on all safety-critical forgings.	process can introduce both surface		

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			and internal defects for which		
			inspection is needed.		
4.2.4.3a	Castings	[MPR 118] Castings used in spaceflight	It is NASA policy to use voluntary		
		hardware that provides mission-critical	consensus standards. SAE		
		functions shall meet the requirements of	AMS2175 is the industry		
		SAE AMS2175A (2010), Castings,	specification for classifying and		
		Classification and Inspection of.	inspecting castings and has been		
			reviewed and approved for use by		
			NASA.		
4.2.4.3b	Castings	[MPR 119] Where castings are used in	For mission-critical castings, it is		
		mission-critical applications, pre-	considered mandatory to subject the		
		production castings shall be subjected to	first casting(s) to destructive testing		
		first-article inspection to verify proper	to verify the mechanical properties		
		material flow, proper material integrity,	and metallurgical characteristics of		
		minimum required mechanical properties,	the casting process.		
		proper grain size, and			
		macro/microstructure.			
4.2.4.3c	Castings	[MPR 120] The mechanical properties in	Trim rings/protrusions will be		
		trim ring/protrusion of the first article	obtained for all production castings		
		shall be compared to the control coupons	so the first article testing needs to		
		to show they are predictive of the	verify that they are representative		
		properties in the body of the first article.	of the cast parts.		
4.2.4.3d	Castings	[MPR 121] The same casting practice and	Ensures to a reasonable degree that		
		heat-treating procedure shall be used for	the production castings will have		
		the production castings as for the	the same mechanical properties and		
		approved first-article castings.	metallurgical characteristics as the		
			first-article casting(s) that validated		
			the casting process.		
4.2.4.3e	Castings	[MPR 122] For Class 1 and Class 2	Tensile bars cast at the same time		
		castings (classes as defined by SAE	as the production casting(s) ensure		
		AMS2175A (2010)), mechanical property	that the casting process is		
		testing of integrally cast or excised tensile	reproducing the same mechanical		
		bars at critical locations shall be	properties. Integrally casting tensile		

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		conducted to ensure foundry control of cast lots.	bars with each production lot is a standard practice in the casting industry.		
4.2.4.3f	Castings	[MPR 123] Periodic cut-ups or functional testing shall be conducted for Class 1 and Class 2 castings (classes as defined by SAE AMS2175A (2010)).	For the most critical castings, periodic cut-ups or functional testing ensures that the casting process is under control and is reproducible.		
4.2.4.3g	Castings	[MPR 124] Surface and volumetric nondestructive inspection shall be performed on all safety-critical castings.	Castings frequently contain unacceptable defects that cannot be detected except by these NDE techniques.		
4.2.4.4a	Formed Panels	[MPR 125] Where formed panels are used in mission-critical applications, preproduction panels shall be subjected to first-article inspection to verify proper material integrity, minimum required mechanical properties, proper grain size, and macro/microstructure.	The process for forming panels needs to be verified as producing panels with proper material integrity, mechanical properties, grain size, and macro/microstructure.		
4.2.4.4b	Formed Panels	[MPR 126] The mechanical properties of the first production article shall be compared to control coupons to show they are predictive of the properties in the body of the first article.	Control coupons will be used for verification of the properties of each production formed panel, so the first article testing needs to verify that they are representative of the formed panels.		
4.2.4.4c	Formed Panels	[MPR 127] The same forming practice and heat-treating procedure shall be used for the production formed panels as for the approved first-article panels.	Ensures to a reasonable degree that the production formed panels will have the same mechanical properties and metallurgical characteristics as the first-article formed panel that validated the process.		

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4.2.4.4d	Formed Panels	[MPR 128] Sectioning to determine mechanical properties at control areas shall be repeated after any substantive change in the forming technique, as determined by M&P analysis.	Since any changes in the forming process can significantly alter the grain flow, microstructure, and mechanical properties of the panel, it is necessary to conduct a first-article-like cut-up to ensure the resulting properties are still acceptable.		
4.2.4.4e	Formed Panels	[MPR 129] Surface and volumetric NDI shall be performed on all safety-critical formed panels.	Formed panels may contain unacceptable defects that cannot be detected except by these NDE techniques.		
4.2.4.5a	Adhesive Bonding	[MPR 130] Structural adhesive bonding shall meet MSFC-SPEC-445A, Adhesive Bonding, Process and Inspection, Requirements for.	MSFC-SPEC-445 is the NASA-wide, accepted specification for adhesive bonding and inspection.		
4.2.4.5b	Adhesive Bonding	[MPR 131] Structural adhesive bonding processes shall be controlled to prevent contamination that would cause structural failure that could affect the safety of the mission, crew, or vehicle or affect mission success.	The strength of a structural adhesive bond can be significantly degraded by bond surface contamination, particularly from silicones. Therefore, it is imperative that bond surface cleanliness be maintained and verified.		
4.2.4.5c	Adhesive Bonding	[MPR 132] Bonded primary structural joints shall demonstrate cohesive failure modes in shear.	In bonded joints, cohesive failure is the desired failure mode that best ensures a reliable and repeatable shear strength design value, whereas an adhesive failure is almost always the result of inadequate surface preparation and is indicative of an improper bonding process.		
4.2.4.6a	Welding	[MPR 133] If alternative specifications to	The AWS D17 welding		

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		those cited in this section are utilized or developed, those specifications shall meet the requirements of NASA-STD-5006A, General Welding Requirements for Aerospace Materials.	requirements are commonly used by aerospace companies, but are far more detailed than is required by NASA and also have some deficiencies. If an aerospace company chooses to not follow the AWS D17 requirements, plus the supplemental requirements identified in this document, they may develop their own standard, provided that it complies with the less detailed but more stringent requirements in NASA-STD-5006.		
4.2.4.6b	Welding	[MPR 134] Material Review Board disposition shall be required for weld repair/rework/processing activities that are not in accordance with the approved weld process specification (WPS).	Weld procedure variances that have not been qualified by prior test or experience need to be reviewed and approved by a Material Review Board and/or M&P knowledgeable personnel.		
4.2.4.6c	Welding	[MPR 135] A weld development and certification plan shall be developed for large structural welded components such as crew modules and welded cryogenic tanks.	The welding of large structural welded components can have major problems if the weld development and certification plan isn't established well before welding flight hardware. The plan is expected to include full scale pathfinder weldments, tooling development, and a design values program including sensitivity testing.		
4.2.4.6.1	Fusion Welding	[MPR 136] The processing and quality assurance requirements for manual, automatic, and semiautomatic welding for	It is NASA policy to use voluntary consensus standards where possible. The cited specification is		

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		spaceflight applications that provide mission-critical functions shall meet the	the aerospace industry specification for fusion welding of aerospace		
		requirements of AWS D17.1/D17.1M	structures and components and has		
		(2010) AMD 1 (2012), Specification for	been reviewed and approved for use		
		Fusion Welding for Aerospace	by NASA with		
		Applications, with the following	modifications/additions to address		
		modifications/additions:	minor deficiencies in the baseline standard.		
4.2.4.6.1a	Fusion Welding	[MPR 137] Mission-critical structural	Structural welds that are safety-		
		welds shall comply with AWS	critical are required to meet the		
		D17.1/D17.1M (2010) AMD 1 (2012),	most stringent set of requirements,		
		Class A requirements.	as is the case for the cited Class A		
		•	requirements. Note that the weld		
			classes in AWS D17.1 are based on		
			nondestructive inspection		
			requirements (with the most		
			stringent inspection requirements		
			for Class A welds), whereas		
			traditional NASA weld classes		
			were based on weld criticality (with		
			Class A welds being the highest		
			criticality level).		
4.2.4.6.1b	Fusion Welding	[MPR 138] Other structural welds shall	Structural welds that are not safety-		
		comply with AWS D17.1/D17.1M (2010)	critical are allowed to meet a less		
		AMD 1 (2012), Class A or Class B	stringent set of requirements, as is		
		requirements.	the case for the cited Class B		
			requirements. The more stringent		
			Class A requirements may also be		
			used.		
4.2.4.6.1c	Fusion Welding	[MPR 139] Non-structural welds	Non-structural, non-safety-critical		
		(including seal welds) shall comply with	welds are allowed to meet the least		
		AWS D17.1/D17.1M (2010) AMD 1	stringent set of requirements, as is		
		(2012), Class C requirements.	the case for the cited Class C		

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			requirements.		
4.2.4.6.1d	Fusion Welding	[MPR 140] All Class A and Class B	Ensures that Class A and B manual		
		welds (including manual welds), as	weld processes are also qualified,		
		defined by AWS D17.1/D17.1M (2010)	not just the operators who perform		
		AMD 1 (2012), shall be qualified in	the welds.		
		accordance with AWS D17.1/D17.1M			
		(2010) AMD 1 (2012).			
4.2.4.6.1e	Fusion Welding	[MPR 141] Titanium welds shall be	Titanium welds with worse		
		light/dark straw or better (Ref. AWS	coloration than light/dark straw (as		
		D17.1/D17.1M (2010) AMD 1 (2012),	listed in AWS D17.1, Table 7.1)		
		Table 7.1).	indicate improper inert gas control		
			during welding and presents the		
			possibility that weld		
			contamination/oxidation occurred.		
4.2.4.6.1f	Fusion Welding	[MPR 142] Titanium and its alloys shall	Prevents the creation of a		
		be welded with alloy-matching or	completely unknown titanium alloy		
		metallurgically compatible fillers or	in the weldment by welding		
		autogenously.	together, for example, an alpha		
			alloy and an alpha-beta alloy or		
			other incompatible combinations of		
			titanium alloys.		
4.2.4.6.1g	Fusion Welding	[MPR 143] Extra low interstitial (ELI)	ELI weld wire produces a more		
		filler wires shall be used for titanium	ductile weld at cryogenic		
		cryogenic applications and are preferred	temperatures.		
		for general applications.			
4.2.4.6.1h	Fusion Welding	[MPR 144] Commercially pure (CP)	Welding Ti-6Al-4V with CP weld		
		titanium filler shall not be used on Ti-	wire results in a significant alloy		
		6Al-4V or other alloyed base material.	content and interstitial solubility		
			difference between the parent metal		
			and the weld metal, which can lead		
			to interstitial migration and		
			precipitation of embrittling species,		
			such as titanium hydride, at the		

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			weld fusion line. An Apollo SIV-B stage was destroyed due to inadvertently welding a Ti-6Al-4V pressure vessel with CP weld wire.		
4.2.4.6.1i	Fusion Welding	[MPR 145] Nitrogen, hydrogen, carbon dioxide, and mixtures containing these gases shall not be used in welding titanium and its alloys.	Titanium welding needs to be performed in an inert gas environment. The cited gases are not considered inert to titanium and can react with titanium alloys at weld temperatures.		
4.2.4.6.1i(1)	Fusion Welding	[MPR 146] The inert gas shall have a dew point of -60° C (-76° F) or lower.	Ensures that the water content in the inert gas is low enough that the potential reaction of water with titanium at the welding temperature is not a problem.		
4.2.4.6.1j	Fusion Welding	[MPR 147] Welded alpha and alpha plus beta titanium alloys shall be stress relieved in a vacuum or inert gas environment (Ar or He), or stress relieved in air with verification of oxide removal per SAE AMS-H-81200D or SAE AMS 2801B, or certified in the as-welded condition.	Welding of titanium alloys may produce residual stresses that are high enough that the weld needs to be stress relieved. Such stress relief treatments are done at high enough temperatures that precautions against oxidation of the titanium must be exercised.		
4.2.4.6.1k	Fusion Welding	[MPR 148] Titanium beta alloys that are welded shall be evaluated on a case-by-case basis with respect to stress relief.	Titanium beta alloys are less prone to residual stress during welding, but stress relieving of beta welds still needs to be considered.		
4.2.4.6.11	Fusion Welding	[MPR 149] Laser welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or AWS C7.4/C7.4M (2008), Process Specification and Operator Qualification	It is NASA policy to use voluntary consensus standards where possible. The cited specifications are industry standards for laser welding that have been reviewed and approved for use by NASA.		

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Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
	for Laser Beam Welding.			
Fusion Welding	[MPR 150] Electron beam welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or SAE AMS2680C, Electron-Beam Welding for Fatigue Critical Applications.	It is NASA policy to use voluntary consensus standards where possible. The cited specifications are industry standards for electron beam welding that have been reviewed and approved for use by NASA, whereas SAE AMS2681 is another common industry standard for electron beam welding but is not considered adequate.		
Fusion Welding	[MPR 151] The following welding practices permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012) shall not be used without an approved MUA to document the acceptance rationale:  (1) Welding from both sides if full penetration of the first pass is not verified (either by inspection of the back side or by grinding prior to welding on the opposite side).  (2) Partial weld penetration in structural welds.  (3) Straightening operation after welding.  (4) Lap welds in structural	Although permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012), these practices have been determined to be unacceptable for NASA Program hardware unless approved through an MUA review process.		
	Fusion Welding	Fusion Welding  Fusion Welding  Fusion Welding  [MPR 150] Electron beam welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or SAE AMS2680C, Electron-Beam Welding for Fatigue Critical Applications.  [MPR 151] The following welding practices permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012) shall not be used without an approved MUA to document the acceptance rationale:  (1) Welding from both sides if full penetration of the first pass is not verified (either by inspection of the back side or by grinding prior to welding on the opposite side).  (2) Partial weld penetration in structural welds.  (3) Straightening operation after welding.	Fusion Welding  Fusion Welding  [MPR 150] Electron beam welding for spaceflight hardware that provides mission-critical functions shall comply with AWS D17.1/D17.1M (2010) AMD 1 (2012) or SAE AMS2680C, Electron-Beam Welding for Fatigue Critical Applications.  Fusion Welding  [MPR 151] The following welding practices permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012) shall not be used without an approved MUA to document the acceptance rationale:  (1) Welding from both sides if full penetration of the back side or by grinding prior to welding on the opposite side).  (2) Partial weld penetration in structural  for lectro use woluntary consensus standards where possible. The cited specifications are industry standards for electron beam welding that have been reviewed and approved for use by NASA, whereas SAE AMS2681 is another common industry standards for electron beam welding but is not considered adequate.  Although permitted by AWS D17.1/D17.1M (2010) AMD 1 (2012), these practices have been determined to be unacceptable for NASA Program hardware unless approved through an MUA review process.  (1) Welding from both sides if full penetration of the back side or by grinding prior to welding on the opposite side).  (2) Partial weld penetration in structural welds.	Fusion Welding  Fusion Welding  Fusion Welding  Image: Image: It is NASA policy to use voluntary consensus standards where possible. The cited specifications are industry standards for electron beam welding that have been reviewed and approved for use by NASA, whereas SAE AMS2681 is another common industry standard for electron beam welding but is not considered adequate.  Fusion Welding  Image: Im

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4.2.4.6.10	Fusion Welding	[MPR 152] The Welding Procedure Specification (WPS) shall include the following content in addition to that required by AWS D17.1/D17.1M (2010) AMD 1 (2012):  (1) Prequalified rework welds in accordance with AWS D17.1/D17.1M (2010) AMD 1 (2012).  (2) Testing and documentation of allowable parameter variations for automatic and semi- automatic welds.  (3) Manual welding parameters.  (4) An associated Procedure Qualification Record (PQR) with tension testing and macro- examination results as part of	NASA review of the cited AWS specification has determined that these additional requirements need to be included in the WPS to ensure the adequacy and completeness of the welding process.	(Yes or No)	
4.2.4.6.2	Resistance Welding	weld qualification requirements.  [MPR 153] Resistance welding for spaceflight hardware that provides mission-critical functions, including resistance spot welding (RSW), shall meet the requirements of AWS D17.2/D17.2M (2013), Specification for Resistance Welding for Aerospace Applications.	It is NASA policy to use voluntary consensus standards where possible. The cited specification is an industry standard for resistance welding that has been reviewed and approved for use by NASA. Resistance welding is not used frequently in NASA programs and then primarily for spot welding of batteries.		
4.2.4.6.3	Friction-Stir Welding of	[MPR 154] Friction-stir welding of	It is NASA policy to use voluntary		

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	Aluminum Alloys	aluminum alloys for spaceflight hardware	consensus standards where		
		that provides mission-critical functions	possible. The cited specification is		
		shall meet the requirements of AWS	an industry standard for friction-stir		
		D17.3/D17.3M (2016), Specification for	welding that has been reviewed and		
		Friction Stir Welding of Aluminum	approved for use by NASA.		
		Alloys for Aerospace Applications.			
4.2.4.6.4	Inertia Welding	[MPR 155] Inertia welding for spaceflight	Although this standard is no longer		
		hardware that provides mission-critical	active, it has been determined by		
		functions shall meet the requirements of	NASA that it is the best standard		
		MIL-STD-1252 (1975), Inertia Friction	existing for establishing and		
		Welding Process, Procedure and	controlling the inertia welding		
		Performance Qualification.	process. Other active inertia friction		
			welding specifications were		
			reviewed and found to be		
			inadequate for NASA's use or were		
			only recommended practices, not		
			requirements.		
4.2.4.6.4a	Inertia Welding	[MPR 156] Surface inspection (penetrant)	Generally, inertia welds are		
		and volumetric inspection (radiography)	performed on pressure-containing		
		shall be performed.	tube and valve components that		
			require inspection for surface and		
			subsurface defects that could		
			develop into leaks.		
4.2.4.6.4b	Inertia Welding	[MPR 157] All welds shall be proof	Generally, inertia welds are		
		tested.	performed on pressure-containing		
			tube and valve components that		
			need to be proof tested.		
4.2.4.6.4c	Inertia Welding	[MPR 158] Inertia welds used in fluid	Generally, inertia welds are		
		systems shall be helium leak tested.	performed on pressure-containing		
			tube and valve components that		
			need to be helium leak tested.		
4.2.4.7a	Brazing	[MPR 159] Brazing for spaceflight	It is NASA policy to use voluntary		
		hardware that provides mission-critical	consensus standards where		

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		functions shall be conducted in accordance with AWS C3.3 (2008), Recommended Practices for Design, Manufacture, and Examination of Critical Brazed Components.	possible. The cited specification is the industry specification for the design, manufacture, and examination of critical brazed components and has been reviewed and approved for use by NASA.		
4.2.4.7b	Brazing	[MPR 160] Brazing of aluminum alloys for spaceflight hardware that provides mission-critical functions shall meet the requirements of AWS C3.7M/C3.7 (2011), Specification for Aluminum Brazing.	It is NASA policy to use voluntary consensus standards where possible. The cited specification is an industry specification for brazing of aluminum that has been reviewed and approved for use by NASA.		
4.2.4.7c	Brazing	[MPR 161] Torch, induction, and furnace brazing for spaceflight hardware that provides mission-critical functions shall meet the requirements of AWS C3.4M/C3.4 (2016), Specification for Torch Brazing; AWS C3.5M/C3.5 (2016), Specification for Induction Brazing; and AWS C3.6M/C3.6 (2016), Specification for Furnace Brazing, respectively.	It is NASA policy to use voluntary consensus standards where possible. The cited specifications are the industry specifications for the types of brazing cited, and they have been reviewed and approved for use by NASA.		
4.2.4.7d	Brazing	[MPR 162] Subsequent fusion-welding operations in the vicinity of brazed joints or other operations involving high temperatures that might affect the brazed joint shall be prohibited for spaceflight hardware that provides mission-critical functions unless it can be demonstrated that the fixturing, processes, methods, and/or procedures employed will preclude	Need to ensure that high- temperature processing near existing braze joints does not degrade the joint by re-melting and reflowing the braze metal.		

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		degradation of the brazed joint.			
4.2.4.7e	Brazing	[MPR 163] Brazed joints used in spaceflight hardware that provides mission-critical functions shall be designed for shear loading and not be relied upon for strength in axial loading for structural parts.	Since transferring all of the load in a structural braze joint by tension through the braze material is not considered as reliable as transferring the load by shear through the braze material, tension loaded braze material has to be avoided. This is accomplished by using lap joint designs versus butt joints, where the large brazed surface area in a lap joint results in a relatively low shear stress in the braze material.		
4.2.4.7f	Brazing	[MPR 164] The shear strength of brazed joints used in spaceflight hardware that provides mission-critical functions shall be evaluated in accordance with AWS C3.2M/C3.2 (2008), Standard Method for Evaluating the Strength of Brazed Joints.	It is NASA policy to use voluntary consensus standards where possible. The cited standard is an industry standard for how to evaluate the strength of brazed joints and has been reviewed and approved for use by NASA.		
4.2.4.7g	Brazing	[MPR 165] For furnace brazing of complex configurations of spaceflight hardware that provides mission-critical functions, such as heat exchangers and cold plates, destructive testing shall be conducted on pre-production brazed joints to verify that the braze layer that extends beyond the fillet area is continuous and forms a uniform phase.	Destructive testing ensures the adequacy of the braze flow and that the braze alloy and its adhesion to the brazed surfaces are continuous and metallurgically acceptable.		
4.2.4.8	Structural Soldering	[MPR 166] Soldering shall not be used for structural applications.	The low strength and poor creep resistance of solders means		

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			soldering cannot be used in		
			structural applications.		
4.2.4.9a	Electrical Discharge	[MPR 167] Electrical-discharge	Since the high surface temperature		
	Machining and Laser	machining (EDM) and laser machining	associated with the EDM and LM		
	Machining	(LM) processes for spaceflight hardware	machining processes causes		
		that provides mission-critical functions	undesirable surface damage, it is		
		shall be controlled to limit the depth of	necessary to control the processes		
		the oxide layer, the recast layer, and the	to ensure the depth of damage is		
		heat-affected zone.	predictable and manageable.		
4.2.4.9a(1)	Electrical Discharge	[MPR 168] The oxide layer shall be	The oxide layer that is produced by		
	Machining and Laser	removed from the surface.	the EDM and LM machining		
	Machining		processes is generally brittle and		
			crack-prone and must be removed.		
4.2.4.9a(2)	Electrical Discharge	[MPR 169] In addition, the recast layer	The recast layer and the heat-		
	Machining and Laser	and the heat-affected zone shall be	affected zone produced by the		
	Machining	removed from bearing, wear, fatigue or	EDM and LM machining processes		
		fracture-critical surfaces, and from crack-	are generally undesirable		
		or notch-sensitive materials.	conditions, and need to be removed		
			from wear surfaces and fracture-		
			critical surfaces.		
4.2.4.9b	Electrical Discharge	[MPR 170] EDM/LM schedules for	Qualification of the EDM and LM		
	Machining and Laser	spaceflight hardware that provides	machining processes ensures that		
	Machining	mission-critical functions shall be	the depth of the detrimental surface		
		qualified to determine the maximum	conditions is predictable and the		
		thickness of the affected layers when the	amount of material that must be		
		depth of the affected material must be	removed is known.		
		known for removal or analysis.			
4.2.4.10a	Nickel Plating	[MPR 171] Electrodeposited nickel	It is NASA policy to use voluntary		
		plating for spaceflight hardware that	consensus standards where		
		provides mission-critical functions shall	possible. The cited specifications		
		be applied according to the requirements	are industry standards for		
		of SAE AMS2403N, Plating, Nickel	electroplating nickel that have been		
		General Purpose; SAE AMS2423E,	reviewed and approved for use by		

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		Plating, Nickel Hard Deposit; or ASTM B689-97, Standard Specification for Electroplated Engineering Nickel Coatings.	NASA.		
4.2.4.10b	Nickel Plating	[MPR 172] Electroless nickel plate for spaceflight hardware that provides mission-critical functions shall be applied per SAE AMS2404G, Plating, Electroless Nickel, or ASTM B733-15, Standard Specification for Autocatalytic (Electroless) Nickel-Phosphorus Coatings on Metal.	It is NASA policy to use voluntary consensus standards where possible. The cited specifications are industry standards for electroless nickel plating that have been reviewed and approved for use by NASA.		
4.2.4.10c	Nickel Plating	[MPR 173] The nickel-aluminum interface in nickel-plated aluminum used in spaceflight hardware that provides mission-critical functions shall be protected from exposure to corrosive environments.	Since there is a strong galvanic couple between nickel and aluminum, the interface between them must be protected in corrosive environments.		
4.2.4.11	Additive Manufacturing	[MPR 174] When structural hardware is manufactured by additive manufacturing techniques, a manufacturing and qualification plan shall be submitted to NASA and approved by the responsible NASA M&P and design organizations.	Ensures that the NASA M&P technical authority reviews and approves this relatively new manufacturing technique that is not yet controlled by NASA or consensus standards or specifications.		
4.2.5.1a	Nondestructive Evaluation (NDE) Plan	[MPR 175] The NDE Plan shall address the process for establishment, implementation, execution, and control of NDE through design, manufacturing, operations, and maintenance of spaceflight hardware.	Since there are many NDE techniques that are available to inspect spaceflight hardware and such inspections are performed throughout the life cycle of the hardware, a Plan is needed to		

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			ensure that the application and		
			sequence of the inspections are		
			proper and efficient.		
4.2.5.1b	Nondestructive	[MPR 176] The Plan shall meet the intent	Obviously, since NASA-STD-5009		
	Evaluation (NDE) Plan	of MIL-HDBK-6870B, Nondestructive	sets NDE requirements for fracture-		
		Inspection Program Requirements for	critical components, it has to be		
		Aircraft and Missile Materials and Parts,	included in the NDE Plan for		
		and, when fracture control is applicable,	spaceflight hardware. Although		
		the requirements of NASA-STD-5009,	MIL-HDBK-6870 states that it is		
		Nondestructive Evaluation Requirements	for guidance only, it is to be treated		
		for Fracture-Critical Metallic	as a requirements document for		
		Components.	non-fracture-critical components in		
			the NDE Plan.		
4.2.5.1c	Nondestructive	[MPR 177] Qualification and certification	NAS-410 has long been the		
	Evaluation (NDE) Plan	of personnel involved in nondestructive	aerospace industry and NASA		
		testing shall comply with NAS 410	standard for certifying and		
		(Revision 4), NAS Certification and	qualifying NDE personnel.		
		Qualification of Nondestructive Test	Although ASNT-TC-1A is also		
		Personnel.	widely used for certifying and		
			qualifying nondestructive test		
			personnel, it is a recommended		
			practice only.		
4.2.5.2a	NDE Etching	[MPR 178] All machined or otherwise	Machining metal surfaces causes a		
		mechanically disturbed surfaces on	disturbed, smeared thin layer of		
		metallic parts that are to be fluorescent	metal that masks cracks, and the		
		dye-penetrant inspected shall be	disturbed layer must be removed by		
		adequately etched to assure removal of	etching prior to penetrant		
		smeared, masking material prior to	inspection.		
		penetrant application, with the following			
		exceptions:			
		(1) Previously etched parts do not			
		need etching if the surface has			

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		not been smeared since the last etching.			
		(2) When supporting rationale is provided, close tolerance parts may be machined near-final and etched and penetrant inspected before final machining in lieu of etching and penetrant inspecting after final machining.			
4.2.5.2b	NDE Etching	[MPR 179] The etching procedure shall specify the minimum amount of material to be removed to ensure that smeared metal does not mask cracks.	Since the disturbed metal layer has a certain depth, it is required that at least an amount of metal equal to the thickness of the disturbed layer be removed to have an effective penetrant inspection.		
4.2.5.2c	NDE Etching	[MPR 180] If etching is not feasible, it shall be demonstrated that the required flaw size can be reliably detected.	Since not being able to etch means that the penetrant inspection process would be ineffective, it is necessary to employ other NDE methods, such as eddy current or ultrasonics that can detect the critical flaw size.		
4.2.6.1a	Residual Stresses	[MPR 181] Estimates of residual stresses in structural or stress-corrosion-sensitive hardware shall be considered in structural analyses and corrosion/stress-corrosion assessments.	Many metal processes produce residual stresses that can add to the stresses from the normally applied service stresses resulting in a higher stress state that needs to be addressed and accounted for in the analyses.  An important lesson was learned in		

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			repair welding of 2195 Aluminum		
			Lithium. The repair weld material		
			was very low strength compared to		
			the parent material (it was 4043		
			weld wire in 2195 parent material),		
			so the effect of the residual stress		
			was not apparent (i.e., there wasn't		
			much warpage). However, when		
			wide specimens containing only a		
			short repair-welded area were		
			tensile tested, the residual stress		
			added to the discontinuity shear		
			stress at the weld/parent metal		
			interface, causing early failure.		
4.2.6.1b	Residual Stresses	[MPR 182] The straightening of warped	Since straightening of a warped part		
		parts in structural hardware shall require	requires plastic deformation and		
		an approved MUA.	creates the potential for mechanical		
			damage and high residual stresses,		
			it is necessary for M&P engineering		
			to review and approve the process.		
4.2.6.2a	Sandwich Assemblies	[MPR 183] For vented sandwich	Vents on vented sandwich		
		architectures, the differential pressure on	constructions must be large enough		
		ascent shall be adequately relieved to	to prevent the pressure differential		
		preclude core-to-face sheet bond line	between the sandwich interior and		
		"peel" failure modes that could result in	the external environment during		
		face-sheet separation.	launch becoming large enough to		
			cause face-sheet separation.		
4.2.6.2b	Sandwich Assemblies	[MPR 184] Sandwich architectures that	Non-vented sandwich structure will		
		are not vented shall be capable of	develop a pressure differential		
		withstanding pressure buildup without	during ascent of one atmosphere		
		violating strength and stability	(14.7 psia) between the sandwich		
		requirements.	interior and space vacuum. The		
			structure must be verified to		

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			withstand this pressure differential	( 110 1 11)	
			without causing face-sheet		
			separation.		
4.2.6.2c	Sandwich Assemblies	[MPR 185] Structural sandwich	Since moisture can accumulate in		
		assemblies shall be designed to prevent	vented core sandwich assemblies		
		the entrance and entrapment of water	and can migrate from cell to cell		
		vapor or other contaminants into the core	presenting a corrosion problem, and		
		structure.	since it can also cause structural		
			failure in a launch environment		
			where the exterior pressure		
			decrease and the rapid temperature		
			increase can flash the water to		
			vapor causing over pressurization		
			of the face sheet, it is necessary to		
			prevent such water entrapment and		
			migration in sandwich assemblies.		
			An Apollo lesson learned occurred		
			when a vented core honeycomb		
			interstage tank structure failed due		
			to moisture accumulation and flash		
			evaporation during launch. Water		
			intrusion can occur from		
			condensation / exposure of		
			sandwich constructions to humid		
			air below the dew point, "cryo-		
			pumping" where sandwich		
			structures are exposed to large		
			thermal / humidity gradients		
			induced by cryogenic fluid storage,		
			gravitational migration of rain		
			water, forced penetration of wind-		
			driven rain, etc.		
4.2.6.2d	Sandwich Assemblies	[MPR 186] Structural honeycomb	The use of metallic or glass-		
		sandwich assemblies that will be	reinforced cores to minimize		

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		subjected to heating shall be tested for the expected environments to show that the construction can withstand them.	intrusion of moisture intrusion into the sandwich core and can result in vapor build-up over-pressurizing the sandwich assembly when it is heated by the launch environment.		
4.2.6.2e	Sandwich Assemblies	[MPR 187] Sandwich assemblies using perforated and moisture-absorbing cores shall be protected from water intrusion during assembly and prelaunch activities.	To prevent moisture accumulation that can cause internal corrosion and structural failure, sandwich assemblies need to be protected from water intrusion prior to launch in addition to their being designed to prevent moisture intrusion.		
4.2.6.2f	Sandwich Assemblies	[MPR 188] Test methods for structural sandwich constructions and core materials shall meet the requirements of SAE AMS-STD-401 (1999), Sandwich Constructions and Core Materials: General Test Methods.	It is NASA policy to use voluntary consensus standards where possible. The cited standard is an industry-accepted standard for sandwich construction and core materials that has been reviewed and approved for use by NASA.		
4.2.6.3	Corrosion Prevention and Control	[MPR 189] All parts, assemblies, and equipment used in spaceflight hardware that provides mission-critical functions, including spares, shall be finished to provide protection from corrosion in accordance with the requirements of NASA-STD-6012, Corrosion Protection for Space Flight Hardware, with the following exceptions:  a. SAE AMS2404G is permitted for electroless nickel plating as an alternative to ASTM B733-15.	Ensures that corrosion of space spaceflight hardware will be addressed and eliminated to the extent possible.		

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		b. Titanium fasteners may be used in contact with graphite composites, provided that they are wet installed with sealant or primer materials.			
4.2.6.3.1	Passivation	[MPR 190] Corrosion-resistant steels used in spaceflight hardware that provides mission-critical functions shall be passivated after machining.	Ensures that the normally present passive layer that provides corrosion resistance is restored.		
4.2.6.3.2	Sealing	[MPR 191] Removable panels and access doors in exterior or interior corrosive environments shall be sealed either by mechanical seals or by separable, faying-surface sealing.	Ensures that corrosive environments cannot intrude into sealed compartments.		
4.2.6.4a	Hydrogen Embrittlement	[MPR 192] When designing liquid or gaseous hydrogen systems, the degradation of metallic materials properties by hydrogen embrittlement shall be addressed in the Materials and Processes Selection, Control, and Implementation Plan.	Ensures that the potential for hydrogen embrittlement of metallic structures containing hydrogen will be evaluated.		
4.2.6.4b	Hydrogen Embrittlement	[MPR 193] An MUA shall be written rationalizing the selection of metallic materials for liquid or gaseous hydrogen systems to preclude cracking and to ensure system reliability and safety.	Ensures that the potential for hydrogen embrittlement of metallic structures containing hydrogen has been evaluated.		
4.2.6.4c	Hydrogen Embrittlement	[MPR 194] Electrochemical processes or exposure to acids or bases during manufacturing or processing of spaceflight hardware that provides mission-critical functions shall be controlled to prevent hydrogen embrittlement, or embrittlement relief treatment shall be performed promptly	Ensures that the potential for hydrogen embrittlement is minimized by controlling the time of exposure to electrochemical processes and to acids and bases or that the embrittlement relief treatments are carried out soon after exposure to such processes and		

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Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		after processing.	fluids.		
4.2.6.4c(1)	Hydrogen	[MPR 195] When acid cleaning baths or	Baking ensures relief of the		
	Embrittlement	plating processes are used on steel parts	potential for hydrogen		
		for spaceflight hardware that provides	embrittlement in steels after		
		mission-critical functions, the part shall	exposure to acids or plating		
		be baked in accordance with SAE	processes. The baking process in		
		AMS2759/9D, Hydrogen Embrittlement	SAE AMS2759/9D has a long		
		Relief (Baking) of Steel Parts, to alleviate	history and is the accepted way to		
		potential hydrogen embrittlement	relieve the potential for hydrogen		
		problems.	embrittlement in steels.		
4.2.6.5.1	Gold-Indium	[MPR 196] Gold shall not be used in	A lesson learned when indium		
	Intermetallic Formation	contact with indium or an indium alloy	solder in a Goddard satellite		
		(such as indium solder) for spaceflight	contacted gold wires and the		
		hardware that provides mission-critical	resulting gold-indium intermetallic		
		functions.	resulted in severe embrittlement		
			and failure of the gold wires.		
4.2.6.5.2a	Gold-Tin Intermetallic	[MPR 197] When used with tin-based	Ensures that the dissolution of gold		
	Formation	solder joints in mission-critical hardware,	into tin-based solder will be		
		gold shall be removed from at least 95	minimized, thereby minimizing the		
		percent of the surface to be soldered of all	formation of brittle gold-tin		
		component leads, component	intermetallic compounds.		
		terminations, and solder terminals.			
4.2.6.5.2b	Gold-Tin Intermetallic	[MPR 198] Gold-coated contacts shall not	Ensures that the propensity for		
	Formation	be mated with tin or tin alloy-coated	fretting corrosion between gold-		
		contacts for separable contact interfaces	coated contacts and mating tin-		
		in mission-critical hardware.	coated contacts will be avoided.		
4.2.6.5.3a	Gold-Aluminum	[MPR 199] Gold-aluminum brazing	An aluminum-rich intermetallic		
	Intermetallic Formation	processes shall be controlled to minimize	phase, the AuAl <sub>2</sub> intermetallic		
		formation of the AuAl <sub>2</sub> intermetallic	known as "Purple Plague," is		
		known as "Purple Plague" and prevent	inherent (and not necessarily		
		formation of the Au <sub>5</sub> Al <sub>2</sub> intermetallic	harmful) to gold-aluminum brazing;		
		known as "White Plague."	however, if excessive heat is		
			applied, too much of the		

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Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
			intermetallic can form at the	,	
			braze/part interface, causing joint		
			failure. A gold-rich phase, the		
			Au <sub>5</sub> Al <sub>2</sub> intermetallic known as		
			"White Plague," is always		
			detrimental. Its formation is		
			catalyzed by silicon, so care should		
			be taken to keep the braze joint		
			zone free of contamination		
4.2.6.5.3b	Gold-Aluminum	[MPR 200] Gold-aluminum bonding	Purple Plague is a significant		
	Intermetallic Formation	processes shall be controlled to prevent	problem in microelectronic		
		the formation of the AuAl <sub>2</sub> intermetallic	applications, because as purple		
		known as "Purple Plague" and the Au <sub>5</sub> Al <sub>2</sub>	plague forms, it reduces in volume.		
		intermetallic known as "White Plague."	This creates cavities in the metal		
			surrounding the purple plague,		
			which increases electrical resistance		
			and structurally weakens the wire		
			bonding. White plague is worse,		
			because it has low electrical		
			conductivity and, if enough of it		
			forms, the resulting electrical		
			resistance can cause a total failure		
			of the component. Whereas some		
			amount of purple plague is		
			expected and acceptable for gold-		
			aluminum brazing processes, it is		
			never acceptable in electrical		
			bonding processes.		
4.2.6.6.1	Liquid Locking	[MPR 201] If a liquid-locking compound	Imposing NASA-STD-5020		
	Compounds	is used as a locking feature where	ensures that issues and problems		
		rotational loosening or disengagement	associated with the use of liquid-		
		would result in a critical or catastrophic	locking compounds will be		
		hazard, its use shall comply with the	avoided.		
		design and quality requirements and best			

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Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		practices in NASA-STD-5020, Requirements for Threaded Fastening			
		Systems in Spaceflight Hardware,			
		sections 5.5 and 7.6 and Appendix C.			
4.2.6.6.2	Silver-Plated Fasteners	[MPR 202] Silver-plated fasteners shall	Ensures that the friable black oxide		
		not be used in external applications where	that forms on silver exposed to		
		the silver plating is directly exposed to	atomic oxygen will not contaminate		
		atomic oxygen for a period longer than 2	other components or mechanisms		
		weeks.	or contaminate astronaut suits and		
			gloves during EVAs.		
4.2.6.7a	Contamination Control	[MPR 203] A Contamination Control	Spacecraft performance can be		
		Plan shall be generated in accordance	severely degraded by the presence		
		with the guidelines of ASTM E1548	of excessive contamination, leading		
		(2009), Standard Practice for Preparation	to loss of mission or mission		
		of Aerospace Contamination Control	objectives. A Contamination		
		Plans.	Control Plan covering the entire		
			hardware life cycle is necessary to		
			ensure that a "build clean"		
			approach is properly implemented.		
			The cited ASTM standard is a		
			voluntary consensus standard that		
			has been reviewed and approved for		
4.2.6.7b	Contamination Control	[MPR 204] The Contamination Control	use by NASA.  The cited areas of material		
4.2.0.70	Contamination Control	Plan shall include controls on	processing, hardware packaging,		
		contamination-sensitive manufacturing	and FOD prevention are the most		
		processes, such as adhesive bonding,	important types of contamination		
		controls on packaging for shipment and	that need to be controlled and		
		storage, and a foreign object	addressed in the Contamination		
		damage/debris (FOD) prevention	Control Plan.		
		program.			
4.2.6.7c	Contamination Control	[MPR 205] The FOD prevention program	Since damage to spaceflight		
		shall be established for all ground	hardware from FOD can be very		

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Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		operations of mechanical and electrical	expensive and impact schedules, it		
		systems of spaceflight hardware,	is mandatory that a FOD prevention		
		including the design, development,	program be established that		
		manufacturing, assembly, repair,	addresses all sources and means of		
		processing, testing, maintenance,	preventing FOD damage		
		operation, and checkout of the equipment	throughout the hardware's life		
		to ensure the highest practical level of	cycle.		
		cleanliness.			
4.2.6.7d	Contamination Control	[MPR 206] The FOD prevention program	It is NASA policy to use voluntary		
		shall conform to NAS 412 (Revision 1),	consensus standards where		
		Foreign Object Damage/Foreign Object	possible. NAS 412 is the aerospace		
		Debris (FOD) Prevention.	industry standard for FOD		
			prevention and has been reviewed		
			and approved for use by NASA.		
4.2.6.7e	Contamination Control	[MPR 207] Cleanliness levels for	Ensures that the cleanliness level of		
		assembly- and subassembly-level	each hardware item has been		
		hardware shall be identified on the	specified.		
		engineering drawings.			
4.2.6.8	Packaging	[MPR 208] Packaging shall protect	Obviously, spaceflight hardware		
		spaceflight hardware from corrosion and	needs to be protected during		
		contamination during shipping and	shipment and storage.		
		storage.			
4.3	Verification	[MPR 209] Verification of compliance	Since it is NASA policy to provide		
		with the requirements of this NASA	clear, concise, verifiable		
		Technical Standard shall consist of the	requirements, it is necessary for		
		following steps as a minimum:	NASA M&P to have oversight and		
			insight into how the contractors and		
		a. NASA approval of the contractor	their subs and vendors implement		
		Materials and Processes Selection,	and control spaceflight hardware		
		Control, and Implementation Plan and	M&P. The cited steps of reviewing		
		other applicable materials data	and approving the contractors'		
		requirements documents, such as the	M&P plans, requiring M&P		
1		Contamination Control Plan and NDE	drawing signature approval,		

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

Section	Section Title	NASA-STD-6016B Requirement Statement	Justification	Applicable (Yes or No)	If No, Enter Rationale
		b. Contractor M&P signature on engineering drawings to verify compliance with the requirements of this NASA Technical Standard or the Materials and Processes Selection, Control, and Implementation Plan.  c. NASA audits of contractor M&P activities relating to hardware design and manufacturing.	conducting audits, membership on the materials control panel, and approval of MUAs and MIULs provide NASA M&P with the oversight and insight necessary to verify that the requirements of NASA-STD-6016 have been met.		
		<ul> <li>d. Establishment and operation of the M&amp;P control panel in accordance with section 4.1.4 of this NASA Technical Standard.</li> <li>e. NASA approval of MUAs.</li> </ul>			
		f. NASA approval of MIULs.			

NOTE: Per section 4.1.6: The use of M&P that do not comply with the technical requirements of this NASA Technical Standard may be acceptable in the actual hardware applications. MUAs are required for all M&P that are technically acceptable but do not meet the technical requirements of this NASA Technical Standard, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan.

# **APPENDIX B**

# TYPICAL MUA FORM

MATERIAL US	С	USAGE A	AGREE	MENT :	NO.		REV	PAGE OF				
PROJECT: SYSTEM:		CATEGORY:		ORIGINATOR:		ORGAN	ORGANIZATION/CONTRACTOR:					
PART NUMBER(S): USING		3 ASSEME	BLY(S):		I	TEM DE	SCRIPT	ION:	ISSUE:			
1 ACT TOTALLOS). USING			ASSEMBL I (S).		ITEM DESCRIPTION:							
MATERIAL DESIG	NATION:	MAN	NUFACTU	RER:		SPECIFICATION:			N:	PROPOSED E	FFECTIVITY:	
M	IATERIAL CO	ODE:		LOCA			ATION:			ENVIRONMENT:		
THICKNESS:	WEIGHT:	EXPOSE	ED AREA	HABITABLE PR		PRESS	SURE PSIA:	E PSIA: TEMP.F: MEDIA:				
				NONE	HABITA	BLE						
RATIONALE: (use sec	RATIONALE: (use second page if required.)											
		MAT	ERIAL 1	USAGE	E AGR	EEMI	ENT D	ISPOS	ITION			
CONTRACTOR TIER 1 CONT		RACTOR PRIME		NASA PROJECT MGR.		MGR.	NASA M & P					
								-				
			D	ATE	APPR	ROVE	REJE	CT	DEFER	MEMO NO.:		
										EFFECTIVITY:		
APPRO	<del>VED F</del> C	<del>R PURL</del>	<del>IC RE</del>	LEAS	SE-	DIS'	FRIR	<del>UTI</del>	)N IS I	ORIGINATING CO		

### **APPENDIX C**

### RETIRED CATEGORY III MUA RATIONALE CODES

The Category III MUA rationale codes in the interim and baseline release of NASA-STD-6016 have been incorporated (with modifications) into the body of this NASA Technical Standard as exceptions to the requirements or have been eliminated. Category III MUAs are no longer required for codes that were incorporated as exceptions. Codes were eliminated when the rationales were no longer applicable or a full MUA was considered appropriate for the deviation. The retired codes are listed here for continuity with programs working to the earlier releases. As described in section 4.1.6.1.3, contractors who want to use Category III rationale codes may do so through their approved Materials and Processes Selection, Control, and Implementation Plan.

### RETIRED FLAMMABILITY RATIONALE CODES

CODE	RATIONALE
101	Approved Materials Usage Agreement (MUA) Category I.
102	Approved Materials Usage Agreement (MUA) Category II.
103	Materials passed requirements when tested in configuration.
104	Unexposed, overcoated, or sandwiched between nonflammable materials and no ignition source or propagation path.
105	Minor usage (less than 45 g (0.1 lb) mass and 13 cm <sup>2</sup> (2 in <sup>2</sup> ) surface area); no propagation path or ignition source.
107	Passes test No. 10 of NASA-STD-6001, Flammability Test for Materials in Vented Containers, by test or analysis.
108	Off-the-shelf equipment having material acceptable in configuration; no ignition source or propagation path.
109	Material not exposed; totally immersed in fluid; evaluated for fluid compatibility only.
110	Material is acceptable when used on a metal substrate that provides a good heat sink. Material considered noncombustible in this configuration by test or analysis.
111	Material is flammable but is sandwiched between nonflammable materials with edges only exposed and is more than 5 cm (2 in) from an ignition source or more than 30 cm (12 in) from other flammable materials.
112	Material is flammable but is unexposed or is overcoated with a nonflammable material.
113	Material is flammable but has a thickness <u>less than</u> 0.25 mm (0.010 in) and is sprayed or bonded to a metallic surface greater than 1.6 mm (0.062 in) thick.
114	Material is flammable but is used in "small amounts" and is more than 5 cm (2 in) from an ignition source or more than 30.5 cm (12 in) from other flammable materials. "Small amounts" for flammability may be quantified as follows: total weight less than 45 g (0.1 lb) and less than 13 cm <sup>2</sup> (2.0 in <sup>2</sup> ) surface area.

# RETIRED TOXICITY (OFFGASSING) RATIONALE CODES

CODE	RATIONALE
201	Approved Material Usage Agreement (MUA) Category I.
202	Meets toxicity requirements with performed cure.
203	T value for material/component in usage weight is <0.5 for manned flight
	compartment volume.
204	Materials usage in hermetically sealed container.

### RETIRED FLUID SYSTEM COMPATIBILITY RATIONALE CODES

CODE	RATIONALE
301	Approved Material Usage Agreement (MUA) Category I.
302	Passes requirements in configuration.
303	Material is B-rated in MAPTIS (batch/lot testing required) but batch/lot used in hardware passed test.
304	Approved Material Usage Agreement (MUA) Category II.

# RETIRED THERMAL VACUUM STABILITY RATIONALE CODES

CODE	RATIONALE
401	Approved Material Usage Agreement (MUA) Category I.
402	Approved Material Usage Agreement (MUA) Category II.
403	VCM between 0.1 and 1.0 percent; exposed area is less than 13 cm <sup>2</sup> (2 in <sup>2</sup> ) and
	not near a critical surface.
404	VCM >1.0 percent; exposed area is less than 1.6 cm <sup>2</sup> (0.25 in <sup>2</sup> ).
405	Unexposed, overcoated, or encapsulated with approved material.
406	Material is B-rated in MAPTIS (batch/lot testing required) but batch/lot used in
	hardware cured to meet requirements.
407	Meets thermal vacuum stability requirements in configuration.
408	Materials usage in hermetically sealed container.
409	Material has VCM >0.1 percent but is enclosed in a sealed container (maximum
	leak rate less than $1 \times 10^{-4} \text{ cm}^3/\text{sec}$ ).

# RETIRED STRESS CORROSION CRACKING RATIONALE CODES

CODE	RATIONALE
501	Approved Material Usage Agreement (MUA) Category I.
502	Approved Material Usage Agreement (MUA) Category II.
503	Maximum tensile stress <50 percent of yield strength for part on
	electrical/electronic assemblies.
504	Martensitic or PH stainless steels used in ball bearing, race, or similar
	applications where the primary loading is compressive.
505	Metal not listed in table 1 of MSFC-STD-3029 for stress corrosion cracking is
	not exposed to a corrosive environment after final assembly through end-item
	use.
506	Carbon and low alloy high strength steels greater than 1240 MPa (180 ksi) used
	in ball bearings, springs, or similar applications where primary loading is
	compressive, low tensile stresses, or history of satisfactory performance.

### RETIRED CORROSION RATIONALE CODES

CODE	RATIONALE
601	Approved Material Usage Agreement (MUA) Category I.
602	Approved Material Usage Agreement (MUA) Category II.
603	Adequately finished for corrosion protection.
604	Acceptable in use environment.
606	Electrical grounding required, cladding plus conversion coating adequate.
607	Thermal conductance and electrical bonding requirements preclude painting.
	Conversion coating is adequate (for aluminum only).
608	Finished on a higher assembly.
609	Laminated shim - minimum exposure of corrosion resistant material.
610	Material does not meet the requirements of MSFC-SPEC-250, Class II, but is
	treated or coated in a manner which meets or exceeds the requirements of
	MSFC-SPEC-250. Actual surface treatment shall be listed.
611	Material does not meet the requirements of MSFC-SPEC-250, Class II, but is
	not exposed to a corrosive environment after final assembly through end-item
	use.
612	Welding of titanium alloy-to-alloy or commercially pure-to-alloy using
	commercially pure filler metal in mixed alloy welds where hydrogen
	embrittlement is not predicted in service.

# RETIRED GENERAL CODES

CODE	RATIONALE
702	Generic materials controlled by military or industry specification using MAPTIS averages for ratings or test results. Material codes for generic material shall be used.
703	Military specification or industry specification allowing several material options where all options have acceptable ratings.

### APPENDIX D

# RECOMMENDED DATA REQUIREMENTS DOCUMENTS

## **D.1** Recommended Data Requirements

The purpose of this appendix is to provide recommended Data Requirements Documents (DRDs) as follows:

- Materials and Processes Selection, Control, and Implementation Plan.
- Materials Usage Agreements (MUAs).
- Materials Identification and Usage List (MIUL).
- Contamination Control Plan (CCP).
- Nondestructive Evaluation (NDE) Plan.
- Additively Manufactured Hardware Manufacturing and Qualification Plan.
- Corrosion Prevention and Control Plan.

Examples of DRD content for the first six recommended DRDs are provided on the following pages. An example of DRD content for the Corrosion Prevention and Control Plan is provided in NASA-STD-6012. The specific DRDs and the content of those DRDs should be tailored to each spacecraft program and additional DRDs may be appropriate.

### DATA REQUIREMENTS DESCRIPTION (DRD)

1. PROGRAM: 2. DRD NO.: XXXX

3. **DATA TYPE**: 1 4. **DATE REVISED**:

5. **PAGE**: 1

6. **TITLE**: Materials and Processes Selection, Control, and Implementation Plan

#### 7. **DESCRIPTION/USE**:

This Plan shall document the degree of conformance and method of implementation for each requirement in this standard, identifying applicable in-house specifications used to comply with the requirement. It shall also describe the methods used to control compliance with these requirements by subcontractors and vendors. The Materials and Processes Selection, Control, and Implementation Plan, upon approval by the procuring activity, shall become the Materials and Processes implementation document used for verification.

- 8. **DISTRIBUTION**: As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION**: SRR
- 10. **SUBMISSION FREQUENCY**: Final at SDR
- 11. **REMARKS**:
- 12. **INTERRELATIONSHIP**: Parent SOW Paragraph: XXXX
- 13. **DATA PREPARATION INFORMATION:**
- 13.1 **SCOPE**:

The Materials and Processes Selection, Control, and Implementation Plan shall describe the hardware developer's activities involved in the identification, evaluation, documentation, and reporting of materials and processes usage in space spaceflight hardware, support hardware, and ground support equipment.

### 13.2 **APPLICABLE DOCUMENTS**:

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft

### 13.3 **CONTENTS**:

The necessary interfaces with procuring activity in the operation of this Plan shall be defined. The method for materials control and verification of subcontractors and vendors shall be included in the hardware developer's plan. As a minimum and as applicable, the Plan shall address the following:

Conformance – The Plan shall address each applicable paragraph of NASA-STD-6016A and describe the method of implementation and degree of conformance for each

applicable requirement. If tailoring of the requirements is planned or necessary, alternate approaches to NASA-STD-6016A may be submitted in this Plan, which meet or exceed the stated requirements. This tailoring approach will allow for NASA approval of alternate requirements.

Hardware Developer's Organization – Authority shall be assigned to an individual or group who shall be responsible for review and approval of all M&P specified prior to release of engineering documentation.

Materials and Processes Identification – Identification and documentation of the M&P used, both in the original design and in any changes, shall be contained in the Materials Identification and Usage List (MIUL) DRD.

Testing – Logic, procedures, and data documentation for any proposed test program to support materials screening and verification testing. Any material/process testing to be performed by the hardware developer shall require prior NASA approval.

Materials Usage Agreement (MUA) Procedures – Logic, procedures, and documentation involved in documenting and approving materials/processes as indicated in NASA-STD-6016A shall be defined, including those that do not meet the established requirements but are proposed for use due to lack of replacement materials/processes or other considerations, and shall be contained in the Materials Usage Agreement (MUA) DRD.

Material Design Properties – The Plan shall contain the philosophy describing how material properties will be determined, and if those properties do not exist, how the material properties will be developed, including, but not limited to, the statistical approaches to be employed.

Process Controls – The Plan shall identify all process specifications used to implement specific requirements in NASA-STD-6016A. All materials processes used in manufacturing shall be documented in process specifications, and all applicable process specifications shall be identified on the engineering drawing. Each processing step in the process specification shall be identified in a level of detail that ensures the process is repeatable.

- 13.4 **FORMAT**: Electronic, Word®-compatible document or Adobe® PDF. For each paragraph in section 4 of NASA-STD-6016A, the Plan shall state the requirement from NASA-STD-6016A, identify the degree of conformance under the subheading "Degree of Conformance," and identify the method of implementation under the subheading "Method of Implementation."
- 13.5 <u>MAINTENANCE</u>: Contractor-proposed changes to document shall be submitted to NASA for approval. Complete reissue of the document is required.

### DATA REQUIREMENTS DESCRIPTION (DRD)

1. **PROGRAM**: 2. **DRD NO.**: XXXX

3. **DATA TYPE**: 1 (Category I and II MUAs) 4. **DATE REVISED**:

2 (Category III MUAs) 5. **PAGE**: 1

6. **TITLE**: Materials Usage Agreements (MUAs)

#### 7. **DESCRIPTION/USE**:

MUAs shall be submitted for all materials and processes that are technically acceptable but do not meet the technical requirements of NASA-STD-6016A, as implemented by the approved Materials and Processes Selection, Control, and Implementation Plan. [The use of materials and processes that do not comply with the technical requirements of this standard may be technically acceptable if hardware reliability and vehicle safety are not affected.]

- 8. **DISTRIBUTION**: As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION**: PDR.
- 10. **SUBMISSION FREQUENCY:** At PDR and as the need for new MUAs is identified during the detailed design process. MUAs shall be revised and resubmitted whenever design modifications affect the part numbers or the environment or loads change to more severe than identified on the MUA or the MUA rationale.
- 11. **REMARKS**:
- 12. **INTERRELATIONSHIP**: Parent SOW Paragraph: XXXX
- 13. **DATA PREPARATION INFORMATION:**
- 13.1 **SCOPE**:

MUAs shall be submitted as described below.

Category I MUAs – Category I MUAs are those that involve material/processes usage that could affect the safety of the mission, crew, or vehicle or affect the mission success, but **must** be used for functional reasons. Approval by the responsible NASA Materials and Processes organization and the NASA Program/Project Office shall be required.

Category II MUAs - Category II MUAs are those that involve material/processes usage that fails a screening of Materials and Processes requirements and is not considered a hazard in its use application but for which no Category III rationale code exists. Approval by the responsible NASA Materials and Processes organization shall be required.

Category III MUAs – Category III MUAs are those that involve materials or processes that have not been shown to meet these requirements but have an approved rationale code

listed in the hardware developer-approved Materials and Processes Selection, Control, and Implementation Plan. They are evaluated and determined to be acceptable at the configuration/part level. Category III MUAs shall be reported in the Materials Identification and Usage List (MIUL) system or electronic data system utilizing the approved rationale codes in the Materials and Processes Selection, Control, and Implementation Plan. No MUA form is submitted. [Category III MUAs are identified here for completeness but are not required until after PDR.]

### 13.2 **APPLICABLE DOCUMENTS**:

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft MSFC-STD-3029, Guidelines for the Selection of Metallic Materials for Stress Corrosion Cracking Resistance in Sodium Chloride Environments

### 13.3 **CONTENTS**:

The MUA package shall include all technical information required to justify the application. MUAs for stress corrosion shall include a Stress Corrosion Cracking Evaluation per MSFC-STD-3029, section 5.4.

- 13.4 <u>FORMAT</u>: Electronic. A sample MUA form is provided in NASA-STD-6016A; however, Contractor format is acceptable. The complete MUA package shall be provided in Adobe® PDF format; the MUA form shall also be provided in a format that is compatible with the NASA Materials and Processes Technical Information System (MAPTIS) database.
- 13.5 <u>MAINTENANCE</u>: Contractor updates to the Category I and Category II MUAs shall be submitted to NASA for approval. Complete reissue of the MUA is required.

### DATA REQUIREMENTS DESCRIPTION (DRD)

1. **PROGRAM**: 2. **DRD NO.**: XXXX 3. **DATA TYPE**: 2 4. **DATE REVISED**:

DATA TYPE: 2
4. DATE REVISED: 5. PAGE: 1

6. **TITLE**: Materials Identification and Usage List (MIUL)

#### 7. **DESCRIPTION/USE**:

The MIUL is an electronic searchable parts list or separate electronic searchable materials identification and usage list. The MIUL identifies all Materials and Processes (M&P) usages contained in the end item, excluding piece part electronics and materials in sealed containers (maximum leak rate less than 1 x 10<sup>-4</sup> cm<sup>3</sup>/sec), for evaluation of the acceptability of M&P selected and utilized.

- 8. **DISTRIBUTION**: As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION**: PDR
- 10. **SUBMISSION FREQUENCY**: As-designed MIUL at Hardware Acceptance Review As-built MIUL updates prior to FRR
- 11. **REMARKS**:
- 12. **INTERRELATIONSHIP**: Parent SOW Paragraph: XXXX
- 13. **DATA PREPARATION INFORMATION**:
- 13.1 **SCOPE**:

Materials and processes usage shall be documented in an electronic searchable parts list or separate electronic searchable Materials Identification and Usage List (MIUL). The procedures and formats for documentation of materials and processes usage will depend upon specific hardware but shall cover the as-built hardware. The system used shall be an integral part of the engineering configuration control/release system. A copy of the stored data shall be provided to NASA in a form compatible with the Materials and Processes Technical Information System (MAPTIS).

Wire, cable, and exposed surfaces of connectors shall be reported on the MIUL. All other standard and nonstandard electrical, electronic, and electromechanical (EEE) parts are exempt from reporting on the MIUL. Materials used in hermetically sealed electronic containers (maximum leak rate less than 1 x 10<sup>-4</sup> cm<sup>3</sup>/sec) are also exempt from inclusion in the MIUL.

### 13.2 **APPLICABLE DOCUMENTS**:

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft

### 13.3 **CONTENTS**:

The parts list or MIUL shall identify the following applicable information:

- Detail drawing and dash number
- Next assembly and dash number
- Change letter designation
- Drawing source
- Material form
- Material manufacturer
- Material manufacturer's designation
- Material specification
- Process specification
- Environment
- Weight (nonmetallic materials)
- MAPTIS Material Code (if data are to be provided in a form compatible with MAPTIS)
- Standard/commercial part number
- Contractor
- System
- Subsystem
- Maximum operating temperature
- Minimum operating temperature
- Fluid type
- Surface area (nonmetallic materials)
- Associate contractor number
- Project
- Document title
- Criticality
- Line number
- Overall evaluation
- Overall configuration test
- Maximum operating pressure
- Minimum operating pressure
- MUA number or rationale code
- Cure codes
- Materials rating
- Remarks (comments field)
- 13.4 **FORMAT**: Contractor format is acceptable. However, Contractor format for electronic submittal of MIUL data shall be compatible with the NASA Materials and Processes Technical Information System (MAPTIS) database.

13.5	<u>MAINTENANCE</u> : Contractor updates to the MIUL shall be submitted to NASA for approval. Complete reissue of the document is not required.

### DATA REQUIREMENTS DESCRIPTION (DRD)

PROGRAM:
 DATA TYPE: 2
 DATE REVISED:

5. **PAGE**: 1

6. **TITLE**: Contamination Control Plan (CCP)

#### 7. **DESCRIPTION/USE**:

The Contamination Control Plan defines implementation measures to control contamination of spaceflight hardware and fluid systems during manufacturing, assembly, test, transportation, storage, launch site processing, and post-flight refurbishment.

- 8. **DISTRIBUTION**: As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION**: PDR
- 10. **SUBMISSION FREQUENCY**: The contractor may submit updates/revisions at any time. Final submission shall be at CDR.
- 11. **REMARKS**:
- 12. **INTERRELATIONSHIP**: Parent SOW Paragraph: XXXX
- 13. **DATA PREPARATION INFORMATION**:
- 13.1 **SCOPE**:

The Contamination Control Plan shall be generated in accordance with the guidelines of ASTM E1548, Standard Practice for Preparation of Aerospace Contamination Control Plans (as specified by NASA-STD-6016A) and shall include:

- a. A Foreign Object Debris (FOD) Control Plan to prevent damage to spaceflight hardware and injury to the flight crew by FOD during manufacture, assembly, test, transportation, storage, launch site processing, operation, repair, modification, refurbishment, and maintenance. The FOD prevention program shall conform to NAS 412, Foreign Object Damage/Foreign Object Debris (FOD) Prevention, as specified by NASA-STD-6016A.
- b. Definition of cleanliness level acceptance limits and verification methods for fluid systems, and for general spaceflight hardware internal and external surfaces. The Plan shall also contain a list identifying all system fluids, together with the fluid specifications (for procurement or custom mixing) and the required cleanliness levels for the fluid system.

### 13.2 **APPLICABLE DOCUMENTS**:

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft NAS 412, Foreign Object Damage/Foreign Object Debris (FOD) Prevention

#### 13.3 **CONTENTS**:

The FOD Control Plan shall address the following elements:

- a. Identification of probable FOD sources.
- b. Early design considerations for FOD prevention, resistance to damage, foreign object entrapment, etc.
- c. Manufacturing planning for minimizing FOD generation and cleaning up whatever FOD is generated.
- d. FOD control methods.
- e. FOD Awareness and Prevention Training.
- f. Metrics Measuring techniques for analysis, trending, and feedback.
- g. Incident investigation/reporting, "lessons learned."
- h. Awareness/Employee Feedback.

The contractor shall define cleanliness level acceptance limits and verification methods for fluid systems and for general spaceflight hardware internal and external surfaces. The contractor shall also provide a list identifying all system fluids, together with the fluid specifications (for procurement or custom mixing) and the required cleanliness levels for the fluid system.

- 13.4 **FORMAT**: Electronic, Word®-compatible document or Adobe® PDF.
- 13.5 **MAINTENANCE**: Changes to the document proposed by the contractor shall be submitted to NASA for approval. Complete reissue of the document is required.

### DATA REQUIREMENTS DESCRIPTION (DRD)

1. **PROGRAM:** 2. **DRD NO.:** XXXX

3. **DATA TYPE:** 4. **DATE REVISED:** 

5. **PAGE:** 1

6. **TITLE:** Nondestructive Evaluation (NDE) Plan

#### 7. **DESCRIPTION/USE:**

The Nondestructive Evaluation (NDE) Plan shall address the NDE requirements necessary to assure the health and integrity of the spaceflight hardware throughout its life cycle. This Plan shall identify all Nondestructive Evaluation (NDE) standards employed in the inspection of materials.

- 8. **DISTRIBUTION:** As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION:** PDR
- 10. **SUBMISSION FREQUENCY:** The contractor may submit updates/revisions at any time.
- 11. **REMARKS:**
- 12. **INTERRELATIONSHIP:**
- 13. **DATA PREPARATION INFORMATION:**
- 13.1 **SCOPE:**

The NDE Plan shall address the process for establishment, implementation, execution, and control of NDE. The Plan shall meet the intent of MIL-HDBK-6870, Inspection Program Requirements, Nondestructive for Aircraft and Missile Materials and Parts, and the requirements of NASA-STD-5009, Nondestructive Evaluation Requirements for Fracture-Critical Metallic Components as specified by NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft.

### 13.2 **APPLICABLE DOCUMENTS:**

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft MIL-HDBK-6870, Inspection Program Requirements, Nondestructive for Aircraft and Missile Materials and Parts

NASA-STD-5009, Nondestructive Evaluation Requirements for Fracture-Critical Metallic Components

NAS 410, NAS Certification and Qualification of Nondestructive Test Personnel

### **13.3 CONTENTS:**

NDE Specifications and Standards – The NDE Plan shall address the selection and the order of precedence of applicable government, industry, and prime contractor NDE specifications and standards and how the requirements contained therein are implemented through internal procedures and how-to documents. The oversight of subcontractor implementation and flow down of the NDE requirements shall also be addressed. The Plan shall address commonly used aerospace industry NDE methods including, but not limited to, fluorescent dye penetrant, radiographic (film radiography, digital radiography, computed tomography), ultrasonic, neutron radiography, magnetic particle, eddy current, infrared thermography, and visual inspection. The Plan shall address how all NDE specifications and standards will be approved by the appropriate Government authority.

NDE Requirements During Hardware Design – The NDE Plan shall address how the processes are implemented to ensure that all designs are reviewed to establish NDE inspection requirements and to ensure that the parts are inspectable. The Plan shall address how the areas or zones of the part to be inspected are identified on the drawing. The Plan shall address how the operations and maintenance NDE requirements will be integrated in the design of the hardware.

Part Classification – The Plan shall address appropriate spaceflight hardware and GSE part classification in accordance with MIL-HDBK-6870.

NDE Sensitivity Levels – NDE sensitivity levels shall be classified as Standard NDE, Special NDE, Custom NDE, and Visual Inspection in the NDE Plan. The Plan shall address minimum detectable flaw size for Standard NDE for each material group of spaceflight hardware in compliance with NASA-STD-5009 where applicable. The Plan shall address procedures for defining NDE acceptance criteria for each of the sensitivity levels and identify organizations and their responsibilities in establishing NDE acceptance criteria, NDE drawing call outs, and NDE Operations and Maintenance criteria. Note: Custom sensitivity level refers to an NDE sensitivity level that is not covered under the other three NDE sensitivity levels and is applicable to non-fracture-critical parts.

NDE Acceptance Criteria – The Plan shall address how NDE acceptance criteria are determined and implemented for each sensitivity level. For spaceflight hardware, the Plan shall require rejection of any crack-like flaw irrespective of the sensitivity level of the inspection. The Plan shall address how significant flaw indications, irrespective of the acceptance criteria, will be dispositioned.

NDE During Manufacturing –The Plan shall address establishment of minimum NDE acceptance requirements in terms of NDE sensitivity level, methods of inspection (fluorescent dye penetrant, ultrasonic, etc.), sampling frequency, and NDE inspection coverage (e.g., 100 percent surface area or selected area) for manufactured hardware as grouped by classification of the part, material type, and form. The NDE Plan shall address how NDE is sequenced such that inspection reliability is optimized by

performing NDE before manufacturing processes that may significantly reduce flaw detection capability. The requirements for etching of metal parts prior to penetrant inspection shall be specifically addressed in the Plan.

NDE Material Compatibility – The Plan shall address compatibility of NDE materials and processes with the hardware.

Fracture-Critical Parts – The Plan shall address how the listing of all Fracture-Critical parts, created according to the Fracture Control Plan, will be integrated with NDE requirements. The Plan shall address Special NDE and Standard NDE methods in accordance with NASA-STD-5009.

NDE During Operations and Maintenance – The NDE Plan shall address the NDE requirements necessary to assure the health and integrity of the hardware throughout its life cycle. The NDE Plan shall address NDE requirements during operations and maintenance of those parts that are susceptible to damage, such as impact, corrosion, material degradation and wear, etc. The NDE Plan shall address NDE requirements for inspecting repaired parts. The Plan shall address the NDE procedures and physical standards required to perform the operations and maintenance NDE inspections.

NDE Reporting and Record Retention – The NDE Plan shall describe the NDE nonconformance reporting system, record retention, and traceability.

Process Audit – The Plan shall address periodic auditing of NDE processes at prime contractor, vendors, and subcontractors to verify compliance with the NDE requirements established in the Plan.

Personnel Training – The NDE Plan shall identify formal training and certification requirements for NDE Inspection in accordance with NAS 410, NAS Certification and Oualification of Nondestructive Test Personnel.

- 13.4 **FORMAT:** Electronic, Word®-compatible document or Adobe® PDF.
- 13.5 <u>MAINTENANCE</u>: Changes to the document proposed by the contractor shall be submitted to NASA for approval. Complete reissue of the document is required.

### DATA REQUIREMENTS DESCRIPTION (DRD)

1. **PROGRAM:** 2. **DRD NO.:** XXXX

3. **DATA TYPE:** 4. **DATE REVISED:** 

5. **PAGE:** 1

6. **TITLE:** Additively Manufactured Hardware Manufacturing and Qualification Plan

#### 7. **DESCRIPTION/USE:**

The Additively Manufactured Hardware Manufacturing and Qualification Plan shall address the manufacturing process controls and hardware qualification process implemented to ensure repeatable manufacture of additively manufactured (AM) structural hardware with consistent structural properties.

- 8. **DISTRIBUTION:** As determined by the Contracting Officer.
- 9. **INITIAL SUBMISSION:** PDR
- 10. **SUBMISSION FREQUENCY:** The contractor may submit updates/revisions at any time.
- 11. **REMARKS:**
- 12. **INTERRELATIONSHIP:**
- 13. **DATA PREPARATION INFORMATION:**
- 13.1 **SCOPE**:

The Additively Manufactured Hardware Manufacturing and Qualification Plan shall address the process for manufacture and verification of materials properties for AM structural hardware.

### 13.2 **APPLICABLE DOCUMENTS:**

NASA-STD-6016A, Standard Materials and Processes Requirements for Spacecraft

### **13.3 CONTENTS:**

The Additively Manufactured Hardware Manufacturing and Qualification Plan shall address the following elements:

- a. Risk Classification of each AM part, based on consequence of failure, margin of safety, and build complexity.
- b. Development of Part Development Plans (PDP) to document the implementation and interpretation of the requirements for each AM part. [PDPs are configuration-controlled documents, enforced by each engineering drawing for an AM part to convey all process controls and requirements not within drawing notes.] The engineering drawing/PDP should address part classification and rationale; witness

- sampling requirements and acceptance criteria; thermal processing; first article evaluations and re-sampling periods; build orientation, platform material, and layout; special cleaning requirements; repair allowance; inspection requirements; critical dimensions; any other factors that affect physical/mechanical properties.
- c. Development of process controls on metallurgical process constituents, including the assembled part build file; feedstock controls; chemistry; powder feedstock (including recycled powder); fusion process controls (machine type and operating parameters: laser power, speed, layer thickness, hatch width, etc.); chamber atmosphere; chamber contamination control; and thermal processing controls.
- d. Controls on AM-related equipment, including addressing updates to improve machine performance.
- 13.4 **FORMAT:** Electronic, Word®-compatible document or Adobe® PDF.
- 13.5 <u>MAINTENANCE</u>: Changes to the document proposed by the contractor shall be submitted to NASA for approval. Complete reissue of the document is required.

### **APPENDIX E**

# **REFERENCES**

# E.1 Purpose and/or Scope

The purpose of this appendix is to provide reference material for background information only. The referenced sections below refer to this NASA Technical Standard. In case of conflict, refer to paragraph 2.4.

# **E.2** Reference Documents

DOT/FAA/AR-03/19 (Reference Section 4.1.8.1)	Material Qualification and Equivalency for Polymer Matrix Composite Material Systems: Updated Procedure
NASA NPR 8020.12 (Reference section 4.2.6.7)	Planetary Protection Provisions for Robotic Extraterrestrial Missions
NASA-STD-5012 (Reference section 4.1.8.1)	Strength and Life Assessment Requirements for Liquid-Fueled Space Propulsion System Engines
NASA-STD-5019 (Reference sections 4.1.8.1 and 4.1.8.2)	Fracture Control Requirements for Spaceflight Hardware
NASA/CR-2005- 213424 (Reference section 4.2.3.4)	Lubrication for Space Applications
NASA-STD-5005 (Revision D or later) (Reference section 4.0)	Standard for the Design and Fabrication of Ground Support Equipment
NASA/TM-2007- 213740 (2007) (Reference section 4.2.1.4)	Guide for Oxygen Compatibility Assessments on Oxygen Components and Systems
NASA/TM-2016- 218602 (2016)	Hydrogen Embrittlement

Reference section 4.2.6.4)	
NASA-TM-86556 (1985) (Reference section 4.2.3.4)	Lubrication Handbook for the Space Industry, Part A: Solid Lubricants, Part B: Liquid Lubricants
ANSI/AIAA G-095 (Reference section 4.2.6.4)	Guide to Safety of Hydrogen and Hydrogen Systems
ASTM E1559 (Reference section 4.2.3.6)	Standard Test Method for Contamination Outgassing Characteristics of Spacecraft Materials
ASTM E2900 (Reference section 4.2.3.6)	Standard Practice for Spacecraft Hardware Thermal Vacuum Bakeout
ASTM G63 (Reference section 4.2.1.4)	Standard Guide for Evaluating Nonmetallic Materials for Oxygen Service
ASTM G88 (Reference section 4.2.1.4)	Standard Guide for Designing Systems for Oxygen Service
ASTM G94 (Reference section 4.2.1.4)	Standard Guide for Evaluating Metals for Oxygen Service
ASTM MNL 36 (Reference section 4.2.1.4)	Safe Use of Oxygen and Oxygen Systems: Handbook for Design, Operation, and Maintenance
AWS G2.4/G2.4M (Reference section 4.2.4.6.1)	Guide for the Fusion Welding of Titanium and Titanium Alloys
SAE AMS2453 (Reference section 4.2.2.2.1)	Low Stress Grinding of Steel Parts Heat Treated to 180 ksi or Over, and Low Stress Grinding of Chrome Plating Applied to Steel Parts Heat Treated to 180 ksi or Over

SAE CMH-17-5 (Reference section 4.1.8.1) (Scheduled for publication in 2017) Composite Materials Handbook Volume 5 - Ceramic Matrix Composites